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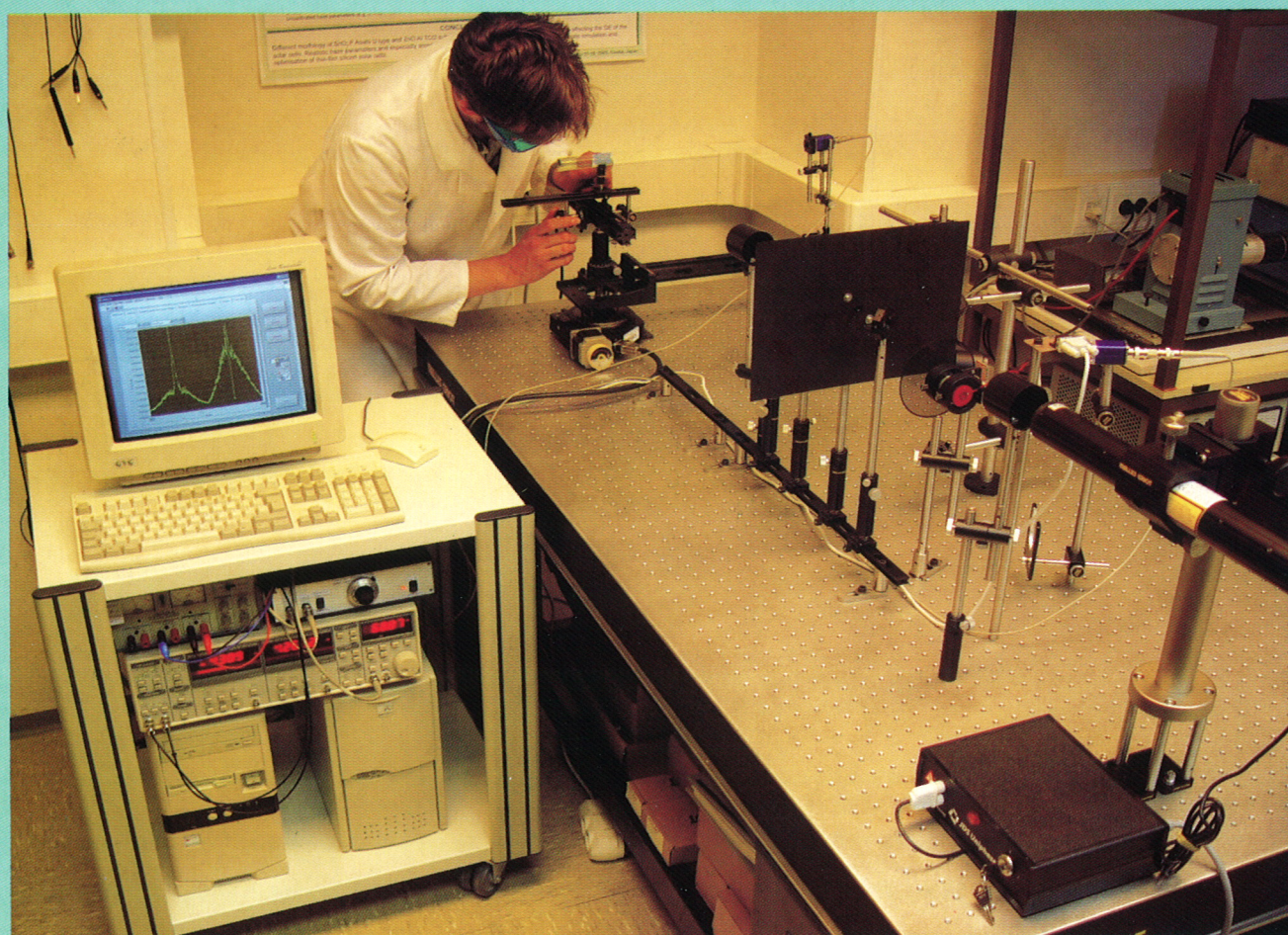
MIDEM

2°2003

Strokovno društvo za mikroelektroniko
elektronske sestavne dele in materiale

Strokovna revija za mikroelektroniko, elektronske sestavne dele in materiale
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**FACULTY OF
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INFORMACIJE

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POROSITY SENSOR

Vojko Matko

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Key words: porosity, soils, glass test tube, capacitive-dependent crystal, direct digital method.

Abstract: In response to a need for a more accurate porosity measuring method for small solid samples (approximately 1 g in mass) the porosity measurement sensor using a sensitive capacitive-dependent crystal was developed. This paper presents the new sensor and the probe sensitivity, frequency dependence on the volume. In addition, the new idea of excitation of the entire sensor with stochastic test signals is described, and the porosity measuring method is provided. The latter includes the influence of test signals on the weighting function uncertainty. The experimental results of the porosity determination in volcanic rock samples are presented. The uncertainty of the porosity measurement is less than 0.1 % in the temperature range 10 - 30 °C.

Senzor poroznosti

Ključne besede: poroznost, zemljine, steklena merilna epruveta, kapacitivno odvisni kristali, direktna digitalna metoda.

Izleček: V iskanju bolj natančnega merjenja poroznosti malih trdnih delcev (mase približno 1 g) je bila razvita metoda, ki uporablja kapacitivno odvisne kristale. V delu je prikazan novi senzor in njegova frekvenčna odvisnost od volumna. V nadaljevanju je prikazana nova ideja vzbujanja senzorja s stohastičnimi signali in zmanjšanje merilne negotovosti vpliva sistema (senzorja). Prikazani so eksperimentalni rezultati merjenja poroznosti vulkanskega pepela s pogreškom 0.1% v temperaturnem območju 10 - 30°C.

1 Introduction

Porosity is defined as the ratio of the volume of voids to the total volume of the material.

Solid rock is often not so solid. Sandstone might have started out as a sand dune or a beach, which got buried and compressed. But spaces and pores, remain between the particles. Soils, too, contain pores, which can be classified as micro and macro. Pore diameters larger than 0.06 mm are called macropores and those less as micropores. Soils may be considered as a porous four-phase system composed of air, water, solids and admixtures. The latter are a mixture of water and solids and are soft. In this four-phase soil system, the density ρ of soils is defined as the ratio of the sum of mass m to the sum of volume V of various soil phases /1/-/3/

$$\rho = \frac{\sum m_i}{\sum V_i} = \frac{m_s + m_w + m_a + m_{ad}}{V_s + V_w + V_a + V_{ad}}, \quad (1)$$

$$\sum m_i = m_s + m_w + m_a + m_{ad}, \quad (2)$$

$$\sum V_i = V_s + V_w + V_a + V_{ad} \quad (3)$$

where

s solid phase
w water phase
a air phase
ad admixture.

Equation (1) can also be rewritten as

$$\rho = \frac{\rho_s V_s + \rho_w V_w + \rho_a V_a + \rho_{ad} V_{ad}}{V_s + V_w + V_a + V_{ad}}, \quad (4)$$

where solid particle density is

$$\rho_s = \frac{m_s}{V_s}, \quad (5)$$

water phase density is

$$\rho_w = \frac{m_w}{V_w}, \quad (6)$$

air phase density is

$$\rho_a = \frac{m_a}{V_a}, \quad (7)$$

and soil admixture density is

$$\rho_{ad} = \frac{m_{ad}}{V_{ad}}. \quad (8)$$

Instead of density, the specific gravity can be written. From equation (4) we can write

$$\gamma = \frac{(\rho_s V_s + \rho_w V_w + \rho_a V_a + \rho_{ad} V_{ad}) \cdot g}{V_s + V_w + V_a + V_{ad}}, \quad (9)$$

In practice, we can define mass as the ratio of weight of soil to gravity

$$m = \frac{W}{g}. \quad (10)$$

During weighting in air the mass must be increased due to the presence of the air (Avogadro's law)

$$m_s = \frac{W_s}{g} + \rho_a \cdot V_s, \quad (11)$$

$$m_w = \frac{W_w}{g} + \rho_a \cdot V_w, \quad (12)$$

$$m_{ad} = \frac{W_{ad}}{g} + \rho_a \cdot V_{ad}. \quad (13)$$

Porosity of soil is defined by two parameters - void ratio e and porosity parameter η . The total void ratio e is defined as the ratio of volume of pores to volume of solid particles

$$e = \frac{V_w + V_a}{V_s} \quad (14)$$

and phases void ratio as

$$e_w = \frac{V_w}{V_s}, \quad (15)$$

$$e_a = \frac{V_a}{V_s}. \quad (16)$$

The porosity parameter η is defined as the ratio of volume of water plus volume of air to volume of soil samples.

Total:

$$\eta = \frac{V_w + V_a}{V} = \frac{V_w + V_a}{V_s + V_w + V_a}. \quad (17)$$

Phases:

$$\eta_w = \frac{V_w}{V} = \frac{V_w}{V_s + V_w + V_a}, \quad (18)$$

$$\eta_a = \frac{V_a}{V} = \frac{V_a}{V_s + V_w + V_a}. \quad (19)$$

The water content w_a is defined as the ratio of the weight of water to the weight of soil particles

$$w = \frac{W_w}{W_s} = \frac{W - W_a - W_s - W_{ad}}{W_s}. \quad (20)$$

The absolute water content w_a is defined as the ratio of the weight of water to the total weight of sample

$$w_a = \frac{W_w}{W} = \frac{W - W_a - W_s - W_{ad}}{W}. \quad (21)$$

The degree of saturation S_r is defined as the ratio of the volume of pores saturated with water to the volume of all pores

$$S_r = \frac{V_w}{V_w + V_a} = \frac{\eta_w}{\eta_w + \eta_a}. \quad (22)$$

1.1 Porosity determination methods

The simplest method is the determination of porosity by saturation method (Fig. 1) /4/. In this standardised procedure, the beakers are first filled to the same mark with gravel, sand, silt or mixture of these three materials. Then the water is poured into each of the beakers until it reaches the top of each material.

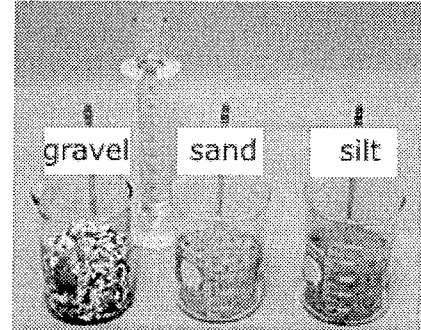


Fig. 1. Determination of porosity by saturation.

Porosity is determined by dividing the volume of water that you were able to pour into the material by the total volume of that material. The result is expressed as a percentage. It dictates how much water a saturated material can contain and has an important influence on bulk properties of material, e.g. bulk density, heat capacity, seismic velocity, etc.

$$\eta = \frac{V_{void}}{V_{total}} \cdot 100 \% \quad (23)$$

where

V_{void} pore space volume

V_{total} total volume

There are many different porosity measurement methods. The imaging porosity method aims to identify and quantify different pore systems to determine the nature and abundance of matrix and macroporosity. Matrix porosity is characterised from digital images obtained from thin sections cut from core plugs /5/.

The helium pycnometer method uses helium. The pycnometer consists of two chambers, connected by a tube with a valve in it. The idea is to measure the pressure difference between the two containers, one of which has the sample material in it. The degree of porosity is determined by the difference in the pressures (due to porosity) caused by the opening of the valve at constant temperature. The porosity of the sample is the percentage difference between the grain volume and bulk volume, divided by the bulk volume /6/.

Porosity can also be determined by other conventional methods such as adsorption method, infrared scattering, mercury porosimetry, capillary method, dielectric method, analytical method, proton nuclear magnetic resonance, chromatography and ultrasound method /7/, /8/.

The new porosity measuring method described in this paper uses a highly sensitive sensor with improved uncertainty of measuring results and reduced influence of disturbing noise signals /9/. In comparison to the helium pycnometer method it is a lot simpler. In addition, the water is not poured on the material. Instead, the soil or rock sample is immersed in the water.

Most capacitive bridge methods can be adapted to three-terminal measurements by the addition of components to balance the ground admittances /10/, /11/. However, the balance conditions for these and the main bridge being interdependent, the balancing process can become very tedious. Also, the ratio signal/noise is supposed to be high.

The well-known method is Miller's etalon /12/ which is designed to sense small changes in the ≈ 4 pF capacitor from the phase change of a series-resonant circuit. The weakness of Miller's etalon is a greater sensitivity to phase noise than with the bridge method, which is due to higher frequencies (up to 45 MHz).

An alternative approach has been described by Van Degrieff /13/ who used very sensitive tunnel-diode oscillator systems for measuring extremely small capacitance changes. This gain in sensitivity is somewhat offset by a loss in stability.

2 The porosity sensor

The porosity sensor uses sensitive capacitive-dependent crystals (40 MHz with stability of ± 1 ppm in the temperature range from -5 to $+55$ °C) due to stability and the long-term repetition (Fig. 2). Two pseudo stochastic three-state signals $x_1(t)$ and $x_2(t)$ are used to influence the frequencies of the two quartz oscillators /14/, /15/. The frequency of oscillator 1 is 40 MHz and that of oscillator 2 is 40.001 MHz /16/, /17/. The output of the pulse-width modulator (EXOR) is a pulse-width signal which is compensated for temperature and voltage drift.

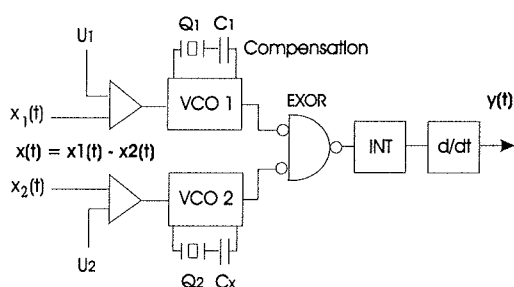


Fig. 2. Sensor structure.

The sensor probe C_x is a capacitor on the outer surface of the glass test tube (Fig. 3) /18/. The crystal is used as a stable oscillation element whose substitutional electrical structure only is being changed through the variation of the series capacitance C_x . The values in the quartz substitutional electrical structure and the capacitance $C_x = 5$ pF

are measured with impedance/gain phase analyser HP 4194A.

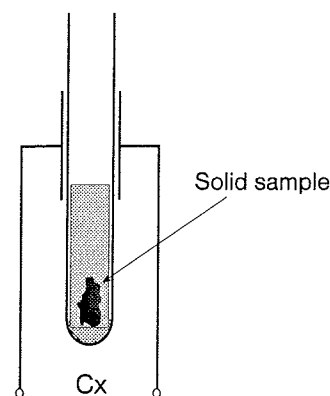


Fig. 3. Glass test tube.

The change of the water level causes the change of capacitance and frequency change in oscillator 2 (Fig. 2, Fig. 3). The probe dependence df on the volume is shown in Fig. 4. The frequency measurement uncertainty is ± 0.1 Hz. The results suggest that the change in frequency is proportional to the volume in the range 0 - 1 ml.

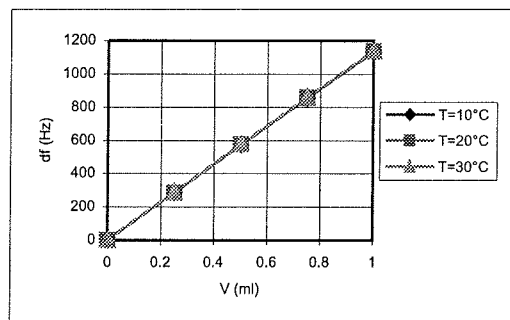


Fig. 4. The probe dependence df on the volume with signals $x_1(t)$ and $x_2(t)$.

3 Reduction of the measurement uncertainty

The uncertainty of the measuring results is improved by the direct digital method (DDM), which reduces the influence of disturbances /9/. Linear time-invariant system has been chosen due to signals $x_1(t)$ and $x_2(t)$, which form a special correlation function that is real-time independent.

$$\Phi_{xy}(\tau) = \sum_{u=0}^T g(u) \cdot \Phi_{xx}(\tau - u) \quad (24)$$

- $\Phi_{xy}(\tau)$ - cross-correlation function
- $g(u)$ - weighting function
- $\Phi_{xx}(\tau - u)$ - auto-correlation function
- T - measuring period

For every value of τ , one equation with various numbers of elements is obtained. To calculate the value of the weighting functions $g(0), g(1), \dots, g(L)$, the equations are united in the system with $L + 1$ equations

$$\begin{bmatrix} \Phi_{xy}(-P+L) \\ \vdots \\ \Phi_{xy}(-1) \\ \Phi_{xy}(0) \\ \Phi_{xy}(+1) \\ \vdots \\ \Phi_{xy}(M) \end{bmatrix} = \begin{bmatrix} \Phi_{xx}(-P+L) & \dots & \Phi_{xx}(-P) \\ \vdots & \ddots & \vdots \\ \Phi_{xx}(-1) & \dots & \Phi_{xx}(-1-L) \\ \Phi_{xx}(0) & \dots & \Phi_{xx}(-L) \\ \Phi_{xx}(+1) & \dots & \Phi_{xx}(1-L) \\ \vdots & \ddots & \vdots \\ \Phi_{xx}(M) & \dots & \Phi_{xx}(M-L) \end{bmatrix} \begin{bmatrix} g(0) \\ \vdots \\ g(L) \end{bmatrix}$$

or its mathematical equivalent

$$\hat{\Phi}_{xy} = \hat{\Phi}_{xx} \cdot \underline{g}. \quad (25)$$

The biggest negative time move $\tau_{min} = -P$ and the biggest positive one $\tau_{max} = M$ were used. The system of equations has thus $P - L + M + 1$ number of equations. If $M = -P + 2L$ is chosen, $L + 1$ number of equations remain, so that $\hat{\Phi}_{xx}$ becomes a square matrix and we get

$$\hat{g} = \hat{\Phi}_{xx}^{-1} \cdot \hat{\Phi}_{xy}. \quad (26)$$

If $P = L$ is determined, then the same number of values (symmetrical auto-correlation functions (AKF) because $\tau_{min} = -P = -L$ and $\tau_{max} = M = L$ for the positive and negative τ) is used to calculate $\Phi_{xx}(\tau)$. The calculation of the weighting function is simplified if the input signal is white noise with the auto-correlation function as

$$\Phi_{xx}(\tau) = \sigma_x^2 \cdot \delta(\tau) = \Phi_{xx}(0) \cdot \delta(\tau), \quad (27)$$

$$\delta(\tau) = \begin{cases} 1 & \text{for } \tau = 0 \\ 0 & \text{for } |\tau| \neq 0 \end{cases}. \quad (28)$$

It follows that

$$\hat{g}(\tau) = \frac{1}{\hat{\Phi}_{xx}(0)} \cdot \hat{\Phi}_{xy}(\tau). \quad (29)$$

Having formulated (26) and having considered the measurement time t_{meas} which is to be as long as possible, we get the weighting function $\hat{g}(\tau)$ (29) /9/.

4 Porosity measurement

Due to the specially chosen test signals $x_1(t)$ and $x_2(t)$ the function $\Phi_{xy1}(\tau)$ begins in the origin of coordinates and ends on the X axis when $\tau = t_{meas}$ (Fig. 5).

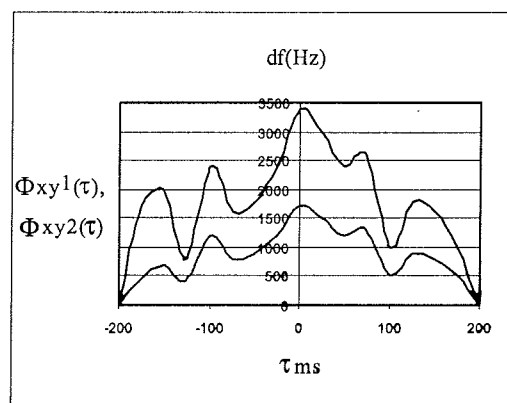


Fig. 5. Functions $\Phi_{xy1}(\tau)$ and $\Phi_{xy2}(\tau)$.

Consequently, the porosity is defined as a change of area between the functions $\Phi_{xy2}(\tau)$ and $\Phi_{xy1}(\tau)$, whose change is defined by capacitance C_x and specially chosen test signals $x_1(t)$ and $x_2(t)$. In this way the test signal has been considered throughout the entire t_{meas} period, as well as the sign change compensation in the calculation of the cross-correlation function. Comparing to the measurements that are not DDM method based the improvement of the ratio signal/noise by ≈ 30 dB is the most significant gain.

4.1 Calibration

The frequency is simultaneously converted into volume units by calibrating the ratio between the frequency and the volume for each glass tube. Mercury, whose mass is measured at an error of 0.01 % (at known temperature) is used for calibration /19/. The mechanical nonlinearities of the glass tube diameter along the whole tube are taken into account. According to the producer's data these do not exceed 0.01 %. The dependence can be linearized by using the spline method.

4.2 The influence of temperature and measurement error

The influence of temperature on measurements is considered in three ways. We must know the influence of the temperature on the measuring equipment, on the measuring medium in which the measurement is performed (i.e. the fluid in which the test is carried out), and the influence of the soil's temperature on its physical properties /19/.

The temperature of the environment affects the linearity of the measuring sensor. Calibration is used to establish the measurement error of the sensor which is 0.03 %. If the relation between the output frequency and the volume is known (Fig. 4), we get

$$V(T) = V(T_0) + \Delta V(T). \quad (30)$$

Equation (30) gives the correction of the measurement with respect to temperature changes. Temperature changes also affect the volume of the measured medium, i.e. of the

soil sample. Consequently, the change of volume due to temperature changes is expressed in the determination of the soil's specific gravity as follows

$$\gamma(T) = \gamma(T_0) + \Delta\gamma(T). \quad (31)$$

In conditions of linear temperature relationship inside a certain temperature range it holds true that

$$V(T) = V_s(T_0) \cdot (1 + \alpha_{V_s}(T - T_0)) \quad (32)$$

where α_s is the temperature coefficient of soil.

The change of volume due to temperature changes in naturally humid soils is expressed as the sum of volume changes of all soil phases

$$dV(T) = dV_s(T) + dV_w(T) + dV_{ad}(T). \quad (33)$$

The total measurement error of the porosity sensor in relation to known individual partial influences such as glass tube nonlinearity, calibration with mercury, the influence of temperature on the sensor (Fig. 4), linearization of df on V , frequency measurement $y(t)$ (Fig. 2), specific soil weight (31), change of water volume in the test tube and the change of sample volume $dV(T)$ (33) does not exceed 0.1 % (10 – 30°C). This value was calculated on the basis of calibration data and the influence of temperature and measurement error.

5 Experimental porosity measurement

To test the new method, volcanic rock samples, which are known for their porosity, were selected for experimental determination of porosity. Four characteristic samples approximately 1 ml in size and 1 g in weight were gathered near Puerto de Santiago, Mount Teide volcano (3715 m), Tenerife (Fig. 6).

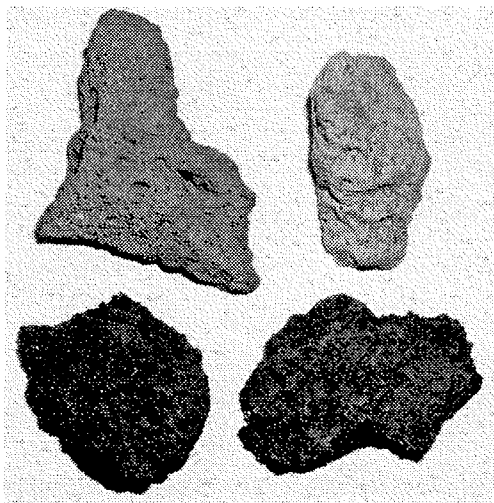


Fig. 6. Four typical porous volcanic rock samples of about 1 ml in size and 1 g in mass.

All test samples were randomly selected. To determine the porosity of a random solid sample (at 20 °C), the sample is immersed in water contained in a test tube around which the capacitor C_x is placed (Fig. 3). The volume of the sample is measured. In the first case, the glass solid sample with ~ 0 % porosity was immersed (Fig. 7).

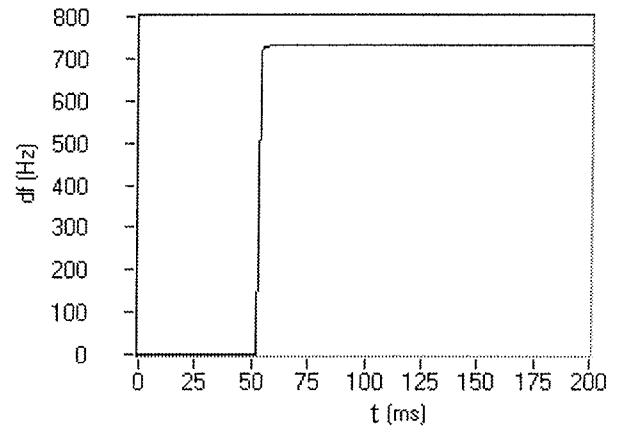


Fig. 7. Measurement of sample having ~ 0 % porosity.

The frequency remained unchanged after immersion, which indicates that there was no air leak. In the second case, a dry randomly selected volcanic rock sample (weighting 0.821 g) was immersed in the water. Since the sample was porous, the air leaked, which was reflected in the dynamic change of frequency (Fig. 8). The transitional phenomenon caused by immersion ends in 1 ms.

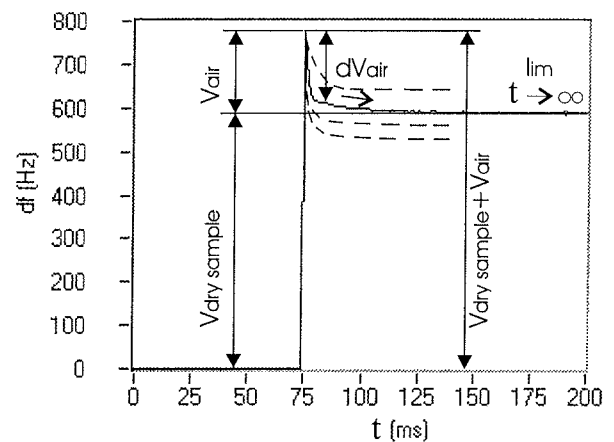


Fig. 8. Air leak after sample immersion.

The measurement is performed until the final state towards which the measurement limits is reliably predicted. Depending on the degree of porosity, this saturation limit is higher or lower as shown for the other three samples (Fig. 8).

At known temperature the sample porosity can be determined

$$\eta = \frac{V_{air}}{V_{dry sample} + V_{air}}. \quad (34)$$

The sample porosity on Fig. 8 was 23.8 %. The fastest measurement time without test signals is 1 μ s.

6 Conclusion

The porosity sensor using the capacitive-dependent crystals has been described and the dependence of df on the volume of the sensor probe has been presented. The porosity determination procedure includes the influence of test signals on the weighting function uncertainty.

The formation of the cross-correlation function between the test signal $x(t)$ and the system response $y(t)$ decreases the influence of all disturbing signals that are not correlated to the test signal $x(t)$ for ≈ 30 dB /9/. Other advantages of the proposed method are high sensitivity, high stability, a series resonant circuit which is not composed of the elements L and C , the ratio signal/noise does not affect the accuracy of measurements, reduced disturbances due to the structure and the method, the long-term repetition, reduced hysteresis /17/ and low cost. It should be noted, however, that pairs of crystals with similar temperature characteristics should be used. The accuracy and repeatability are determined only with the temperature frequency difference of the crystal pairs /19/.

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OSNOVE TEORIJE OPTIČNIH PRESLIKAV, PRIREJENE ZA POTREBE SIMULACIJ FOTOLITOGRAFSKEGA PROCESA

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Ključne besede: Fouriereva optika, Fraunhoferjev uklon, MTF, fotolitografija, projekcijski poravnalniki, mikroelektronika

Izveček: V prispevku so predstavljene osnove teorije optičnih preslikav. Obravnavani so tisti aspekti Fourierove optike, Abbejeve teorije preslikav in teorije modulacijskih prenosnih funkcij (MTF), ki se nanašajo na preslikavo vzorcev s fotolitografske maske na s fotopolimerom prevlečeno rezino s projekcijskimi poravnalniki.

Basics of Optical Imaging Theory Applied to the Photolithography Process Simulation

Key words: Fourier optics, Fraunhofer diffraction, MTF, photolithography, projection aligners, microelectronics

Abstract: Lithography is the cornerstone of modern IC manufacturing, and lithography tools and process characterization at the core of the lithography process engineering. Most of the ICs today are manufactured by optical photolithography. As the dimensions of the features to be fabricated on the wafer approach 0.1 μm the classical limits of resolution of optical tools used in photolithography are approached. Understanding and optimization of the performance of the lithographic process are thus becoming less accessible by the empirical methods traditionally used in IC manufacturing process development and have to be complemented by different computer simulation tools. Such tools are based on Fourier optics to describe the performance of exposure systems, and for their use a basic understanding of the underlying optical theory is required. In this tutorial these basics are covered, with the intention to facilitate a study of more advanced literature.

All of the projection exposure systems used in IC manufacturing industry today are diffraction limited optical instruments. Consequently Fraunhofer diffraction theory is used to describe their performance. This has important consequences for imaging the fine mask patterns on the photoresist covered wafer. In order to understand the relation between the (spatial) Fourier transform of the mask pattern and the diffraction image formed by the objective lens in its focal plane, it is instructive to compare the Fourier transform of a pulse function and the analytical expression for the diffraction image of a line source. It can immediately be seen, that they are equal. This conclusion can be generalized to the more complex case of mask imaging. Thus the far-field electric field intensity $E(y_H, z_H)$ is given by

$$E(y_H, z_H) = F\{f(y, z)\}$$

where $f(y, z)$ is mask transmittance function, and F Fourier transform operator. The objective lens performs an inverse Fourier transform of $E(y_H, z_H)$, resulting in an image of the mask in the image plane of the objective lens, where the wafer is positioned. Field intensity distribution $E(y_i, z_i)$ of the image in the wafer plane is

$$E(y_i, z_i) = F^{-1}\{E(y_H, z_H) P_o(f_y, f_z)\} = F^{-1}\{F\{E(y, z)\} P_o(f_y, f_z)\}$$

where F^{-1} inverse Fourier transform operator. The pupil function $P_o(f_y, f_z)$ of the objective lens is introduced into the expression in order to take account of finite dimensions of the lens. From this expression the well known resolution criteria of a projection system can be extracted.

Another basic optics concept allowing modeling of the aerial image on the surface of the photoresist film is the modulation transfer function (MTF). MTF is basically a measure of the contrast in the aerial image produced by the exposure system. It is also governed by the diffraction effects and MTF is therefore a function of the normalized spatial frequency ξ of the image. The resolution and the $\text{MTF}(\xi)$ characterise performance of an exposure tool, and have to be incorporated in a simulation. An implementation of these ideas in FOLIS, a photolithography simulation tool developed at the Microelectronics laboratory of the Faculty of Electrical Eng., University of Ljubljana, is reported elsewhere [5].

Uvod

Fotolitografija je eden od temeljev modernih postopkov izdelave integriranih elektronskih vezij in fotolitografska osvetljevalna orodja njeno središče. Velika večina takšnih orodij so danes projekcijski poravnalniki. Minimalne (tako imenovane kritične) dimenzije na sodobnih integriranih vezij segajo v področje velikosti 0,1 μm , kar je povsem na meji, če ne celo pod njo, ločljivosti osvetljevalnih orodij. Zato

predstavljajo postopki preslikave in osvetljevanja velik izziv za razvijalce mikroelektronskih postopkov in dodobra uveljavljeni, empirični pristop k reševanju litografskih problemov, ki se pojavljajo pri njihovem delu, jim v resnici ni več povsem kos. Toda uspešno ga lahko dopolnijo različna programska orodja za simulacijo fotolitografskega postopka. Njihova uporaba pa zahteva vsaj osnovno poznavanje optične teorije.

Vsi projekcijski osvetljevalni sistemi, ki se danes uporabljajo v mikroelektronski industriji, so naprave, ki jim kvaliteto preslikave omejujejo uklonski pojavi. Te obravnava teorija Fraunhoferjevega uklona (uklona v daljnem polju), ki ga najpreprosteje simuliramo v okvirih Fourierove optike. Tudi če fotolitografsko preslikavo okarakteriziramo s prenosno funkcijo sistema, se upoštevanju uklonskih pojavov pri preslikavi ne moremo izogniti. Vse omenjene teme so v teoriji optike dobro in že dolgo časa poznane ter jih obravnava vrsta knjig /na primer 1, 2/ ter priročnikov /3/. Vendar se zdi, da je v praksi njihova uporaba omejena, morda v duhu pregovora, da v gozdu ni videti dreves. Fizikalni temelji sicer kompleksne optične teorije pa so razmeroma lahko razumljivi tudi v okviru znanj, ki jih razvojni inženir, delujoč na področju mikroelektronske fotolitografije, že ima. Namen tega prispevka je, da prav v tem okviru predstavi osnove relevantne optične teorije in tako olajša prvi korak pri poglobljenem študiju zahtevnejše literature. V prispevku zato ni govora o tehničnih podrobnostih projekcijskih osvetljevalnih naprav itd. Te so na voljo v literaturi /na primer v izboru literature v 4/. Prav tako v njem ni govora o simulacijskih orodjih, ki jih obravnavamo drugje /5/, pač pa so poudarjeni prav osnovni fizikalni pojmi optične teorije preslikav.

Fourierova transformacija pulzne funkcije

Fourierov integral neke funkcije $f(x)$ je definiran /6/ kot

$$f(x) = \frac{1}{\pi} \left[\int_0^{\infty} A(k) \cos kx \, dk + \int_0^{\infty} B(k) \sin kx \, dk \right]$$

kjer sta

$$A(k) = \int_{-\infty}^{\infty} f(x) \cos kx \, dx \quad \text{in}$$

$$B(k) = \int_{-\infty}^{\infty} f(x) \sin kx \, dx$$

Podobnost gornjih izrazov z morda nekoliko bolj domačimi izrazi za Fourierovo vrsto je očitna, če se le spomnimo, da je integral limita vsote neskončne vsote. Količini $A(x)$ in $B(x)$, ki ju lahko razumemo kot amplitudi kosinusnih in sinusnih prispevkov k funkciji $f(x)$ v intervalu od k do $k+dk$, se imenujeta kosinusna in sinusna transformacija funkcije $f(x)$.

Oglejmo si Fourierovi transformaciji funkcije, ki predstavlja pravokoten pulz z dolžino L :

$$f(x) = E_0, \text{ če je } |x| \leq L/2$$

$$0, \text{ če je } |x| > L/2$$

Ker je $f(x)$ soda funkcija, je njena sinusna transformacija $B(k)$ enaka 0, medtem ko je

$$A(k) = \int_{-\infty}^{\infty} f(x) \cos kx \, dx = \int_{-L/2}^{L/2} E_0 \cos kx \, dx = \frac{2E_0}{k} \sin kL/2$$

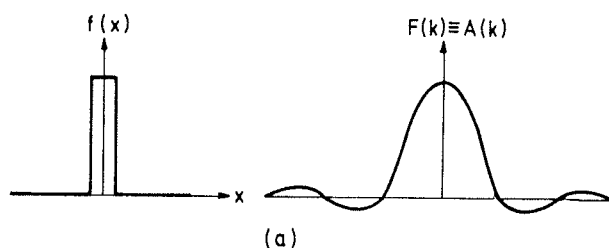
Če v zadnjem izrazu ulomek v števcu in imenovalcu pomnožimo z L ter člene nekoliko preuredimo, je končni izraz za Fourierovo transformacijo pulzne funkcije

$$A(k) = E_0 L \frac{\sin kL/2}{kL/2}$$

Funkcijo $\frac{\sin kL/2}{kL/2}$ v optiki srečujemo tako pogosto, da zanjo običajno uporabljajo poseben simbol, $\text{sinc } kL/2$. Fourierovo transformacijo pulzne funkcije torej zapišemo kot

$$A(k) = E_0 L \text{ sinc } kL/2$$

Na sliki 1 sta prikazani pulzna funkcija $f(x)$ in njena Fourierova transformacija.



Slika 1: Pulzna funkcija in njena Fourierova transformacija.

Uklon

Če neko EM valovanje (svetlobo) prestrežemo z ravnim zaslonom v katerem je izrezana dolga, ravna reža, se skozi njo del vpadnega valovanja širi v polprostor za zaslonom. Kako to valovanje opišemo? Nalogo poskušamo rešiti s pomočjo Huygens-Fresnelovega načela /1/, ki zagotavlja, da širjenje valovanja lahko opišemo tako, da si neko valovno čelo valovanja zamišljamo razdeljeno na primerno majhne dele, ki so vsak izvor sekundarnih, krogelnih valovanj. Ta imajo isto valovno dolžino kot vpadno valovanje, kjer koli v prostoru za izbranim valovnim čelom pa je nato vrednost nihajoče količine (pri EM valovanju na primer velikost električnega polja, oz. električna poljska jakost E) določena s superpozicijo (nekoliko grobo rečeno, vsoto) prispevkov sekundarnih valov. Pri seštevanju moramo seveda upoštevati amplitude in faze posameznih prispevkov, kar nalogo v splošnem zelo zaplete. Sorazmerno preprosto jo lahko rešimo pravzaprav le v dveh primerih. Prvi je tisti pri katerem točka v kateri iščemo valovanje, od izbrane valovne fronte ni preveč oddaljena (v tako imenovanem bližnjem polju), drugi pa, če je točka od nje zelo oddaljena (v daljnem polju). V zvezi s projekcijskim osvetljevanjem nas zanima le drugi primer.

Preden se resnično lotimo seštevanja prispevkov sekundarnih valov k polju v toči T , definirajmo geometrijo problema:

na zaslon padajoče valovanje naj se širi v smeri x , zaslon pri $x = 0$ naj leži v ravnini y, z , torej naj bo vzporeden valovnim frontam upadlega valovanja in reža v njem, ki ima širino L , naj leži, simetrično na os x , v smeri z . Če je dolžina reže mnogo večja od njene širine, je očitno, da mora biti rešitev neodvisna od koordinate z . Z drugimi besedami, rešitev iščemo le v ravnini x, y , kar 3-dimenzionalno nalogo praktično prevede v 2-dimenzionalno in jo znatno poenostavi. Za valovno čelo, ki je izhodišče računa, izberemo ravnino zaslona. Režo si moramo torej zamisliti razdeljeno na primerno majhne dele, ki so izvori sekundarnih valov in v neki točki T za zaslonom seštetih njihove prispevke k polju E .

Električno polje ravnega EM valovanja, ki potuje v pozitivni smeri osi x pred zaslonom, opisuje enačba

$$E(x) = E_0 \sin(\omega t - kx)$$

kjer sta ω krožna frekvenca ($2\pi\nu$) in k valovni vektor ($2\pi/\lambda$, λ je valovna dolžina valovanja). Valovanje, ki se širi iz točkastega izvora, pa opisuje enačba

$$E = (\Lambda/r) \sin(\omega t - kr)$$

kjer sta Λ tako imenovana jakost izvora in r razdalja od izvora do točke T v kateri valovanje opazujemo. V primeru, ki ga obravnavamo, r leži v ravnini x, y . Podobnost izrazov za ravno in krogelno valovanje je očitna, pomembna razlika med njima je le v faktorju $1/r$, ki pri slednjem opisuje zmanjševanje amplitude polja z razdaljo. Režo si mislimo po širini razdeljeno na majhne dele dy . Prispevek vsakega izmed njih k skupnemu polju v točki T je

$$dE = (\Lambda_L/r) \sin(\omega t - kr) dy$$

kjer je Λ_L linearna jakost izvora, Λ/L . Da bi dobili celotno polje, moramo gornje prispevke integrirati po celotni širini reže. V primeru daljnega polja, pri katerem je širina reže L mnogo manjša od r , faktor $1/r$ brez zadrege lahko zamenjamo z $1/R$, kjer je R razdalja od koordinatnega izhodišča (sredine reže) do točke v kateri računamo polje valovanja. Tega pa ne moremo storiti pri prostorsko spremenljivi fazi valovanja kr (torej v izrazu $2\pi r/\lambda$), saj pri njej razdalje očitno merimo v enotah valovne dolžine in je zato faza na majhne spremembe razdalje mnogo občutljivejša kot amplituda. Vendar pa pri računu daljnega polja r v izrazu za fazo lahko zamenjamo s približkom

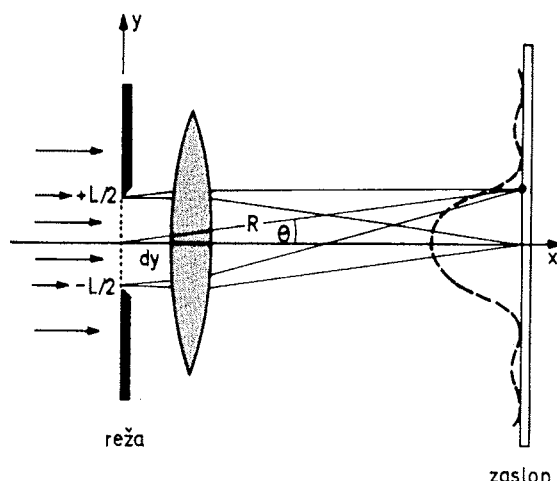
$$r = R - y \sin\theta$$

pri čemer je y koordinata izvora dy v reži (slika 2). Po tej zamenjavi je izraz za skupno električno polje v točki T

$$E = \frac{\Lambda_L}{R} \int_{-L/2}^{L/2} \sin[\omega t - k(R - y \sin\theta)] dy$$

in ga (z zamenjavo spremenljivk) zlahka integriramo:

$$E = \frac{\Lambda_L}{R} \frac{\sin[(kL/2)\sin\theta]}{(kL/2)\sin\theta} \sin(\omega t - kR), \text{ oziroma}$$



Slika 2: Uklon svetlobe na reži s širino L .

$$E = \frac{\Lambda_L}{R} \frac{\sin\beta}{\beta} \sin(\omega t - kR) = \frac{\Lambda_L}{R} \text{sinc}\beta \sin(\omega t - kR)$$

kjer smo $(kL/2)\sin\theta$ zapisali kot β .

Primerjava izrazov za električno polje svetlobe, ki jo sevata reža in točkast izvor, pokaže, da je EM valovanje, ki izhaja iz reže, glede časovne odvisnosti in upadanja amplitude z razdaljo podobno valovanju točkastega izvora, vendar pa ni izotropno - v smereh, torej pri kotih θ , v katerih ima funkcija $\text{sinc}\beta$ vrednost 0 ga enostavno ni. Iz slike 1 je razvidno, da se to prvič zgodi, ko je vrednost njenega argumenta π , torej pri

$$\pi = (kL/2)\sin\theta = (2\pi/\lambda)(L/2) \sin\theta, \text{ oz.}$$

$$L \sin\theta = \lambda$$

V slednjem takoj prepoznamo izraz, ki ga za smer uklonskega minuma prvega reda za uklon svetlobe na ozki reži s širino L daje elementarna teorija uklona /7/.

Moteči časovni odvisnosti električnega polja se izognemo tako, da v izrazu zanj $\sin(\omega t - kR)$ zamenjamo z njegovo

časovno povprečno vrednostjo, ki je $\frac{1}{\sqrt{2}}$. Po takšni zamenjavi postane enakost (do multiplikacijskega faktorja) izrazov za električno polje valovanja, ki ga seva ozka reža v zaslonu, in tistega za Fourierovo transformacijo pulzne funkcije očitna. Enakost ni naključna. Z razširitvijo gornje izpeljave na 2-dimenzionalne reže v zaslonu in njeno manjšo posplošitvijo se da pokazati, da je uklonska slika svetlobe, ki prehaja skozi zaslon s poljubno razporeditvijo in obliko rež, v daljnem polju, vedno enaka Fourierovi transformaciji funkcije, ki opisuje porazdelitev, obliko in propustnost rež na zaslonu. Ugotovitev je za analizo in modeliranje preslikav v projekcijskih poravnalnikih, ki se uporabljajo v mikroelektronski industriji, ter drugod v optiki ključna. In seveda tudi praktična, ker s pomočjo računalnikov Fourierove transformacije poljubne prostorske funkcije lahko izračunamo brez velikih zapletov.

Transmisijska funkcija

Maske, ki se uporabljajo pri izdelavi integriranih vezij, so navadno ravne, kvarčne plošče prevlečene s tanko plastjo kroma. Na mestih, kjer na maski ni kromove plasti, je ta za UV svetlobo izvora prozorna, na prekritih mestih pa zanj povsem neprepustna. Kontrast med svetlimi in temnimi deli maske je velik in zato lahko strukturo na maski zelo natančno opišemo z digitalno transmisijsko funkcijo $f(x,z)$, ki ima vrednost 0 kjer maska ni prozorna in 1 na njenih prozornih delih. Porazdelitev električnega polja svetlobe, ki jo določa takšna maska, je v daljnem polju preprosto

$$E(y_{dp}, z_{dp}) = F[f(y,z)]$$

kjer F pomeni Fourierovo transformacijo. Električno polje je pri preslikavah navadno manj zanimiva količina od gostote energijskega toka, ki je sorazmerna kvadratu električnega polja. Različnim multiplikacijskim faktorjem v izrazih za gostoto toka se pogosto ognejo z vpeljavo iradiance I , ki je le kvadrat polja. Za kotno odvisnost iradiance v primeru dolge reže torej velja

$$I(\Theta) = I_0 \text{sinc}^2 \beta,$$

kjer je I_0 iradianca v smeri optične osi (smeri x). Za masko, ki jo definira transmisijska funkcija maske $f(y,z)$, podaja iradianco v daljnem polju izraz:

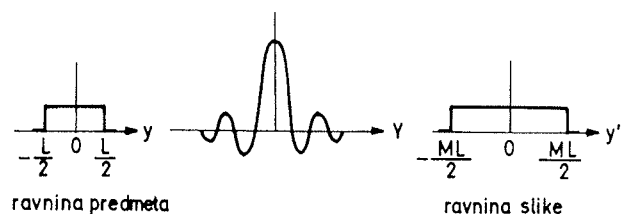
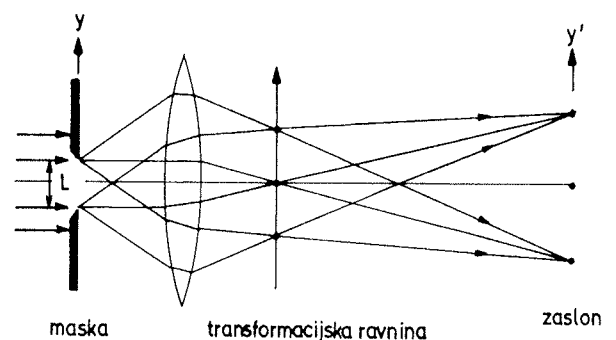
$$I(y_{dp}, z_{dp}) = |F[f(y,z)]|^2$$

Abbejeva teorija preslikave

Pri osvetljevalnih sistemih, ki jih v industriji uporabljajo za preslikavo vzorcev z mask na silicijeve rezine, nas seveda zanimajo predvsem gostote energijskega toka (ali iradianca) na površini fotopolimera. Uklonska slika maske v daljnem polju je, kot smo videli, enaka Fourierovi transformaciji njene transmisijske funkcije in bi jo, v načelu, lahko prestregli in opazovali na dovolj oddaljenem zaslonu. To razdaljo zelo skrajšamo, če za masko postavimo lečo (objektiv). Ker so vsi žarki, ki iz predmeta izhajajo v smeri, določeni s kotom Θ (torej kotom med smerjo razširjanja valovanja in optično osjo sistema), med seboj vzporedni, se po prehodu skozi objektiv sekajo v eni točki. Z drugimi besedami, v goriščni ravnini objektiva nastane Fraunhoferjeva uklonska slika predmeta. Ker je ta slika Fourierova transformacija maske, včasih o objektivu govorijo kot o transformacijski leči in o ravnini v kateri nastane transformirana slika kot o transformacijski ravnini. V našem primeru sta goriščna ravnina objektiva in njegova transformacijska ravnina seveda ista ravnina. Na zaslonu, ki bi ga postavili v to ravnino, bi interferenčno sliko lahko prestregli in opazovali. Če takšnega zaslona ni, pa se svetloba širi še naprej in v neki drugi ravnini, imenovani ravnina slike, rekonstruira sliko maske. Položaje maske, glavne ravnine objektiva, njegove goriščne ravnine in ravnine slike na optični osi povezuje enačba leče

$$1/f = 1/a + 1/b$$

kjer so f goriščna razdalja objektiva, a razdalja od maske (predmeta) do glavne ravnine objektiva in b razdalja od glavne ravnine objektiva do ravnine slike. Proces nastanka slike si morda najlažje pojasnimo tako, da si točke v goriščni ravnini objektiva, kjer se sekajo vzporedni snopi žarkov z maske, predstavljamo kot še ene izvore Huygensovih sekundarnih valov, ki interferirajo v ravnini slike. Prav ta druga interferenčna slika je slika predmeta, ki jo da objektiv (slika 3). Nastanek slike je torej posledica dvojne uklonskega procesa: najprej uklona ravnega valovanja na predmetu in nato uklona valovanj, ki po prvem uklonu potujejo v različnih smereh, na objektivu. Tako je jasno, da pri preslikavi objektiv naredi inverzno Fourierovo transformacijo uklonske slike predmeta.



Slika 3: Nastanek slike je dvojni uklonski proces: slika predmeta nastane zaradi interference svetlobe, ki izhaja iz transformacijske ravnine. M je povečava preslikave.

Ločljivost

Najbrž je očitno, da objektiv lahko rekonstruira popolno sliko predmeta le, če zajame njegovo celotno uklonsko sliko. Praktično je to seveda nemogoče, saj pri uklonu glede velikosti kotov Θ ni nobenih omejitev, vsi objektivni pa imajo končne premere. Če leži predmet na razdalji a pred objektivom, ki ima polmer R , je največji kot med žarki, ki izhajajo iz (majhnega) predmeta in jih objektiv še zajame $\Theta_{\max}$ takšen, da je

$$\text{tg} \Theta_{\max} = R/a$$

Razmerje R/a se imenuje numerična apertura (NA) sistema. (NA iz tehničnih razlogov navadno definirajo kot $\sin \Theta_{\max}$, razlika na tem mestu ni posebno pomembna.) Če želimo z objektivom preslikati nek predmet, recimo rezo, s

tako majhno širino L , da je smer prvega uklonskega minimuma, ki ga določa kot Θ ravno enak numerični aperturi objektiva, torej

$$\sin \Theta = \lambda / L = NA$$

smo očitno na meji resolucije objektiva. Pri še manjših predmetih (ožjih režah) objektivi zajame le še svetlobo ničtega uklonskega maksimuma (torej svetlobo, ki se na reži ne ukloni in skozi sistem potuje v smeri optične osi), v tej pa ni nikakršne informacije o velikosti predmeta. Ta se skriva le v položajih minimov v uklonski sliki in če teh v svetlobi, ki jo zajame objektiv, ni, objektiv predmeta ne more rekonstruirati.

Vpliv omejene kotne velikost objektiva navadno vključijo v modeliranje preslikave z zenično (pupilno) funkcijo objektiva, $P_o(f_y, f_z)$, ki ima vrednost 1, če je $(f_y^2 + f_z^2)^{1/2} \leq NA/\lambda$ in 0, če je $(f_y^2 + f_z^2)^{1/2} > NA/\lambda$, kjer je f_y tako imenovana prostorska frekvenca uklonske slike na objektivu:

$$f_y = y_{ob}/a\lambda$$

f_z je definirana na enak način. Prostorske frekvence, ki jih objektiv lahko transformira (preslika) so očitno omejene z vrednostjo $f_{max} = NA/\lambda$ in zenična funkcija to odraža. Končna velikost objektiva pri preslikavi predmetov z velikimi prostorskimi frekvencami (kar pomeni z majhnimi dimenzijami) igra isto vlogo kot, na primer, nizkopasovni filter pri prenosu ostrih pulznih signalov. Takšen filter signale (seveda v časovni domeni) zaobli, objektiv pa podobno (v prostorski domeni) ne preslika podrobnosti predmeta, ki so skrite v velikih prostorskih frekvencah njihove uklonske slike.

Zenično funkcijo vključimo v izraz za preslikavo in porazdelitev električnega polja na mestu slike zapišemo kot

$$E(y_s, z_s) = F^{-1}[E(y_o, z_o) P_o(f_y, f_z)] = F^{-1}\{F[E(y, z)] P_o(f_y, f_z)\}$$

kjer je F^{-1} inverzna Fourierova transformacija. Iradianca na mestu slike pa je, kot vedno, $|E(y_s, z_s)|^2$.

Povečanje ločljivosti

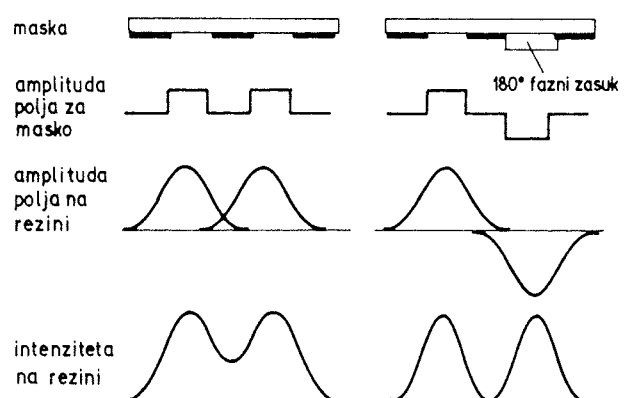
Najmanjšo velikost predmetov, ki jih z nekim projekcijskim poravnalnikom lahko preslikamo z maske na fotopolimer in rezino, torej v načelu omejuje končna ločljivost optičnih sistemov. Vendar sta poznana vsaj dva načina kako povečati ločljivost projekcijskih sistemov /4/. Prvi temelji na dejstvu, da je uklonska slika, na primer reže, simetrična glede na ravnino x, z in da zato vključuje informacijo o velikosti reže dvakrat: enkrat v uklonskih minimih v smeri osi $+y$ ter drugič v minimih v smeri $-y$. Za verno preslikavo pa takšna dvojnost pravzaprav ni potrebna in v načelu za rekonstrukcijo slike zadošča že uklonjena svetloba, ki se od predmeta širi k objektivu le, recimo, nad optično osjo sistema. Če bi objektiv z določeno NA za njegov polmer premaknili vzdolž osi y , bi po premiku njegov spodnji del zajel le še na maski neuklonjeno svetlobo, njegov zgornji del pa dodatno še uklonjeno svetlobo višjih redov. Zaradi vključitve te svetlobe v preslikavo bi bila tudi slika reže ostrejša.

Prav isto bi seveda dosegli z objektivom, ki ima 2 krat večji polmer (in ustrezno večjo NA), ter z zaslonom, ki bi zastrl del objektiva pod optično osjo. Eno ali drugo bi povečalo ločljivost, toda tudi v preslikavo vneslo nesprejemljive aberacije. Podobno bi enako povečanje ločljivosti (iz istega razloga in s podobnimi aberacijami) brez premikanja ali zastiranja objektiva dosegli tudi tako, da bi masko osvetlili pod kotom Θ_{max} . Dejansko so koti izvenosnega osvetljevanja, ki še omogočajo nepopačeno preslikavo, hkrati z nekoliko večjo ločljivostjo, mnogo manjši od Θ_{max} , toda tehnika je pri konstrukciji projekcijskih poravnalnikov često uporabljena.

Povsem drugačna tehnika povečevanja ločljivosti projekcijskih osvetljevalnih sistemov temelji na manipulaciji faze, s katero uklonjena svetloba izstopa iz maske /8/. Za nek del maske lahko postavimo planparalelno ploščico iz snovi z lomnim količnikom n in debelino t , izbrano tako, da del svetlobe, ki gre skozi ploščico, glede na svetlobo, ki gre mimo nje, zaostane za fazni kot π . Debelino t fazne ploščice določa enačba

$$t = \frac{\lambda}{2(n-1)}$$

Deli svetlobe, ki gredo skozi fazno ploščico, pri rekonstrukciji uklonske slike seveda sodelujejo z za π spremenjeno fazo, ali z drugimi besedami, električno polje teh delov svetlobe je pomnoženo s faktorjem -1 . S primerno razporeditvijo faznih ploščic po različnih delih maske je mogoče doseči, da se električno polje na določenih delih slike na rezini izniči. S fazno masko torej lahko dosežemo, da ostanejo deli rezine, ki bi bili pri osvetlitvi z navadno masko osvetljeni, neosvetljeni. Princip delovanja faznih mask je prikazan na sliki 4. V okviru Fourierove optike je



Slika 4: Princip povečanja ločljivosti preslikave z uporabo fazne maske (po /8/).

njihov učinek na ločljivost prav enostavno pojasniti: 180-stopinjski fazni premiki na primerno izbranih delih maske razpolovijo osnovno prostorsko frekvenco vzorca na maski (kar je razvidno iz slike) in zato lahko objektiv z določeno NA, ki sicer deluje na meji ločljivosti, takšne dele maske preslika z velikim kontrastom. Kakšna mora biti razporedi-

tev faznih ploščic na maski s preprosto periodično strukturo je očitno, v splošnem pa načrtovanje fazne maske ni enostavna naloga. Na slikah v /5/ so prikazani primeri simulacije (s programom FOLIS) faznih mask z nekoliko bolj zapleteno strukturo.

MTF

Ločljivost nekega optičnega instrumenta je vsekakor pomembno merilo njegove zmogljivosti, nikakor pa ne edino. Fotolitografske maske tipično niso objekti s preprosto periodično strukturo, katere preslikavo na rezino bi omejevala le ločljivost projekcijskega poravnalnika. Na njih so navadno objekti različnih dimenzij, z bolj ali manj ostrimi vogali itd. in pravi izziv za konstruktorje osvetljevalnih naprav je kontrastna preslikava celotne maske in ne le zadovoljiva preslikava njenih najmanjših delov. Priljubljena analogija preslikavi realne maske je s področja elektroakustike: ocenjevati kvaliteto neke HiFi naprave le po najvišji frekvenci, ki jo zmore reproducirati, je očitno precej pomanjkljivo. Veliko več bi o kvaliteti reprodukcije povedal nek kriterij, ki podaja zmogljivosti naprave v njenem celotnem frekvenčnem območju. Kot takšno merilo kvalitete preslikave se je v optiki uveljavila modulacijska prenosna funkcija (modulation transfer function, MTF) /3/.

Če ob prehodu svetlobe skozi fotolitografsko masko pustimo podrobnosti sipanja itd. povsem ob strani, lahko prehod obravnavamo kot modulacijo curka svetlobe. Na mestih, kjer maska svetlobo prepušča, ostaja gostota svetlobnega toka (oz. iradianca) nespremenjena, na mestih, ki so zakrita s plastjo kroma, pa maska svetlobe sploh ne prepušča. Na osnovi te ugotovitve smo že definirali transmissijsko funkcijo maske in podobno definiramo tudi modulacijo M_M svetlobnega toka, ki prehaja skozi masko, kot

$$M_M = \frac{I_{oM} - I_{tM}}{I_{oM} + I_{tM}}$$

kjer sta I_{oM} največja in I_{tM} najmanjša gostota toka po prehodu svetlobe skozi masko. Povsem enako definiramo modulacijo svetlobe v ravnini slike

$$M_S = \frac{I_{oS} - I_{tS}}{I_{oS} + I_{tS}}$$

MTF optičnega sistema je definirana kot

$$MTF = M_S/M_M$$

in meri kontrastnost slike pri preslikavi. Ker je v praksi transmissijska funkcija maske domala idealno digitalna in je zato M_M zelo natančno enak 1, je prenosna funkcija sistema praktično enaka M_S . Iz opisa mehanizma preslikave bi moralo biti očitno, da je MTF funkcija velikosti struktur na maski, ki jih želimo preslikati. Če so te velike, da preslikava verno, zelo kontrastno sliko predmeta in je vrednost MTF blizu 1. Pri strukturah, ki so istega reda velikosti kot ločljivi-

vost projekcijskega poravnalnika, pa je vrednost MTF blizu 0. Velikost struktur na maski opisuje njena prostorska frekvenca u , ki je za masko, podobno uklonski mrežici, navadno podana kar kot število linij na milimeter. Frekvenca u seveda ni enaka (na žalost pa se enako imenuje) prostorski frekvenci predmeta f_x , ki smo jo srečali pri obravnavi uklona. Dejansko MTF navadno podajajo kot funkcijo normalizirane prostorske frekvence ξ , ki je kvocient obeh, to je

$$\xi = u/f_x$$

Izpeljava MTF za nek optični sistem je sorazmerno nazorna in nezahtevna le za lečo, ki je pri projekcijskih osvetljevalnih sistemih pravzaprav nikoli ne srečamo, namreč za idealno cilindrično lečo. Zato nam v to kisljo jabolko ni treba ugrizniti, omenimo le, da je pri taki leči izpeljava nezahtevna zaradi preproste, cilindrične simetrije rež na maski in leče. Uklonsko omejena MTF za takšno lečo brez aberacij, pri monokromatski svetlobi je

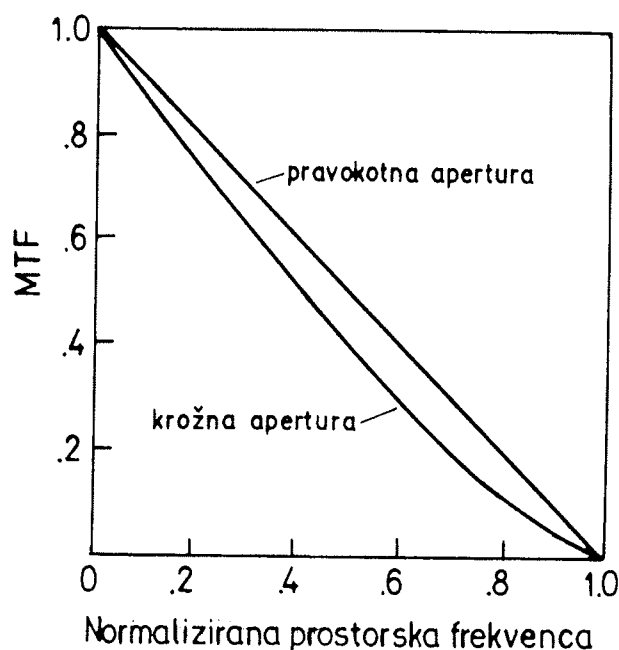
$$MTF(\xi) = (1 - \xi)$$

Za sferično lečo, pri istih pogojih, je MTF

$$MTF = \frac{2}{\pi} \left[\arccos(\xi) - \xi \sqrt{1 - \xi^2} \right]$$

Analogija med obema izrazoma je morda opazna, njuna podobnost na grafu obeh funkcij pa očitna (slika 5). Omeniti je treba, da je pri sferični leči in krožnem predmetu, ki ga leča preslikuje, (kotna) prostorska frekvenca f_r definirana nekoliko drugače kot pri reži,

$$f_r = (2\Theta_{\max} \sin \Theta_{\max})/\lambda$$



Slika 5: MTF za okroglo in pravokotno zaslonko objektiv.

Definicija prenosne modulacijske funkcije nekega sistema, kot je opisana, strogo velja le za preslikavo s koherentno svetlobo. Koherentni pogoj za nek izvor svetlobe je

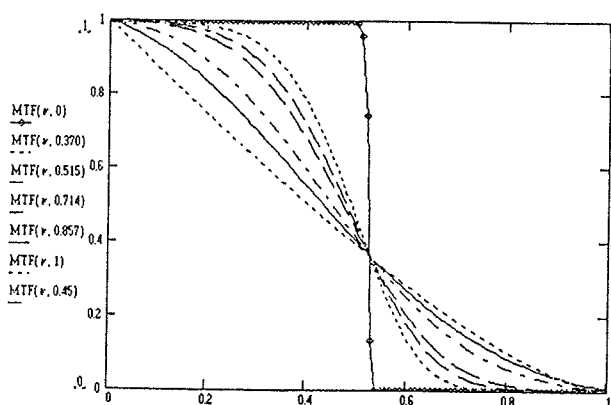
$$d \sin \phi \ll \lambda/2$$

kjer sta d premer izvora in ϕ največji kot med žarkom, ki ga optični sistem še zajame, in optično osjo sistema. Realni izvori končnih dimenzij koherentnemu pogoju lahko zado-
stijo le, če ležijo v neskončnosti, pri takšnem položaju izvora pa je gostota energijskega toka na mestu maske seveda 0. V praksi se problem koherence izvora navadno reducira na razmerje numeričnih apertur kondenzorske in projekcijske optike fotolitografskega sistema in je stopnja nekoherence s definirana kot

$$s = NA_{kon}/NA_{pr}$$

s za idealno koherenten izvor, ali izvor v neskončnosti je torej 0. Na prvi pogled bi morda sodili, da je prav takšen najbolj primeren za potrebe optične litografije, vendar ni tako. Videli smo že, da z izvenosnim osvetljevanjem maske, ki nosi strukture z veliki prostorskimi frekvencami (zelo majhne strukture), natančneje preslikamo kot z osvetljevanjem v osi. Tudi delna nekoherenca izvora privede do tega, da vsa svetloba na masko ne pade pod natančno pravim kotom. Zaradi tega se uklonska slika maske razprši v večji kot kakor pri koherentni osvetlitvi, takšen, ki ga NA objektiva ne zajame več. Slika maske je zato na ravni silicijeve rezine seveda nekoliko bolj razmazana. Zaradi delne izvenosne osvetlitve pa objektiv hkrati zajame tudi del uklonjene svetlobe z drobnih struktur na maski, ki bi jo sicer povsem izločil in jih preslika. Preslikava z delno nekoherentno svetlobo je zato ostrejša.

Stopnjo koherentnosti izvora se da vključiti v MTF [9], toda analitični izraz za MTF(ξ, s) nespecialistu na žalost ne pove prav ničesar. Ponovno si pomagamo z grafom. Na sliki 6 je prikazana simulacija MTF(ξ, s) s programom FOLIS za nek dejanski projekcijski osvetljevalni sistem. Povsem očitno je, da vrednost MTF(ξ, s) pri normaliziranih prostorskih frekvencah ξ , ki so večje od 0,5, narašča z naraščajočo



Slika 6: Simulacija MTF s programom FOLIS za projekcijski osvetljevalni sistem UTS 1100 z Wynne-Dysonovo optiko.

stopnjo nekoherentnosti. Praviloma takšno odvisnost MTF(ξ, s) od s opazimo pri vseh projekcijskih poravnalnikih. To pomeni, da je običajno pri velikih prostorskih frekvencah predmeta (maske) kontrastnost slike pri preslikavi z delno koherentno svetlobo večja kot pri preslikavi s koherentno in preslikava majhnih objektov z maske na površino rezine boljša. Le omenimo, da nelinearni odziv fotopolimera na osvetlitev, kontrast v fotopolimer prenesene fizične slike lahko še izboljša. Še boljši približki MTF nekega optičnega sistema vključujejo tudi efekte globine fokusa, aberacij optičnega sistema, odstopanj optičnih elementov sistema od idealne oblike itd. Vse te popravke v MTF navadno vključijo kot fazno aberacijo ϕ sistema, ki ga torej okarakterizira prenosna funkcija treh spremenljivk, MTF(ξ, s, ϕ).

Zaključek

Vse predstavljene metode analize optičnih preslikav se v takšni ali drugačni obliki uporabljajo v simulacijskih orodjih za modeliranje fotolitografskega osvetljevanja rezin. V praksi jih dopolnjujejo računalniške metode hitrega Fourirovega obrata (FFT), ki so danes postale povsem vsakdanje, in množica empiričnih modelov različnih podrobnosti preslikave. Združiti vse to v uporabno simulacijsko orodje je zahtevna naloga, ki je brez poznavanja osnov optične teorije nerešljiva. V Laboratoriju za mikroelektroniko, Fakultete za elektrotehniko, Univerze v Ljubljani je bilo razvito simulacijsko orodje FOLIS v katerem je opisana teorija implementirana.

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HW/SW PARTITIONED OPTIMIZATION AND VLSI-FPGA IMPLEMENTATION OF THE MPEG-2 VIDEO DECODER

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Key words: MPEG-2 video decoder, FPGA implementation, optimization, ISO/IEC 13818-2, power consumption, speeding-up, inverse discrete cosine transform-IDCT, variable length decoding-VLD, Huffman coding, embedded system

Abstract: In this paper, we have proposed optimized real-time MPEG-2 video decoder. The decoder has been implemented in one FPGA device as a HW/SW partitioned system. We made timing/power-consumption analysis and optimization of the MPEG-2 decoder. On the basis of the achieved results, we decided for hardware implementation of the IDCT and VLD algorithms. Remaining parts were realized in software with 32-bit RISC processor. MPEG-2 decoder (RISC processor, IDCT core, VLD core) has been described in high-level Verilog/VHDL hardware description language and implemented in Virtex 1600E FPGA. Finally, the decoder has been tested on the Flextronics prototyping board.

Strojno in programsko razdeljena optimizacija in FPGA implementacija MPEG-2 video dekoderja

Ključne besede: MPEG-2 video dekodek, FPGA implementacija, optimizacija, ISO/IEC 13818-2, poraba moči, pohitritev, inverzna diskretna kosinusna transformacija-DCT, dekodiranje s spremenljivo dolžino-VLD, Huffmanovo kodiranje, vgrajeni sistem

Izvleček: V članku smo predstavili optimiziran MPEG-2 video dekodek namenjen dekodiranju v realnem času. Dekodek smo realizirali v enem FPGA vezju kot kombinacijo programske in strojne rešitve. Opravili smo analizo in optimizacijo hitrosti delovanja ter porabe moči MPEG-2 dekoderja. Na podlagi rezultatov smo se odločili, da časovno in energijsko zahtevne algoritme (inverzna kosinusna transformacija ter dekodiranje s spremenljivo dolžino) realiziramo direktno v strojni opremi, ostale dele dekoderja pa realiziramo z RISC mikroprocesorjem. Celoten MPEG-2 dekodek (RISC procesor, IDCT jedro, VLD jedro) smo opisali v visokonivojskih jezikih Verilog in VHDL in ga implementirali v Virtex 1600 programirljivem FPGA vezju. Vezje dekoderja smo nato preizkusili v realnem testnem okolju na FPGA prototipnem sistemu proizvajalca Flextronics.

1. Introduction

MPEG-2 video standard is an important standard for video compression today /1/. MPEG-2 coding/decoding algorithm can be found in different applications such as digital video broadcast, DVD, cable TV, graphics/image processing cards, set top boxes, digital cameras, SDTV and HDTV. Due to different profiles and levels of the MPEG-2 video standard, every application has specific ratio between performance and quality. Since modern multimedia applications increase both aspects of the MPEG-2 compression, it is necessary to achieve best performance in terms of real-time operation and reduced hardware cost.

The MPEG-2 standard includes several compression techniques such as variable length coding (VLC), discrete cosine transform (DCT), quantization and motion compensation. It was shown that some of these parts can be optimized with parallel structures and efficiently implemented in the hardware-software partitioned system. Recently, several MPEG-2 decoders have been developed either as software based applications /2/ or hardware based ASIC custom chips /3/.

A parallel decoder for the MPEG-2 standard implemented on a shared memory multiprocessor was presented in /2/. The primary goal of this approach was to provide an all-

software memory solution for real-time high quality video decoding and to investigate the important properties as they pertain to multiprocessor systems.

In /3/, a VLSI chip for real-time decoding of MPEG-2 video was developed as hardware based ASIC device with un-optimized decoding functions.

In literature, we haven't found any description of combined hardware-software implementation of the MPEG-2 decoder on a single chip. The reason is probably the lack of technology that provides efficient hardware/software implementation. With the recent advantages in technology from leading manufactures of the programmable devices (Xilinx-Microblaze /4/, Altera-Nios /5/), the proposed design gain importance. The VLC decoding algorithm and IDCT algorithm are implemented with fast parallel architectures directly in hardware. Hardware part is described in VHDL/Verilog and implemented together with the RISC processor in a single Virtex 1600E FPGA device. Decoding of the coded bitstream, inverse quantization, motion-compensation are running in software on 32-bit RISC processor which is implemented in FPGA and uses Linux as the operating system. This is so due to the non-existence of efficient parallel architectures for these algorithms. This partitioning was selected in order to achieve better timing properties and lower power consumption.

With the proposed parallel optimization in hardware, up to 40% improvement is achieved compared to the complete software implementation. The main benefit of our MPEG-2 decoder is leveraging best characteristics from hardware and software based solutions. The proposed MPEG-2 video decoder was tested on the Flextronics FPGA based industrial board /6,7/ which serves as a testing environment and forms the intermediate step in VLSI chip design cycle.

This paper is organized as follows: the next section describes timing optimization and optimization of the power consumption of the decoder. The implementation of the MPEG-2 decoder is presented in Section 3. Finally, Section 4 completes the paper with a conclusion and future work.

2. Optimization of the MPEG2 Video Decoder

As illustrated in Figure 1, coded pictures are first variable length (Huffman) decoded and their type is determined from the header information. Pictures are inverse scanned and inverse quantized. Inverse quantization is performed in two steps. Data are first divided with a quantization-step matrix and then scaled with a scale factor.

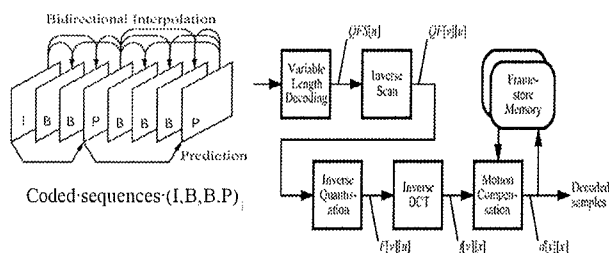


Figure 1: Structure of the ISO/IEC 13818-2 MPEG-2 video decoder

MPEG-2 standard defines 3 types of the coded frames (I, P, B pictures). Intra-coded pictures I take advantages of the picture's spatial correlation. They do not reference any other pictures in the coded bit stream. They provide fast random access with only moderate compression. I pictures are only DCT decoded while no motion compensation is performed. Inter-coded pictures P, B consider also temporal correlation between successive pictures (motion compensation). P pictures are decoded using motion-compensated prediction from the past I or P pictures which are stored in the Frame-Store-Memory. The compression for P pictures is better than for I pictures, and P pictures can be used as reference points for additional motion compensation. Bidirectionally predicted pictures B provide the highest degree of compression. They are decoded using motion-compensated prediction from either past and/or future I or P pictures. Since B pictures are not used in the prediction of other B or P pictures, such pictures accommodate more distortion and hence yielding more compression than I or P pictures.

The ISO/IEC 13818-2 (MPEG-2 video part) standard defines only the frame for different algorithms included in the standard /8/. Therefore, there are various possibilities to optimize particular parts of the decoder.

In order to deal with timing and power-consumption optimization, we have developed a software support in visual C++ programming language. A screenshot of the software tool is shown in Figure 2.



Figure 2: Program for MPEG-2 software simulation

This software allows us to simulate input sequences with different settings (profile/level, bit-rate, I/P frame distance, number of frames in GOP, frame/field pictures and all other coder/decoder parameters). The complete analysis can be performed and timing properties of particular algorithms included in the standard can be simulated. For timing analysis, elapsed time of the decoding parts in milli-seconds is measured for every decoded sequence. Finally, the speed of the program execution is evaluated. Based on the obtained results, we have estimated equivalent decoding speed for real-time decoding.

2.1. Timing Optimization

Figure 3 shows a computational load of the decoding functions in MPEG-2 decoder.

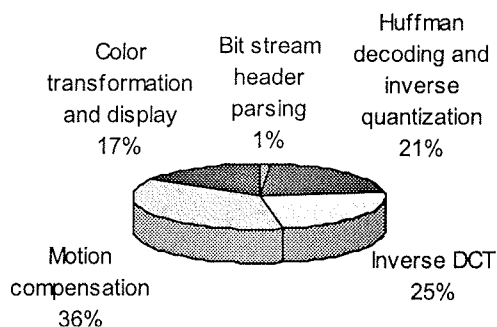


Figure 3: Computational power distribution for MPEG-2 decoding

The data in the Figure 3 are based on simulations of source input format (SIF) (352x244, 25Hz) resolution pictures coded at 4 Mbits/s containing two B-pictures for every P-picture. As illustrated in Figure 3, the most computational expensive parts of the decoder are motion compensation, inverse DCT and VLD decoding.

The main idea of our decoder is to exploit advantages of the parallel structures which can be efficiently implemented in hardware. Hardware implementation of DCT and VLD decoder promises better results compared to software based algorithms. The key point of a parallel hardware structure is reduced number of operation and an ability to work in parallel. On the contrary, hardware implementation of motion compensation does not gain performance versus software based solution. In our decoder, we have therefore built fast hardware cores for IDCT and VLD decoder.

The basic computation element in a DCT-based system is the transformation of an NxN image block from the spatial domain to the DCT domain and vice versa. For the image compression standards, N is usually 8. From a hardware or software implementation point of view, an 8x8 block size does not impose significant memory requirements. Furthermore, the computational complexity of an 8x8 DCT is manageable on most computing platforms. Mathematical formulation for the 2D discrete cosine transform is shown in (1).

$$F(u, v) = \frac{C_u C_v}{4} \sum_{x=0}^7 \sum_{y=0}^7 f(x, y) \cos\left(\frac{(2x+1)u\pi}{16}\right) \cos\left(\frac{(2y+1)v\pi}{16}\right)$$

$$C_u, C_v = \frac{1}{\sqrt{2}} (u, v = 0) \dots \text{otherwise } 1$$

$$\begin{aligned} x, y & \text{ coordinates in pixel domain}(0 \dots 7) \\ u, v & \text{ coordinates in DCT domain}(0 \dots 7) \end{aligned} \quad (1)$$

The separable nature of the 2D DCT is exploited by performing the 1D DCT on the eight rows and then the 1D DCT on the eight columns /9/. Several fast algorithms are available for calculation of the 8-point 1D DCT. In our decoder, scaled version of Chen has been used /10/. It was selected due to the minimum required number of additions and multiplication. Structure of Chen DCT is illustrated in Figure 4.

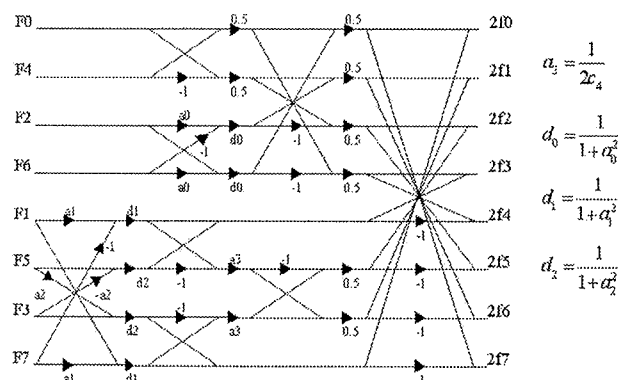


Figure 4: Modified Chen 1D inverse DCT structure

For variable length decoder (VLD), a lookup table based decoder structure proposed by Lei and Sun /11/ has been used. It is one of the fastest known variable length decoders today /1/. It decodes each codeword in a single cycle regardless of its length. The block diagram of the Lei-Sun VLD is illustrated in Figure 5.

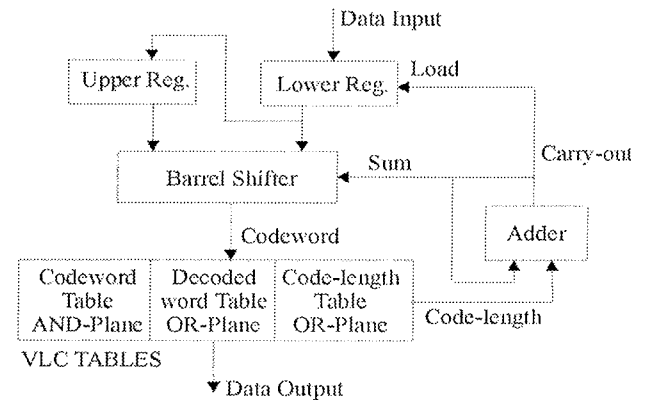


Figure 5: Block diagram of the Lei-Sun variable length decoder

Coded data are always concatenated together and segmented into 16-bit words. When the 16-bit lower and upper register are fully loaded, the decoding process starts. At each cycle, the output of the barrel shifter is matched in parallel with all the entries in the codeword lookup table. The barrel shifter operates like a sliding window on the contents of the two registers. When a match is found, the lookup table outputs the corresponding source symbol and the length of the decoded codeword. The barrel shifter is then shifted to the beginning of the next codeword. As the 4-bit adder overflows 16, this indicates that the upper register has been fully decoded. After the content of the lower register is transferred into the upper register, the VLC decoder loads a new 16-bit segment into the lower register, and operations continue.

Once the IDCT and VLD had been modeled in VHDL, we have performed timing simulation of MPEG-2 decoder. IDCT 1-D Chen structure is described in VHDL at RTL level. Our simulations have shown a delay of 100 ns for 1-D IDCT and 1.6 μ s for 2-D 8x8 IDCT targeting the Xilinx FPGAs. In the VLD decoder, every coded symbol can be decoded in only one cycle. Since the prototyping evaluation board operates at 25 MHz, 40 ns delay for each decoded data is required.

Our results show up to 40% improvement of speed for MPEG-2 decoding compared to software based solution. The results before and after optimization are presented in Figure 6.

These results have been obtained with the software decoding speed of 45 MHz. We have calculated equivalent decoding speed for the real-time decoding rate (40 ns for 25 Hz frame rate) which was 72 MHz. As seen in Figure 6, there are great deviations from the average decoding times.

This is a consequence of the irregular CPU tasks and can be ignored.

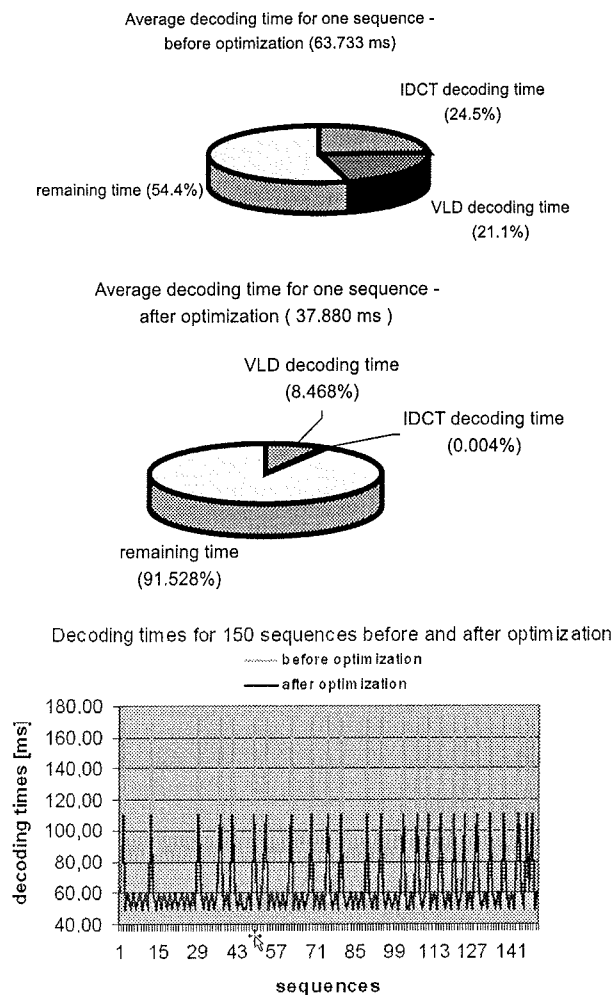


Figure 6: Results of the timing simulation before and after optimization

2.2. Power Consumption Analysis

At this point, we summarize results of the detailed energy conscious study made by Henkel and Li /12/. The study is based on the idea that an application specific hardware can be more energy efficient due to the higher utilization. They made an energy dissipation study by distinguishing five different cases of HW/SW partitioned MPEG-2 encoder (Figure 7). As a reference case a complete software implementation was used. Then, four candidate hardware parts were synthesized (quantization-case 1, two dimensional DCT-case 2, one dimensional DCT-case 3, quantization and two dimensional DCT-case 4) and analyzed. The encoder was intended to run on an architecture composed of the CPU, instruction and data cache, a main memory and an application specific hardware (ASIC). Since every encoder also includes a duplicated decoder, results can be easily adopted for the MPEG-2 decoder. As illustrated in Table 1, each of the selected co-designs in cases 1 to 4 yields an energy savings up to 48% compared to the reference case of software based solution.

Case	Energy [mJ]		
	SW	HW	total
Case 0: All SW Solution	74.32	N/A	74.32
Case 1: Quant. in HW, rest in SW.	49.33	14.09	63.42
Case 2: 2-D DCT in HW, rest in SW.	27.16	0.709	27.869
Case 3: 1-D DCT in HW, rest in SW	49.51	0.156	49.666
Case 4: Quant. and 2-D DCT in HW rest in SW	16.99	22.27	39.26

Table 1: Energy dissipation for selected co-designs

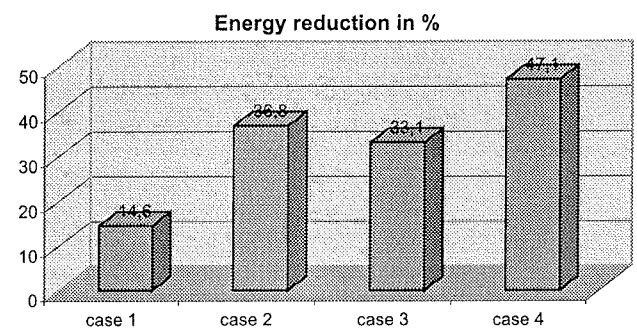


Figure 7: Results of the case study for energy-conscious HW/SW partitioning

3. VLSI-FPGA Implementation of the MPEG-2 Video Decoder

3.1. System Environment

Our HW/SW partitioned MPEG-2 decoder has been tested on the Flextronics /6/ FPGA based prototyping board (Figure 8).

The heart of the board is the Xilinx Virtex 1600E FPGA /13/. Several peripheral devices and connectors (ethernet, VGA, LCD, GSM, UART, IDE, PS2) serve as interfaces from the FPGA to the external world. 32 MByte flash,

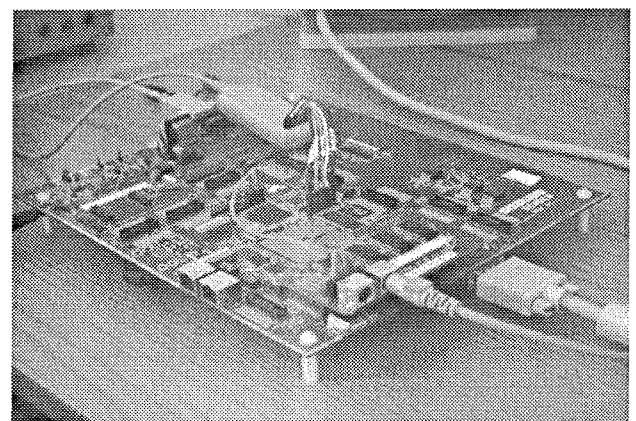


Figure 8: Flextronics prototyping board

64 MByte SDRAM, and 4 MByte SRAM allow implementation of the complex FPGA applications. For the MPEG-2 decoder, we are using flash memory (loaded input sequences), SRAM, UART (display of the MPEG-2 decoding messages) and VGA output to the display.

Every hardware core is first described in Verilog or any other high level hardware description language (HDL). We have used Synplify tool /14/ for circuit synthesis and Xilinx ISE tool /15/ for target implementation. Once the hardware is designed, there are two options how to port software applications on the board. The first is to use Linux operating system. On the RISC processor and various peripheral hardware cores (ethernet, ps2, uart etc), we can port derivative of Linux kernel (uClinux) which is intended for microcontrollers without Memory Management Units (MMUs). The second option is to use the monitor program which is loaded into the RAM of the RISC controller. The latter method is used during the development cycle. When an application meets the requirements, it is compiled for the Linux operating system.

3.2 FPGA Implementation

Our HW/SW partitioned decoder is composed of three parts: a 32-bit RISC processor, IDCT and VLD hardware cores (Figure 9).

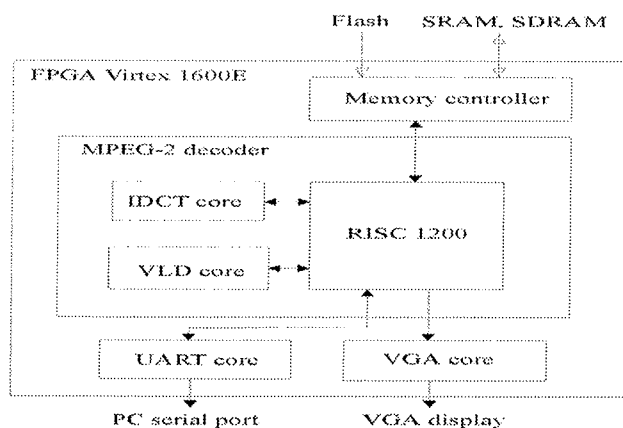


Figure 9: Block diagram of the implemented MPEG-2 decoder

The decoded frames are displayed on the analog monitor. During the MPEG-2 decoding process, we can also see possible decoding errors and warnings ("buffer overrun" for example). For this purpose, we have implemented the VGA Controller core (display of decoded frames) and UART communication core into the FPGA. For the memory accesses from RISC to external memory, the FPGA contains memory controller core.

The RISC processor is based on OpenRISC 1000 /7/ design and is a 32-bit scalar RISC with Harvard microarchitecture, 5 stage integer pipeline, virtual memory support (MMU) and basic DSP capabilities. Default caches are 1-way direct-mapped 8KB data cache and 1-way direct-mapped 8 KB instruction cache, each with 16-byte line

size. Both caches are physically tagged. Block diagram is shown in Figure 10.

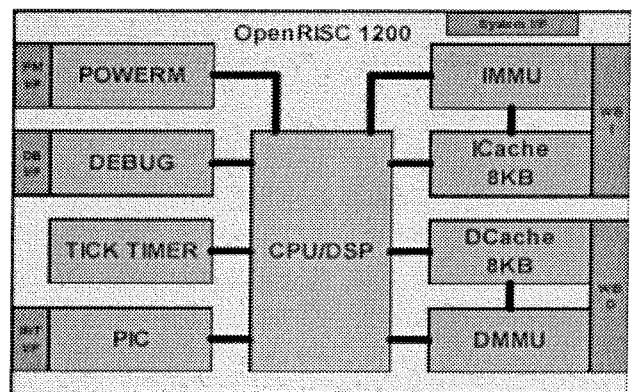


Figure 10: Architecture of the RISC controller

Supplemental facilities include a debugging unit for real-time debugging, a high resolution tick timer, a programmable interrupt controller and power management support. When implemented in a typical 0.18u 6LM process, it provides over 300 dhrystone 2.1 MIPS at 300 MHz and 300 DSP MAC 32x32 operations. OR1200 is intended for embedded, portable and networking applications.

IDCT core follows the Chen IDCT structure described in Section 2.1. The core is described with logic functions at the RTL level. It works with row-column decompositions since 2-D DCT can be computed with 1-D DCT. The simplified architecture is shown in Figure 11.

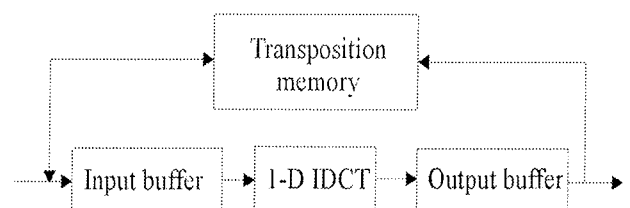


Figure 11: Simplified IDCT core architecture

The architecture of the VLD decoder is described in Figure 5. From the implementation point of view, this core is more complex compared to IDCT core. Due to the need of proper internal logic synchronization, the most complex part is controller of variable length decoding steps. There is also a problem of difficult implementation and routing of the VLD table circuit. MPEG-2 standard specifies 11 different variable length code tables with up to 17 bits wide codewords. Hardware implemented VLD decoding tables require several FPGA look up tables (LUTs), since every Virtex LUT is only 4bit wide. This problem was solved building large (over 12 bits wide) VLD tables with a use of smaller VLD tables.

3.3 Implementation Results

Virtex 1600E device (Figure 12) features a flexible, regular architecture that comprises an 72x108 array of confi-

gurable logic blocks (CLBs) surrounded by programmable input/output blocks (IOBs), all interconnected by a hierarchy of fast, versatile routing resources. CLBs interconnect through a general routing matrix (GRM). The GRM comprises an array of routing switches located at the intersections of horizontal and vertical routing channels. Virtex 1600E also includes 589824 bits of dedicated memory (BlockRAM) and Clock DLLs for clock-distribution delay compensation. For Clock distribution, FPGA uses fast specially dedicated global clocks (GCLKs, GCLKIOBs) or local routing resources GRM. The VersaRing I/O interface provides additional routing resources around the periphery of the device. This routing improves I/O routability and facilitates pin locking.

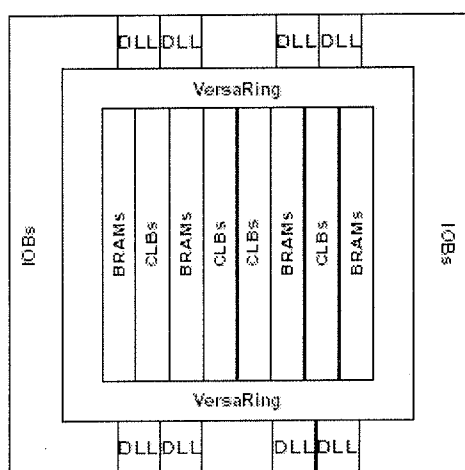


Figure 12: Virtex 1600E architecture

Each CLB is organized in two slices and provides the functional elements for constructing logic. IOBs provide the interface between package pins and the CLBs. Table 2 shows implementation results of the MPEG-2 decoder in the Virtex 1600E FPGA.

Number of:	RISC1200	IDCT	VLD
SLICES	22%	8%	10%
BlockRAMs	12%	0	0
IOBs	90%	20%	6%
GCLKs	75%	75%	25%
GCLKIOBs	90%	25%	25%

Table 2: Utilization of the FPGA

Results in the Table 2 have been obtained with separate implementation of the particular modules (RISC, IDCT, VLD). The most important data is the number of the SLICES (basic FPGA structure) and BlockRAMs. In the common implemented MPEG-2 decoder, this resources are merged together. Entire MPEG-2 decoder utilizes 40% of the Virtex device. Other resources (IOBs, GCLKs, global clock IOBs-GCLKIOBs) are shared, so the decoder utilizes 90% IOBs, 75% GCLKs and 90% GCLKIOBs. As we can see in Table 2, there is about 60% free of space for other applications.

4. Conclusion

In this paper, we have proposed an optimized MPEG-2 video decoder. We have considered optimization of speed and power consumption. Both, timing and the power consumption optimization show correlated results by achieving optimized MPEG-2 decoder. We have shown that 40% higher decoding speed and 36% lower power consumption can be obtained with combined hardware and software implementation. From a power-consumption point of view, it would be reasonable to implement quantization in hardware, but this guarantees any improvements of the decoding speed.

We have presented a modern implementation method where the complex embedded system (MPEG-2 decoder) can be efficiently HW/SW partitioned and optimized. In the future work, we will concentrate on timing optimization and HW/SW implementation of the next generation standard (MPEG-4).

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MONTAŽA PLOŠČ TISKANIH VEZIJ Z ZLITINAMI BREZ SVINCA

Breda Kodek

Razvoj & raziskave, Laboratorijski center, Iskraemeco d.d., Kranj

Ključne besede: plošča tiskanega vezja (TIV), spajkalna pasta, spajka, spajkanje, komponenta, klimatski test, odtržna sila, kot omočenja

Izvleček: Za obdobje spajkanja brez svinca v elektronski industriji smo testirali spoje med elektronskimi komponentami in ploščo tiskanega vezja (TIV). Komponente smo prispajkali na kositrne in zlatene vzorce TIV s spajkalno pasto brez svinca, na TIV izdelane po Hot Air Solder Leveling (HASL) postopku pa z običajno spajkalno pasto s svincom. Vzorce smo starali na pospešenih klimatskih testih, ki simulirajo klimatske obremenitve pri uporabi v naravi. Z merjenjem odtržnih sil in mikroskopskimi preiskavami smo primerjali kvalitete spojev. Rezultati raziskav so pokazali, da se spoji po fizikalnih lastnostih nekoliko razlikujejo od običajnih, narejenih s spajkalno pasto, ki vsebuje svinec, vendar so še dovolj trdni in lahko zadovoljujejo zahteve mednarodnih standardov za elektronsko industrijo. Tudi po pospešenih testih rezultati niso bistveno slabši.

Assembling of Printed Circuits Boards with the Lead Free Alloys

Key words: Printed Circuits Board (PCB), solder paste, solder, soldering, component, climatic test, pull off strength, angle of wettability

Abstract: The soldered joints of assembled printed circuit boards (PCB) for the lead free time were tested. The components were soldered with the lead free solder paste on the tinned and flash gold finished PCBs but with the normal lead solder paste on the Hot Air Solder Leveling (HASL) finished PCB. The samples were exposed to some accelerated climatic tests as a simulation of different climatic changes in use. The quality of the joints was investigated by measuring of the pull off strength and microscopic research. There are some conclusions from this research work that could help us to work in the electronic industry in the lead free time.

The wettability of the lead free solders on the tinned PCBs and the PCBs finished with the flash gold is good enough to satisfy the demands for a good joint. There are inter-metallic structures in all three investigated types of the joints. The thickness of these structures in the joint on the PCB with the flash gold is almost identical to the one on the HASL finished PCB. The joint has a double thickness of the inter-metallic structure on the tinned PCB. The pull off strength of the components on all three different samples does not differ very much even after the accelerated climatic tests.

The results of this research show that the joints are different from those we have today with the lead solders, but they are still strong enough to satisfy the demands of international standards for the quality of solder joints in the electronic industry.

1. Uvod

Predvideno je, da bo v Evropi nastopilo obdobje spajkanja brez svinca v elektronski industriji po letu 2007. Za to obdobje je na voljo že več vrst materialov za spajkanje, hkrati pa tudi več vrst plošč tiskanih vezij (TIV) /1,2,3,4/. Poiskali smo nekaj vzorcev TIV, ki bodo aktualne takrat in nanje prispajkali SMD komponente s spajkalno pasto brez svinca. Tako smo si preskrbeli TIV z naslednjimi prevodnimi liki:

- Kemijski nikelj / zlato
- Kemijski kositer

Komponente smo spajkali z vzorcem spajkalne paste s sestavo Sn 95,5/ Ag 3,8/ Cu 0,7 in rezultate preiskav primerjali z rezultati dobljenimi s spajkanjem z običajno spajko Sn62/Pb/Ag2. V literaturi lahko zasledimo tudi zlitine Sn/Ag/Cu/Sb in Sn/Ag/Bi, vendar so prve kot zlitine štirih kovin manj primerne za uporabo, pa tudi antimon je ekološko oporečen. Tudi bizmutove spajke se v glavnem ne bodo mogle dosti uporabljati, ker že minimalna prisotnost svinca v bizmutu lahko zelo poslabša spoj /5/. Zani-

male so nas naslednje lastnosti spojev:

- Oblika spoja in razlivanje
- Odtržne sile komponent po spajkanju
- Nastanek in debelina intermetalnih plasti takoj po spajkanju in po staranju na pospešenih klimatskih testih.

1. Eksperimentalni del

2.1. Priprava vzorcev

Vzorce smo pripravili tako, da smo SMD komponente SOT 14 vgradili na polagalni liniji z naslednjima spajkalnima pastama:

- Sn 95,5/ Ag 3,8/ Cu 0,7 in
- Sn62/Pb36/Ag2

Spajkalne paste smo pretalili na tri različno izdelane vzorce TIV in sicer:

- Obdelava tiskanine FR-4 s kemijskim Ni/Au
- Obdelava tiskanine FR-4 s kemijskim Sn

- običajne TIV, izdelane po Hot Air Solder Leveling (HASL) postopku

Postopek pretaljevanja je potekal na pretaljevalnem stroju v proizvodnji. Pri pretaljevanju je bil nastavljen ustrezen temperaturni profil (230 - 260°C za spajkalno pasto brez svinca in 210 - 235°C za običajno spajkalno pasto s svincem) /6/. Na prvi dve vrsti TIV smo komponente pretalili s spajkalno pasto brez svinca, na običajne TIV pa s spajkalno pasto s svincem, ki jo uporabljamo danes.

2.2. Klimatski testi

Prilavljene vzorce TIV smo starali na pospešenih klimatskih testih, ki simulirajo nekaj različnih klimatskih obremenitev v uporabi in sicer:

- 6 ciklov testa po IEC 60068-2-30 (tropski test) /7/
- temperaturno cikliranje iz -30°C na +130°C, na vsaki temperaturi po 6 minut; skupaj 15 ciklov

2.3. Ocenjevanje kvalitete spojev

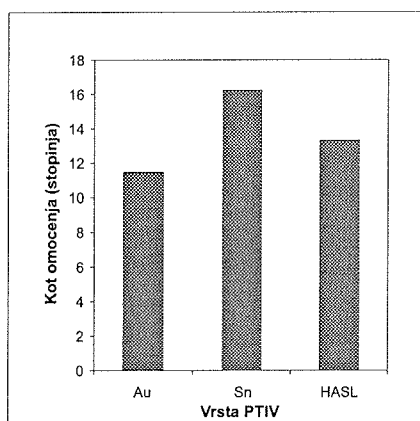
Kvaliteto spojev smo določali z naslednjimi metodami:

- z ocenjevanjem razlivanja spajke v spoju TIV - priključek komponente, oziroma merjenjem kota omočenja
- z oceno mikroskopskega pregleda spoja z mikroskopom OLYMPUS PMG3 pri 2000-kratni povečavi na metalografskih obrusih
- z merjenjem odtržnih sil prispajkane komponente s strižno obremenitvijo na preskusni napravi ZWICK Z 100

3. Rezultati

3.1. Ocenitev oblike spoja in razlivanje spajke po pretaljevanju

Obliko spoja in razlivanje spajke smo ocenili z merjenjem kota omočenja na mikroskopskem posnetku prereza priključka komponente in PTIV. Spajka je bila v vseh primerih lepo razlita, brez napak v strukturi.

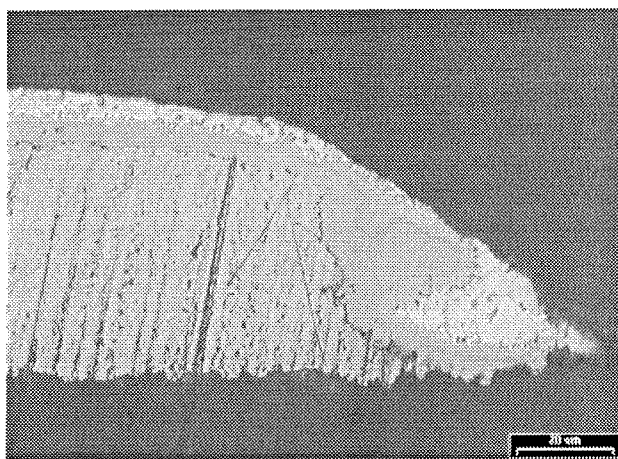


Slika 1: Kot omočenja glede na vrsto PIV (Au - zlatena; Sn - kositrena; HASL - Hot Air Solder Leveling)

Iz zgornje slike 1 je razvidno, da je še najbolj ugoden kot omočenja pri TIV, ki je zlatena (11,5°). Na vseh TIV pa je kot omočenja manjši od 20°, kar pomeni še vedno dobro omočenje in razlivanje spajke

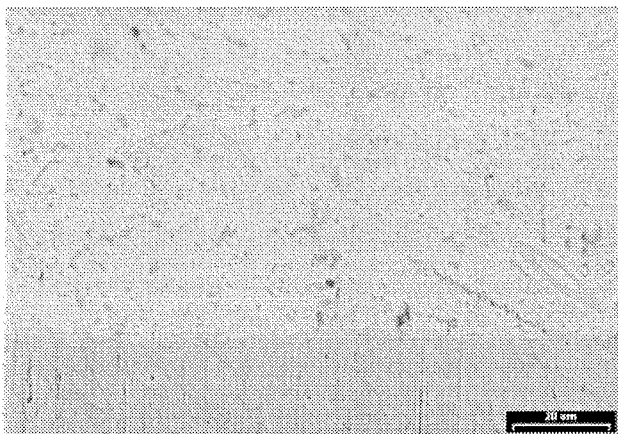
3.2. Rezultati mikroskopskih preiskav

Posnetek na sliki 2 je narejen ob robu vodnika, kjer so se intermetalne faze tvorile najbolj itenzivno. Na bakru je najprej galvanski nanos niklja, nato enakomerna temna intermetalna faza, potem razgibana svetla intermetalna faza in nato spajka. Zlata, ki je nanešen na nikelj, pri mikroskopski preiskavi ne vidimo, ker je debelina le-tega prenizka (pod mejo zaznavnosti optičnega mikroskopa 0,2 µm), ali pa je zlato raztopljeno v spoju.

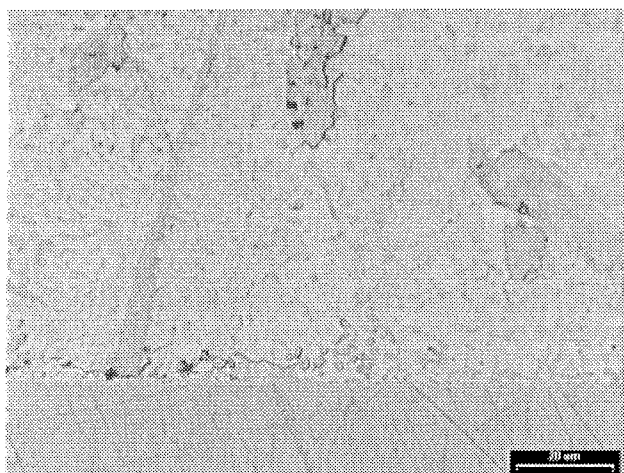


Slika 2: Spoj med pokovinjenjem na TIV (CuNiAu) in spajko brez svinca

Na slikah 3 in 4 vidimo pri preiskavi spojev pri povečavah do 2000-krat med ploščo tiskanega vezja in spajko dve plasti. Temna plast je ob strani plošče, svetla plast pa ob strani spajke. Plasti sta intermetalni fazi, temna plast je najverjetneje intermetalna faza Cu₃Sn, svetla plast pa intermetalna faza Cu₆Sn₅. Kvalitete intermetalnih faz z metalografsko analizo nismo dokazovali. Taka analiza je možna samo z EDS analizo na elektronskem mikroskopu.

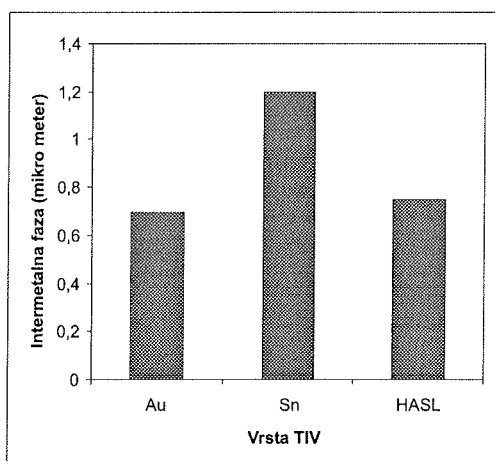


Slika 3: Spoj med pokovinjenjem na TIV (CuSn) in spajko brez svinca



Slika 4: Spoj med pokovinjenjem na TIV (Cu SnPb - HASL) in običajno spajko s svincom

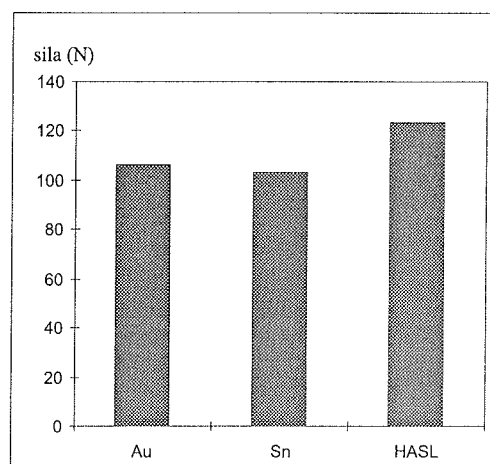
Na sliki 5 so prikazane povprečne debeline intermetalnih plasti za posamezno vrsto spoja. Intermetalne strukture so krhke. Čim večja je njihova debelina, tem slabši je spoj. Iz tega diagrama je razvidno, da je debelina intermetalne plasti na pozlačeni TIV približno identična tisti pri običajnih, po HASL postopku obdelanih TIV, kositrene TIV pa imajo te plasti skoraj dvakrat večje.



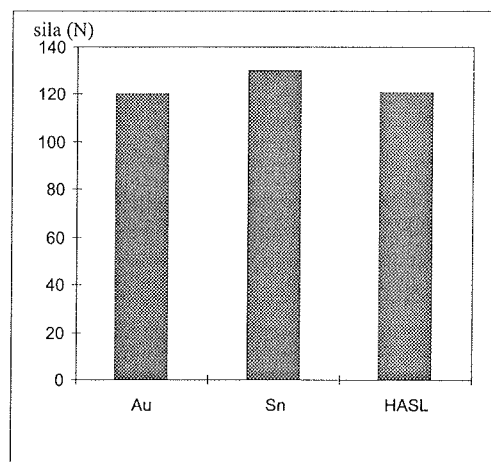
Slika 5: Debeline intermetalnih plasti glede na vrsto TIV (Au – zlatena; Sn – kositrena; HASL – Hot Air Solder Leveling)

3.3. Rezultati odtržnih sil prispajkanih komponent

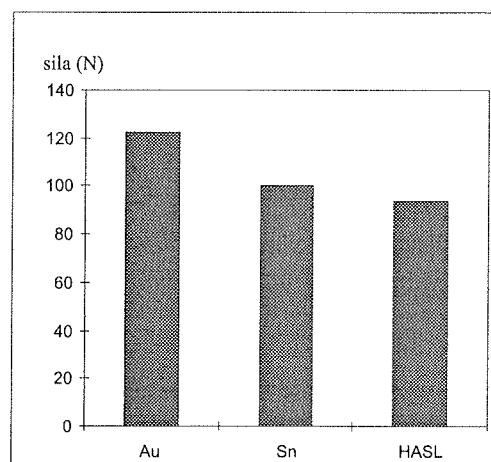
Rezultate odtržnih sil prispajkanih komponent prikazujejo slike 6, 7 in 8. Pri tej raziskavi so nas zanimala tudi spremembe po klimatskih testih.



Slika 6: Odtržne sile komponente po pretaljevanju glede na vrsto TIV (Au – zlatena; Sn – kositrena; HASL – Hot Air Solder Leveling)



Slika 7: Odtržne sile komponente po tropskem testu glede na vrsto TIV (Au – zlatena; Sn – kositrena; HASL – Hot Air Solder Leveling)



Slika 8: Odtržne sile komponente po cikliranju temperature glede na vrsto TIV (Au – zlatena; Sn – kositrena; HASL – Hot Air Solder Leveling)

Iz zgornjih treh diagramov lahko razberemo naslednje:

- Takoj po pretaljevanju (Slika 6) je očitno, da so odtržne sile na zlatenih in kositrenih TIV malenkost manjše (okrog 10%) od tistih na TIV, izdelanih po HASL postopku. Vendar razlike niso velike.
- Vrsta staranja bistveno ne vpliva na velikost odtržne sile komponente (Slika 7 in Slika 8)
- Po pospešenih klimatskih testih se odtržna sila komponente bistveno ne zmanjša.

4. Zaključek

Iz raziskave lahko naredimo nekaj zaključkov, ki nam bodo koristili pri izbiri materialov in postopkov pri spajkanju v obdobju, ko svinca v elektronski industriji ne bo več dovoljen. To so:

- Spajka brez svinca se na pokositrenih in zlatenih TIV lepo razliva. Kot omočenja je sicer nekoliko večji, vendar še vedno v sprejemljivih mejah.
- Intermetalne strukture nastajajo v vseh treh vrstah spojev. Debeline le-teh so na pozlačenih TIV približno identične tistim pri običajnih, po HASL postopku obdelanih TIV. Kositrene TIV imajo te plasti skoraj dvakrat večje. Krhkost spojev na pokositrenih TIV je torej večja.
- Odtržne sile komponent se glede na vrsto TIV, na katere so prispajkane, po velikosti bistveno ne ločijo.
- Po pospešenih klimatskih testih, ki simulirajo naravne pogoje pri delovanju TIV, se odtržna sila komponent bistveno ne zmanjša
- Vrsta pospešenega testa, ki smo jih izbrali, bistveno ne vpliva na velikost odtržne sile komponent.

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- /6/ Technische Information: Litton Kester, Producer of soldering materials
- /7/ IEC 60068-2-30

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INDUKTIVNI SENZORJI

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Ključne besede: Induktivni senzorji, približevalna stikala, izgubni faktor, temperaturni koeficient permeabilnosti, Curiejeva temperatura, induktivnost tuljave, faktor kakovosti tuljave

Izveček: Induktivni senzorji so gradniki nekontaktnih stikal. Uporabljamo jih v avtomatiki in profesionalni elektroniki za merjenje razdalj, razpoznavanje kovin in krmiljenje aktuatorjev. Za zanesljivo delovanje je treba izbrati primeren feritni material, ki ima majhne normalizirane izgube $\tan \delta / \mu$, in čim manjši temperaturni koeficient permeabilnosti α_p . V članku opisujemo princip delovanja induktivnega senzorja in induktivnega stikala, pojasnjujemo nekatere parametre in sklenemo s praktičnim izračunom senzorske tuljavice. Izračunu dodajamo še meritve induktivnega senzorja za primerjavo.

Inductive Sensors

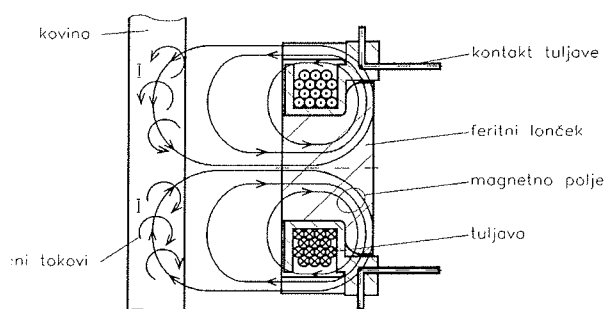
Key words: inductive sensor, proximity switch, loss factor, temperature coefficient of permeability, Curie temperature, inductance of coil, quality factor

Abstract: Inductive sensors form parts of proximity switches. They are used in automotive and professional electronics for measuring distance, recognising different alloys and control actuators. For reliable operation it is necessary to choose a suitable ferrite material that has a very low loss factor $\tan \delta / \mu$, and temperature coefficient of permeability α_p . In the article we describe the working principle of an inductive sensor and a proximity switch. Some important ferrite material parameters are explained and a calculation of the inductivity of an open magnetic coil is added as an example. We conclude with practical measurements of an inductive sensor L14 which are added for comparison.

1 Princip delovanja induktivnih senzorjev

Induktivni senzorji spadajo med robustnejše elemente. Uporabljajo se v industrijski avtomatizaciji, avtomobilski industriji in široki porabi. Delujejo nekontaktno. Če so primerno zaščiteni proti udarcem, prahu in vlagi, imajo zelo dolgo trajnostno dobo. Nepogrešljivi so povsod tam, kjer želimo nedotično ugotavljati pozicijo kovinskega predmeta ali izdelka. Z njimi lahko ugotavljamo premike, leguro materiala, štejemo izdelke ali vrtljaje.

Prerez induktivnega senzorja je podan na sliki 1. Tuljavica je navita na plastični tuljavnik tako, da je njena ravnina natančno poravnana z robom feritnega jedra. To jedro je navadno izdelano v obliki navadnega ali podolgovatega lončka, ki ima odprt magnetni krog. Tako dobimo stresano elektromagnetno polje. Tuljava tvori z vzporedno vezanim kondenzatorjem nihajni krog. Tega napajamo z oscilatorjem. Frekvence osciliranja so navadno med 10 kHz in 1 MHz.



Slika 1. Prerez induktivnega dela senzorja

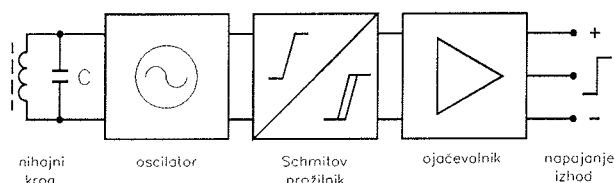
Smer magnetnega polja se spreminja s smerjo toka. Na sliki 1 je narisana smer polja le v eni pol periodi. V naslednji pol periodi se magnetno polje obrne. Obrne se tudi smer vrtilnih tokov. Stresano magnetno polje inducira v kovini vrtilne tokove, ki segrevajo kovino. Velikost vrtilnih tokov je odvisna od razdalje med kovino in induktivnim senzorjem. Razmere so podobne tistim pri transformatorju, ki ima sekundarno navitje v kratkem stiku.

Električne izgube v kovini krije magnetno polje, ki črpa električno energijo iz vezja. Ker je vir elektromagnetne energije šibak, pri približevanju kovine hitro upade amplituda osciliranja elektromagnetnega polja senzorja. Ob približevanju kovine senzorju prične upadati tudi Q nihajnega kroga. To lastnost izkoriščamo pri prepoznavanju kovancev in njihovih legur. Če so kovanci pristni, so izdelani iz enake legure, na katero je možno umeriti induktivni senzor. Tako ugotavljamo pri novčičnih avtomatih vrsto in pristnost kovanca. Ker je v kovancu več različnih kovin, uporabimo več induktivnih senzorjev, ki so umerjeni na posamezne kovine. Navadno uporabljamo tri do štiri induktivne senzorje, ki so z mikroprocesorjem in programom povezani v sistem štetja in ugotavljanja pristnosti kovancev. Pri sodobnih avtomatih na kovinske žetone uporabljamo podoben princip delovanja.

2 Zgradba induktivnih stikal

Induktivno stikalo (slika 2) je sestavljeno iz kvalitetnega induktivnega senzorja L, ki skupaj z L in C sestavlja nihajni krog, oscilatorja, Schmitovega prožilnika in ojačevalnika. Induktivno stikalo napajamo z enosmernim tokom. Izhod induktivnega stikala je visok ali nizek napetostni nivo. Za

krmiljenje močnejših aktuatorjev je treba dograditi ojačevalnik, ki zagotavlja ustrezne izhodne tokove za njihovo proženje.



Slika 2. Shema induktivnega stikala

Napetost na sponkah vzporednega nihajnega kroga je v resonanci najvišja. Najvišja pa je tudi kakovost kroga Q . Ob prisotnosti kovine pa Q , kot je bilo pokazano v predhodnem poglavju, močno upade. Zmanjša se tudi induktivnost tuljave ter posledično frekvenca nihajnega kroga. Induktivna stikala so zato lahko umerjena na padec Q -ja ali na spremembo frekvence nihajnega kroga.

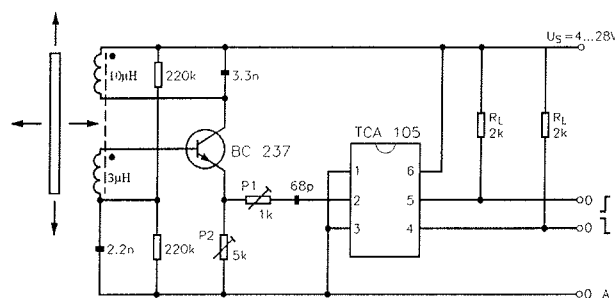
Pri približevanju kovinske plošče induktivnemu stikalu torej dosežemo točko, kjer se stikalo vklopi. Pri oddaljevanju plošče dosežemo novo točko, kjer se stikalo izklopi. Razlika razdalj med vklopom in izklopom stikala je histereza, ki pa je tudi potrebna za zanesljivo delovanje induktivnega senzorja.

3 Praktična izvedba induktivnega stikala

Na sliki 3 je prikazana električna shema induktivnega stikala za industrijske aplikacije. Tranzistorska stopnja poveča občutljivost senzorja in zmanjšuje histerezo preklapljanja na 0,6 do 0,7 mm pri odmiku 0,5 mm. Tipični frekvenci nihajnih krogov sta med 2 in 3 MHz. Frekvenci pa se glede na vrednosti induktivnosti lahko spreminjata med 1 in 10 MHz. Ko se induktivnemu senzorju približa kovinska plošča, se zaradi izgub v njej, zniža frekvenca nihajnih krogov. Integrirano vezje TCA 105 pretvori spremembe resonančnih frekvenc nihajnih krogov v nizek izhodni nivo. Izhodna logična stanja prožita aktuatorje. Z nastavljivim trimerjem P1 nastavljamo širino histerezne zanke v območju 0,3 do 1 mm medtem, ko s trimerjem P2 nastavljamo prag preklapljanja senzorja glede na oddaljenost senzorja od kovinske plošče v območju 3 do 10 mm. Frekvenca nihajnih krogov se zmanjšuje ob horizontalnem ali vertikalnem približevanju tuljavici kovinski plošči.

Za kakovostno in zanesljivo delovanje induktivnih senzorjev izberemo primeren feritni material, ki ima čim manjše izgube pri visokih frekvencah in majhen temperaturni koeficient permeabilnosti. Pomembnejše parametre in bistvene razlike med tremi materiali navajamo v tabeli 1.

Podrobnejše karakteristike so dostopne na spletnih straneh <http://www.iskra-feriti.si>.



Slika 3. Praktična izvedba induktivnega stikala [1]

Tabela 1. Pomembnejši parametri feritnih materialov za induktivne senzorje

Parameter	Material 10G	Material 16G	Material 26G
Začetna permeabilnost μ_i	$750 \pm 20 \%$	$2200 \pm 20 \%$	$2200 \pm 20 \%$
Normalizirane izgube $\tan \delta / \mu_i$	$< 8 \cdot 10^{-6}$; 300 kHz	$< 1,5 \cdot 10^{-6}$; 10 kHz	$< 1,0 \cdot 10^{-6}$; 10 kHz
$\tan \delta / \mu_i$	$< 20 \cdot 10^{-6}$; 1 MHz	$< 3,5 \cdot 10^{-6}$; 100 kHz	$< 2,5 \cdot 10^{-6}$; 100 kHz
Temperaturni koeficient permeabilnosti α_F : - 25 do + 55 °C	$0 - 2 \cdot 10^{-6}/K$	$0,6 - 2,2 \cdot 10^{-6}/K$	$0,4 - 1,5 \cdot 10^{-6}/K$
Curiejeva temperatura	$> 200 \text{ }^\circ\text{C}$	$> 150 \text{ }^\circ\text{C}$	$> 150 \text{ }^\circ\text{C}$

4 Definicije pomembnejših parametrov feritnih materialov

4.1 Normalizirane izgube v feritnem materialu

Magnetne izgube so vsota histereznih izgub, izgub zaradi vrtničnih tokov in preostalih ali remanenčnih izgub. Histerezne izgube so pri majhnih magnetnih gostotah v feritnem materialu zanemarljive. Izgube zaradi vrtničnih tokov naraščajo s hitrostjo spreminjanja smeri tokov. Pri nizkih frekvencah so zanemarljive. Induktivni senzorji uporabljajo majhne magnetne gostote in višje frekvence magnetnih polj.

Normalizirane izgube $\tan \delta / \mu_i$ so neodvisne od velikosti jedra in zračne reže pri magnetno odprtih jedrih. Določajo ga le izgube zaradi vrtničnih tokov in preostale izgube v feritnem materialu, zato ne vključuje histereznih izgub. Faktor narašča s frekvenco.

Normalizirane izgube v feritnem materialu merimo z računalniško podprtim merilnim sistemom. Merilni vzorec je toroidno jedro T 22 14 07, na katerega navijemo 20 ovojev dvakrat lakirane bakrene žice premera 0,25 mm. Merilno frekvenco za nizkoizgubne materiale spreminjamo med 10 kHz in 1 MHz. Merilni sistem pri sobni temperaturi $23 \pm 2 \text{ }^\circ\text{C}$ zagotavlja stalno gostoto 0,1 mT v feritnem jedru, izmeri induktivnost tuljave ter njeno enosmerno in efektivno uporabnost. Na osnovi izmerjenih parametrov izračuna normalizirane izgube feritnega materiala po enačbi (4.1):

$$\tan \delta = \frac{R_{ef} - R_o}{2 \cdot \pi \cdot f \cdot L} = \frac{\tan \delta_e}{\mu_e} \quad (4.1)$$

pri čemer je R_{ef} efektivna upornost tuljave, navite na feritno jedro, pri frekvenci 100 kHz ali 1 MHz in vključuje enosmerne in celotne izgube izražene v Ω , R_o je čista enosmerna upornost tuljave v Ω , f je merilna frekvenca v Hz, L induktivnost tuljave v H, μ_i začetna permeabilnost toroida in μ_e efektivna permeabilnost jedra z režo. Efektivna permeabilnost je vedno nižja od začetne. Podajamo jo za jedra z zračno režo. Izgubni faktor je za obe permeabilnosti enak, ker se pri jedrih z režo zmanjša tudi kot δ_e .

4.2 Curiejeva temperatura

Curiejeva temperatura T_C je temperaturna meja, nad katero izgubi feritni material svoje magnetne lastnosti. Začetna permeabilnost feritnega materiala μ_i sedaj pade na vrednost 1.

4.3 Temperaturni koeficient permeabilnosti

Temperaturni koeficient permeabilnosti materiala α_F je določen kot sprememba začetne permeabilnosti materiala zaradi spremembe temperature in ga podaja enačba (4.2). To je materialna konstanta, ki je neodvisna od reže. Ta faktor posledično vpliva na spremembo induktivnosti tuljave, če se spremeni temperatura v feritnem materialu. V enačbi nastopa relativna permeabilnost μ_i , ki je brezdimenzijska. Temperaturni koeficient permeabilnosti α_F podaja enačba (4.2):

$$\alpha_F = \frac{\mu_{i2} - \mu_{i1}}{\mu_{i1} \cdot \mu_{i2} \cdot [T_2 - T_1]} \left[\frac{1}{K} \right] \quad (4.2)$$

pri čemer je μ_{i1} permeabilnost pri temperaturi T_1 in μ_{i2} permeabilnost pri temperaturi T_2 v stopinjah Kelvina.

5 Oblike in velikosti feritnih lončkov za induktivne senzorje

Iz feritnih materialov 10G, 16G in 26G se izdeluje lončaste oblike feritnih jeder, ki so primerni za induktivne senzorje. Črka pri oznaki običajno pomeni lonček, številka pa njegov zunanji premer.

6 Izračun induktivnosti tuljave za senzor induktivnosti

Izračunavanje induktivnosti tuljav z odprtimi magnetnimi krogi je težavno. Za praktične izračune pa enačba (6.1) do- loča dober rezultat [2]. Natančne vrednosti parametrov induktivnega senzorja ugotavljamo z meritvami. Induktivnost tuljave je določena s številom ovojev in njeno geometrijsko obliko. Vpliv feritnega materiala na induktivnost je izražena s koeficientom k .

$$L = k \cdot \frac{\pi^2 \cdot D^2 \cdot N^2}{l \cdot \left[1 + 0,45 \cdot \frac{D}{l} - 0,003 \cdot \frac{D^2}{l^2} \right]} [nH] \quad (6.1)$$

D = notranji premer tuljave v cm

l = dolžina tuljave v cm

N = število ovojev tuljave

k = koeficient ($k = 1$ za zračno tuljavo, $k = 3$ za tuljavo s feritnim jedrom)

Induktivnost po enačbi (6.1) lahko računamo, kadar je raz- merje notranjega premera tuljave proti dolžini tuljave $\left(\frac{D}{l}\right)$ med 0 in 30.

Kakovost tuljave Q podaja naslednja enačba:

$$Q = \frac{\omega \cdot L}{R} = \frac{2 \cdot \pi \cdot f \cdot L}{R} \quad (6.2)$$

pri čemer je L induktivnost tuljave v H in R enosmerna upor- nost v Ω in f frekvenca v Hz.

Kakovost tuljave linearno raste s frekvenco dokler ne zač- ne s frekvenco rasti še njena upornost. Kakovost nihajne- ga kroga pa se spreminja po značilni zvonasti krivulji. Iz znane induktivnosti in enosmerne upornosti lahko izraču- namo kakovost tuljave pri različnih frekvencah. Reciproč- na vrednost kakovosti je izgubni faktor tuljave.

6.1 Zgled za izračun induktivnosti tipičnega induktivnega senzorja

$D = 0,72$ cm

$l = 0,17$ cm

$N = 300$ ovojev

$k = 1$ za zrak oziroma 2 ali 3 za feritni material

Uporabimo enačbo (6.1) in izračunamo induktivnost zrač- ne tuljave:

$$L = \frac{1 \cdot \pi^2 \cdot 0,72^2 \cdot 300^2}{0,17 \cdot \left[1 + 0,45 \cdot \frac{0,72}{0,17} - 0,003 \cdot \frac{0,72^2}{0,17^2} \right]} \\ = 949\,725,87 \text{ nH} = 949,7 \text{ } \mu\text{H}$$

Z upoštevanjem koeficienta k in enačbe (6.1) izračunamo še induktivnost tuljave s feritnim lončkom:

$$L(k=3) = 3 \cdot 949,7 \text{ } \mu\text{H} = 2.849,1 \text{ } \mu\text{H}$$

6.2 Praktične meritve induktivnega senzorja

Tabela 2. Praktične meritve induktivnega senzorja

Frekvenca	Induktivnost, kakovost		
	Brez feritnega lončka	S feritnim lončkom 10G	S feritnim lončkom 26G
10 kHz	L = 930 μ H Q = 3	L = 2.88 mH Q = 9.2	L = 2.87 mH Q = 9.2
100 kHz	L = 931 μ H Q = 27.5	L = 2.89 mH Q = 73	L = 2.89 mH Q = 72

Induktivnost tuljave s feritnim jedrom se poveča za približno trikrat. Podobno je s kakovostjo Q, na katero najbolj vpliva vrsta feritnega materiala. Praktični rezultati se dovolj dobro ujemajo z izračunom.

7 Sklep

Induktivni senzorji so zelo uporabni za nekontaktna stikala v avtomatiki. So robustni in skoraj neobčutljivi za umazanijo in okolje. Imajo dolgo trajnostno dobo. Delujejo lahko v širokem frekvenčnem področju. Zaradi robustnosti in zanesljivosti lahko sklepamo, da bo njihova uporaba še dolgo nepogrešljiva v industrijski avtomatizaciji in profesionalni elektroniki. Električne izgube in kakovost induktivnih senzorjev določa izbrani feritni material. Računanje parametrov tuljav z odprtimi magnetnimi krogi je lahko le približno.

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HOME AUTOMATION ON THE MOVE

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Key words: home automation, X.10, SMS, mobility, value added services, kitchen center

Abstract: In this article we would like to show how an arbitrary home and building electronic system based on the home automation standards such as X10 might be addressed and controlled by an appropriate mobile technology. Urge for mobility of users, which may be at the same time either the inhabitants of these homes or even administrators and supporters, is growing. The possibility to control and observe the status of home appliances while being on the move away from home using our mobile phones is becoming reality today. As an example we will introduce the prototype system, which gained a lot of attention on the last INFOS conference and was made functional throughout the cooperation of two Slovenian companies, Gorenje and HERMES SoftLab. While Gorenje developed a so-called kitchen center, an unique all-in-one home appliance controlled by the personal computer, HERMES SoftLab contributed the X10 PLC protocol environment and HERMES SoftLab's Smart Service Mediator (SSM) platform, well known from the mobile operators' world, which enable mobile users to control their automated home remotely using ordinary mobile phones and short messaging system (SMS). When developed, this prototype system presented one of the world's first attempts to integrate the home automation system with the GSM network using the SMS.

Hišna avtomatizacija na pohodu

Ključne besede: hišna avtomatizacija, X.10, SMS, mobilnost, storitve z dodano vrednostjo, kuhinjski center

Izleček: V članku bi radi pokazali, kako lahko nek poljuben dom in stavbni elektronski sistem, ki temelji na standardih hišne avtomatizacije kot je X10, usmerjamo in nadzorujemo s pomočjo primerne mobilne tehnologije. Potreba po mobilnosti uporabnikov, ki so lahko hkrati prebivalci teh domov ali celo administratorji in vzdrževalci, vedno bolj narašča. Možnost upravljanja in opazovanja statusa hišnih naprav s pomočjo mobilnega telefona med uporabnikovo odsotnostjo z doma postaja dandanes stvarnost. Kot primer bomo predstavili prototip takšnega sistema, ki je na zadnji konferenci INFOS postal veliko zanimanja in sta ga v sodelovanju razvili dve slovenski podjetji, Gorenje in HERMES SoftLab. Medtem ko je Gorenje razvilo takoimenovan kuhinjski center, edinstveno, vse-v-enem hišno napravo, ki jo nadzoruje osebni računalnik, je HERMES SoftLab prispeval strojno rešitev, temelječo na standardu X10, in sporočilno platformo Smart Service Mediator (SSM), dobro znano v svetu mobilnih operaterjev. Vse to omogoča mobilnim uporabnikom nadziranje avtomatiziranega doma na daljavo z uporabo navadnega mobilnega telefona in pošiljanja kratkih sporočil (SMS). Ob razvoju je ta prototip predstavljal enega prvih poskusov integracije sistema hišne avtomatizacije z omrežjem GSM, ki temelji na pošiljanju kratkih sporočil.

Home automation

In recent years there have been several attempts worldwide to develop a home and building electronic system (HBES) based on the Power Line Carrier (PLC) technology. The PLC technology uses existing electrical power lines in home and buildings to send the control signals for controlling various home appliances. However the different system specifications have confused planning engineers, contractors, installers as well as resellers, end-users, building owners and investors. This situation is hindering market acceptance and growth. Consequently each system lacks the necessary volume success. In Europe specifically there are three solutions, which are candidates to become the home and building electronic system standard:

- BatiBUS - represented by BatiBUS Club International (BCI)
- EIB (European Installation Bus) - represented by European Installation Bus Association (EIBA)
- EHS (European Home Systems) - represented by European Home Systems Association (EHSA)

The three above mentioned associations have agreed to provide the technical basis for the convergence of these three systems so that in future there will be only one common system supported by relevant industrial companies. A common Association resulting from the amalgamation of BCI, EIBA and EHSA will promote the KNX standard.

In the USA and in the last few years also in Europe another system, X10, gained high popularity due to its simplicity, low price, and adoption by the manufacturers. X10 is a PLC protocol that allows compatible devices throughout the home to communicate with each other via the existing 110/220V electrical power lines. Using X10 it is possible to control lights and virtually any other electrical device or collect the data from the sensors (temperature, humidity, motion etc.) from anywhere in the house with no additional wiring.

X10 Power Line Carrier Protocol

The X10 PLC protocol /1/ defines the procedure for communication between the transmitting device and receiving device by sending and receiving signals over the power line wiring. These signals represent short RF bursts, a 120

kHz-coded signal superimposed on the 60Hz/50Hz electrical power line, with encoded digital information. The X-10 signals are synchronized to the zero-crossing point of the AC power line – they are transmitted within 200 μ s of the zero crossing point. Power line interfaces provide 50Hz square wave with a max. delay of 100 μ s from the zero crossing point to the AC power line. The maximum delay between signal envelope input and 120 kHz output bursts is 50 μ s. A binary 1 is represented by a 1 ms burst of 120 kHz, at the zero crossing point. If burst is not presented in this period, a binary 0 is assumed. These 1 millisecond bursts are transmitted three times to cover the zero crossing points of all three phases in a three phase power distribution system, as shown in Figure 1.

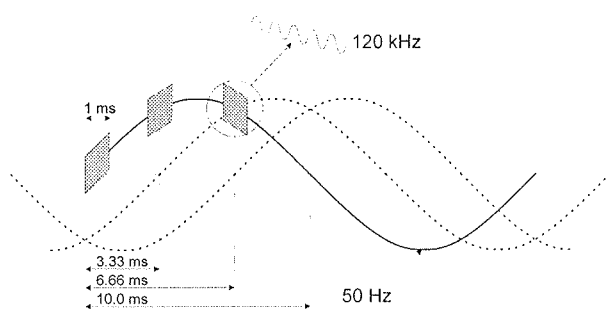


Figure 1: The Power Line Cycle and the X10 signals.

One cycle of the 50Hz power line carries one bit of information. In X10, transmission of the complete information consists of a sequence of three groups of bits (codes): start code, house code, and a number or function code (see Figure 2).

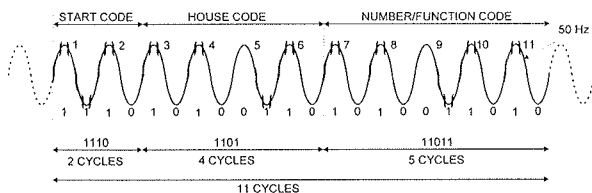


Figure 2: The X10 coding scheme.

The start code is a standard code denoting the start of the transmission and is transmitted within the first 2 power line cycles. The house code is a 4-bit code (any code from 0000 to 1111) and serves as the address of the target device to which the transmission is addressed. The number/function code is a 5-bit code (any code from 00000 to 11111). Transmission of the house code takes 4 power line cycles, while the transmission of the number/function code takes 5 power line cycles. The house codes and the number/function codes are transmitted in a true complement form on alternate half cycles of the power line – if a binary 1 is transmitted on one half cycle (1 millisecond burst of signal) then binary 0 (no signal) should be transmitted on the next cycle (See Figure 3). The Start Code is always 1110, which is a unique code and unlike the house and

number/function codes does not follow true complementary relationship on alternate half cycles. The start code is transmitted within 2 power line cycles (see Figure 2).

The complete transmission (start code, house code, and a number/function code) hence requires 11 power line cycles and is always repeated twice with 3 power line cycles between each transmission: transmission of start, house, and number code followed by the transmission of the start, house, and function code. The house, number, and function codes are listed in Table 1.

House codes		Number codes		Function codes	
A	0110	1	01100	All units OFF	00001
B	1110	2	11100	All Lights ON	00011
C	0010	3	00100	ON	00101
D	1010	4	10100	OFF	00111
E	0001	5	00010	Dim	01001
F	1001	6	10010	Bright	01011
G	0101	7	01010	All Lights OFF	01101
H	1101	8	11010	Extended Code	01111
I	0111	9	01110	Hail Request	10001
J	1111	10	11110	Hail Acknowledge	10011
K	0011	11	00110	Pre-Set Dim	101X1
L	1011	12	10110	Extended Data	11001
M	0000	13	00000	Status=ON	11011
N	1000	14	10000	Status=OFF	11101
O	0100	15	01000	Status Request	11111
P	1100	16	11000		

Table 1: The list of available house, number, and function codes.

We can connect a large number of X10 receiving devices to the power line. To each of them we can assign one of 16 available house codes and one of 16 available number codes giving 256 different possible combinations.

The X10 PLC home automation network consists of the following types of X20 devices:

Receiving devices (executing the commands, no feedback information): light switches, receptacles, chimers

Transmitting devices (transmitting signals to the power line: phone and PC controllers)

Transceiver devices (receiving data and report status): motion detectors, flood detectors, thermometers

X10 PLC Network devices: passive couplers, coupler repeaters, surge protectors, noise filters, and signal blocks that are installed in or near the electrical service panel. Such devices are necessary for providing consistent and reliable signaling performance, especially in the densely populated areas.

Kitchen center of Gorenje

Gorenje's kitchen center (Figure 3) is designed to become not only the central automation/information point of the kitchen but also the central point of the whole home. From outside it looks like a very modern and futuristically shaped kitchen-range. However, many are surprised when instead of a standard button-like control panel a modern flat panel touch screen silently rolls-out from the center whenever we want to monitor or control the system. By pressing the images on the touch screen we are able to turn on/off the oven or heating plates, control their temperature, start different cooking programs, set timers etc.

The brains of the kitchen center represent a personal computer hidden in the very bottom of the center and transparent from the user's point of view. Internal electronic devices (heating plates, oven) are controlled by a proprietary controller made by engineers from Gorenje, which is connected to the computer's serial port /2/.

Another serial port is used for a X10 PLC modem, which connects the computer to the home's power line. This subsystem enables controlling of the X10 compliant home devices from the same point. The prototype system includes several light dimmers and switches as well as IR motion detectors. In general we could control also many other devices, such as heating and air-conditioning system, automatic doors, video and sound devices etc. /3/

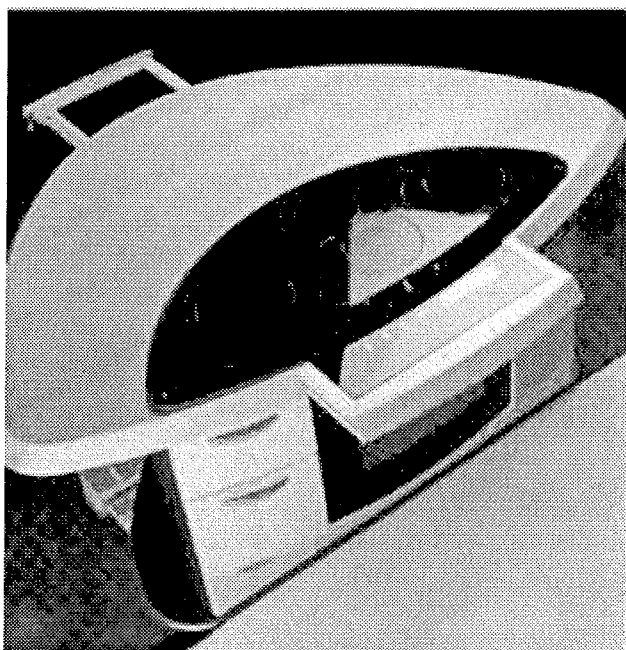


Figure 3: Kitchen center of Gorenje

Mobile phone as a remote control device

To have a complete control over the wide variety of home devices is at least a nice feature. But wouldn't it be nice if

we turned on the air-conditioning system when we were still on our way home? Or we could even use our mobile phone to open the garage door remotely. Some suggestions would perhaps bring a smile to the reader while some others are definitely attracting much more attention. For instance, wouldn't it be very useful if we got an alarm in shape of a short message (SMS) or a voice call in case that motion or fire detectors register some problems? There are several proprietary and closed systems, which provide exactly those functionalities, but there are as many different standards as there are solutions. At the same time, the cost of several isolated and non-compliant solutions exceeds the cost of the solution we are about to introduce.

Today, almost everybody has a mobile phone. The penetration in some countries is reaching numbers higher than 70% of the whole population /4/. Mobile phone is not only voice-based communication device but is also becoming a payment instrument, electronic wallet, gaming device, and of course a special type of a remote controller.

On the other hand, engineers from HERMES SoftLab developed a messaging platform, of which main task is to connect a mobile user with information resources and applications anywhere on the Internet. Starting from the fact that Gorenje's kitchen center is controlled by a built-in personal computer, it seemed a logical step to connect that computer to the Internet and enable users to remotely control the home automation system.

But nonetheless, on the way to the final solution several problems were encountered, such as authentication and authorization issues, real-time message routing, security etc., which are successfully addressed and solved by the messaging platform.

Smart Service Mediator platform

SSM is a multi-channel platform that connects mobile users with the web servers using different communication channels /5/. While primarily it is being used for communication with short messages, voice, WAP, and HTTP channels are supported as well. Besides short messages, voice interaction is becoming more and more used, but in that case the cost of solution is higher because voice recognition system and text-to-speech synthesis must be involved.

Basically, there are two different types of SSM installations, depending on the usage model. SSM platform may be installed either at the mobile operator (Figure 4) or in home servers /6/. In the first case, home servers must be connected to the mobile operator's infrastructure via Internet, while in the second case an in-house GSM modem is needed. Both installation types have their advantages and disadvantages depending on cost, business models, Internet availability etc. First option is cheaper for the end user and is promoted by the mobile operator. Second option is operator independent, needs no Internet connection but is less

suitable for the individual use because of the higher complexity at the user's side. Anyway, the solution with the GSM modem might be appropriate for larger enterprises. In the prototype version web server was connected to the mobile operator's (Mobitel) SSM platform over the Internet.

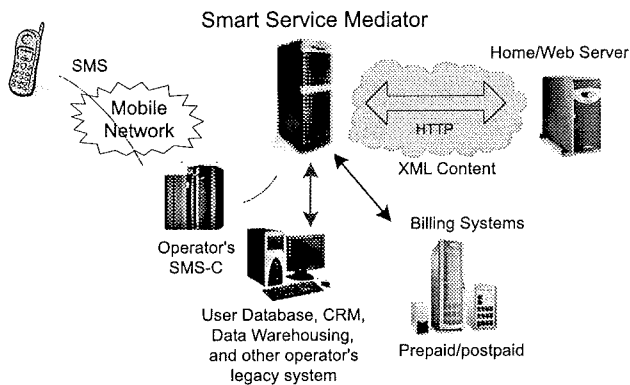
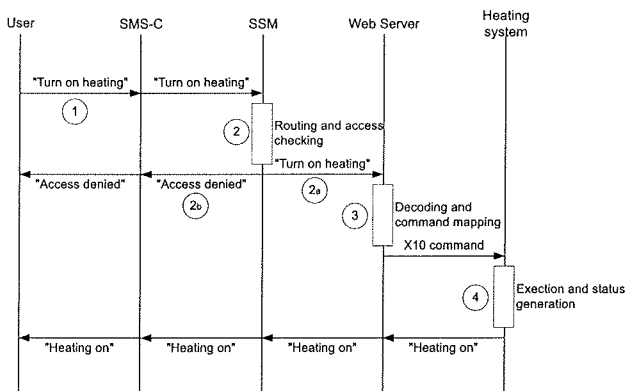


Figure 4: SSM platform as a part of mobile operator's service network.

SSM platform communicates with the external world using standard communication and security protocols, such as XML for message coding, HTTP and HTTPS for transport and message encryption. In Figure 4, reader can notice also a connection between the SSM and mobile operator's billing systems – SSM is used also as an additional revenue generator because it handles and counts the messages traveling through the system. To these messages we can attach service data records (SDR) meaning that users would pay more than just a cost of short messages for this extra service.

Following is a communication scenario between a mobile user and home automation system while remotely turning on the heating device:



1. User initiates the action by sending an SMS with the predefined content structure (i.e. "Turn on heating" or "Heating on") to the certain number or to the so-

called large account¹ (i.e. 1010). The message reaches the SMS Center (SMS-C), which is a vital part of the mobile operator's infrastructure and takes care of all in/outcoming SMS messages. SMS-C forwards the message to the SSM.

2. SSM performs two main tasks – it routes the messages to the relevant home web server depending on a LA number and performs the authorization checks. SSM enables an easy user grouping and generation of access check lists. Only authorized users are allowed to control the devices in a certain home automation environment. If the access is granted (step 2a) the message is routed to the destination web server determined by the URL specified in the SSM settings. Otherwise, user gets a message containing denial of a service (step 2b).
3. Web server parses the message sent by a mobile user. If the message is valid appropriate action is taken – in our case, an X10 command is sent via X10 PLC modem to the heating system with the aim to turn it on.
4. Heating system performs the action and returns the status, which is then forwarded back to the user.

The example shown above is only about turning on the heating system in a house. For controlling the kitchen center devices, such as oven, heaters, fan, and some other household devices, such as lights, alarm and dimmers, the following syntax is used:

command device arg

where

command ON, OFF, STATUS, HELP
(abbreviations allowed: ON, OFF, S, H)

device ALARM/1..n/, LIGHT/1..n/, OVEN,
(abbreviations allowed: A, L, O, S)

arg If command = ALARM, arg can vary between SILENT and LOUD (set by default)
If command = LIGHT, arg can vary between 1 to 10 (default is 10). Arguments from 1 to 9 dim the light (if lights are actually attached to dimmer X.10 devices). Arguments 0 and 10 have the meaning of turning the lights ON/OFF.

Following are some examples used in connection with the kitchen center:

- ON L1 30 (dim light1 to 30%)
- ALARM2 ON (turn on the second alarm in the house)
- OWEN OFF (switch the oven off)
- STATUS OWEN (get the oven status) etc.

¹ Large accounts (LA) or large account numbers are short mobile numbers, usually up to 4 digits long, which are used for easier dialing/addressing of mobile data services.

All examples from above were used in a so-called pull mode, where users send messages and trigger some activities or status reports. However, SSM enables also push functionality, where messages can be sent to mobile users without their requests in case some special situation occurs – i.e. user can be notified with a short message triggered by the motion detector. Motion detectors are not the only originators of pushed messages. You can imagine some other devices, such as fire/smoke/water detectors, timers etc.

Conclusion

Mobile phones have definitely marked current generations in the same way radios, TV sets and cars did in the past. They have become a necessity allowing users of mobile phones to be constantly in contact with each other and in contact with information. The work described in the paper presents a step further – it allows users of mobile phones to be constantly in contact also with a number of different devices either at home or at work. Eventhough the integration of home appliances with the mobile network may seem an insignificant task, it requires a deep knowledge of a number of different technologies and tight cooperation of partners from a different areas. In this case, two inovative companies, HERMES SoftLab – a software engineering company, and Gorenje – a manufacturer of home appliances, have joined their effort and brought ideas to life. Integration of home appliances with the mobile network opens a variety of possibilities both in the business and in consumer environments and the full potential of the features it brings is yet to be discovered.

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ABS-SENZORJI NA OSNOVI ALNiCO-MAGNETOV

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Ključne besede: magneti, trajni magnetni materiali, AlNiCo-magneti, senzorji, sistem ABS (Anti – Lock Braking System), ABS-senzorji, Hall-senzorji, magnetouporovni senzorji, zobnik, merjenje hitrosti vrtenja, magnetni pretok, oprema za kontroliranje in preskušanje

Izleček: Predstavljamo fizikalne osnove in princip delovanja ABS-sistema, zahteve za vgrajene AlNiCo-magnete, ki so ključni element senzorja. Ilustriramo izdelavo samega ABS-senzorja, najpomembnejše značilne elektromagnetne lastnosti senzorja kot osnovo za nadaljnji razvoj elektronskega krmilnega modula ali alternativnih rešitev ter sprememb samega senzorja. Predstavljena je tudi možnost podjetja, da ponudi proizvode z večjo stopnjo integracije za nove potrebe trga ter izsledke razvojno raziskovalnega dela na področju razvoja opreme za kontroliranje in preskušanje magnetov za potrebe drugih področij raziskovalnega dela, proizvodnje elektronskih komponent ter izdelovanja magnetnih sistemov.

ABS Sensor Applications Based on AlNiCo Magnets

Key words: magnets, permanent magnetic materials, AlNiCo magnets, sensors, Anti – Lock Braking System, ABS sensors, Hall sensors, magnetoresistive sensors, gear wheel, rotational speed measurement, magnetic flux, measuring and control equipment

Abstract: Organization Magneti Ljubljana presented the ABS – sensor application of its main production programme of AlNiCo magnets and its potential for the production of the sensors. The article is intended both to domestic organizations for further joint technological development and to successful producers, which already produce sensors, and are looking for a reliable and capable partner to supply them with parts with higher degree of integration. The company has over 50 years of tradition, is successful in the world market and has the quality management system certified according to most important standards, including the automotive specification ISO / TS 16949. According to its policy the company develops new production programmes, including new materials, magnetic systems and equipment for production and control of magnetic products and similar electronic components for the new demands and expectations of the market.

The key sensors in the automotive applications and a scheme of the brake system of a vehicle are presented. The history, the benefits and the behaviour of the Anti-Lock Braking System are briefly described. The system usually contains 4 sensors and a common electronic unit, that handles the data from the sensors and controls the braking process, which is also appropriately described.

It is emphasized, that organization Magneti Ljubljana produces magnets, which are the key element of the ABS sensors. The company has the basic knowledge for the manufacturing processes of ABS sensors. It has already in 1999 taken part in the tender for the production of sensors for its largest customer.

The physical principles of the operation of the sensor, its construction and the behaviour of the induced voltage is described together with the typical requirements for used AlNiCo magnets. The most important typical electromagnetic properties of the sensor are illustrated and this illustration enables further development of the electronic control unit as well as the development of the alternative solutions or modifications of the sensor itself.

Some more contemporary and cheaper solutions for rotational speed measurements, offering important potential for further development and applications, were also mentioned and briefly described.

Since the magnetic, dimensional and visual properties of the magnets in the sensor are critical, the quality assurance in the company obtains the 0-ppm level by 100% sorting processes. These processes are supported by specially developed electronic measuring systems enabling high productivity. The organization has developed its own high speed magnetizing and demagnetizing equipment, fluxmeters and equipment for visual control including optical measurement of dimensions and geometry. This equipment could be of interest also to organizations, which develop magnetic materials, assemble magnets and produce magnetic systems or other similar electronic components.

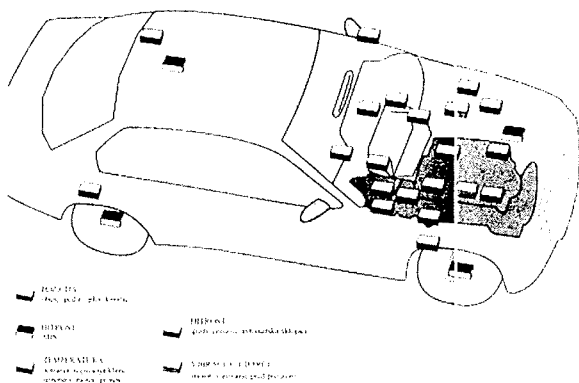
1 Uvod

V prispevku želi podjetje Magneti Ljubljana, d.d. /1/ predstaviti uporabo in delovanje AlNiCo-magnetov, vgrajenih v ABS-senzorje, ter svoje možnosti za proizvodnjo tovrstnih senzorjev. Članek je namenjen tako domačim podjetjem za morebiten skupen nadaljnji razvoj in nastop na svetovnem trgu kot tudi podjetjem, ki že proizvajajo senzorje in iščejo zanesljivega in sposobnega partnerja za dobavljanje sestavnih delov z višjo stopnjo integracije. Podjetje ima 50-letno tradicijo, v zadnjem desetletju ima nenehno in relativno visoko stopnjo rasti fizičnega obsega proizvodnje in se ponaša z zavidljivimi poslovnimi uspehi ter certifikati najzahtevnejših sistemov vodenja kakovosti avtomobilske

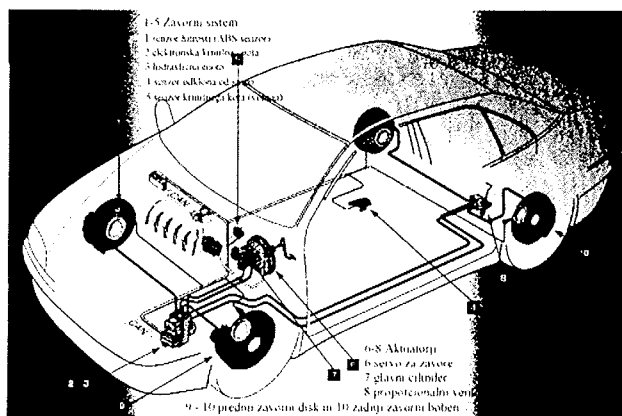
industrije, z ISO / TS 16949 vred. Kupci so renomirani svetovni proizvajalci, predvsem s področja senzorskih aplikacij v avtomobilski industriji, pa tudi električnih merilnih instrumentov, elektromotorjev, tahogeneratorjev itd. Skladno s svojo poslovno politiko podjetje razvija nove programe, kamor spada poleg razvoja materialov in samih magnetov tudi razvoj magnetnih sistemov in procesne proizvodne opreme ter opreme za magnetenje, preskušanje, delno ali popolno razmagnetenje in kalibriranje magnetnih sistemov /5/.

Raznovrstni trajni magneti so v avtomobilski industriji našli številna področja uporabe /4/, razvoj pa se še nadaljuje, še posebej v smeri nenehnega izboljševanja varnosti, za-

nesljivosti, ekonomičnosti in prijaznosti do uporabnika ter okolja. Ključni senzorji /2/ v avtomobilu so povezani s pozicijo (obese, pedal / plin, krmilje), hitrostjo gibanja vozila (ABS), temperaturo (notranja, regulacija klime, armatura, motor, prenos), hitrostjo gibajočih se delov (gredi, prenos, avtomatska sklopka), z vibracijami in udarci (motor, varovanje pred požarom). Na sliki 1 so shematsko prikazani sklopi senzorjev v avtomobilu.



Slika 1: Senzorski sklopi v avtomobilu /2/



Slika 2: Shema zavornega sistema avtomobila /3/

Na sliki 2 je shematsko prikazan zavorni sistem avtomobila /3/, ki ga sestavljajo: senzor hitrosti vrtenja koles (ABS-senzor), elektronska krmilna enota, hidravlična enota, senzor odklona od smeri, senzor krmilnega kota (volana), akuatorji in zavorni diski / bobni.

ABS je kratica za Anti - Lock Braking System, to je sistem, ki preprečuje blokiranje vrtenja koles med zaviranjem, s čimer zagotavlja večji zavorni učinek ter lažje vodenje vozila, povečano stabilnost vozila in ohranjanje varnostne razdalje. Navadno sistem sestavljajo skupno 4 senzorji na posameznih kolesih ter skupna elektronska enota, ki signale iz senzorjev obdelava in vodi proces zaviranja. Elektronska enota pravilno deluje nad minimalno mejno hitrostjo, pri čemer z moduliranjem pritiska v zavorah, torej z zaviranjem in sproščanjem zavor, regulira zmanjševanje hitrosti vozila na ta način, da se hitrost kolesa obvladovano

zmanjšuje, kolo pa se pri tem ne sme popolnoma zaustaviti, dokler je hitrost večja od mejne. V večini primerov se na ta način zagotovi najkrajša možna zavorna pot. Sistem ABS je bil razvit že leta 1930 za letala ter patentiran tudi za avtomobile. Zaradi izboljšane varnosti je pričel doživljati širšo uporabo v obdobju od 1975 do 1979, ko je bil v Združenih državah Amerike uveden v tovorna vozila. Leta 1980 so ga pričeli avtomobilski proizvajalci vgrajevati v osebna vozila, najprej v višji cenovni razred, z nadaljnjim razvojem in nižanjem stroškov pa je hitro našel svoje mesto tudi v avtomobilih nižjega cenovnega razreda.

ABS-sistem s 4 senzorji deluje na naslednji način:

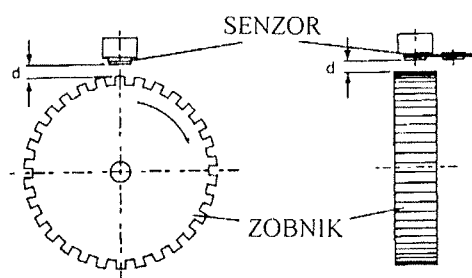
- Ko elektronski modul na osnovi signala iz senzorja prepozna, da bo kolo blokiralo, s tuljavo zapre ventil, ki je navadno odprt, ter s tem prepreči nadaljnje dovajanje hidravlične tekočine in nadaljnje zaviranje kolesa.
- Elektronski modul nadaljuje opazovanje signala iz senzorja iz tega kolesa.
- Če se kolo ustavlja hitreje kot druga tri kolesa, odpre tuljavo ventila. Ujeta tlačna razlika se izravna v rezervoarju glavnega cilindra.
- Ko kolo znova dobi hitrost, modul vrne tuljavo v normalno stanje, ki omogoča dotok tekočine.

Podjetje Magneti Ljubljana, d.d. izdeluje AlNiCo-magnete, ki so bistveni del ABS-senzorja, zato bo v nadaljevanju predstavljen samo tovrstni senzor, razpolaga pa tudi s ključnim znanjem za proizvodnjo samih senzorjev. Tako je podjetje v letu 1999 že konkuriralo za kooperacijsko proizvodnjo nekaterih tipov senzorjev za svojega največjega kupca magnetov.

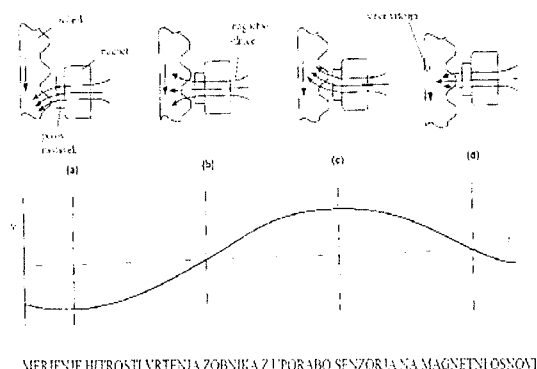
2 Senzor ABS z AlNiCo-magnetom

2.1 Fizikalni princip delovanja

Dajalni sistem sestavljata zobnik iz mehkomagnetnega materiala, ki se vrti skupaj s kolesom, in sam senzor, kjer se zaradi vrtenja zobnika spreminja magnetni pretok, kar ima za posledico inducirano napetost. V nadaljevanju bodo predstavljeni časovni poteki inducirane napetosti na senzorju, posneti pri laboratorijski postavitvi merilnega sistema, prikazani na sliki 3.



Slika 3: Lega senzorja glede na zobnik /6/



MERJENJE HITROSTI VRTENJA ZOBNIKA Z UPORABO SENZORJA NA MAGNETNI OSNOVI

Slika 4: Spreminjanje magnetnega pretoka zaradi vrtenja zobnika ter potek inducirane napetosti /6/

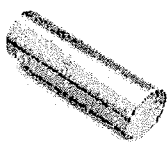
2.2 Izdelava senzorja

Senzor sestavljajo:

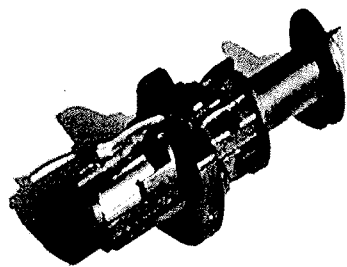
- magnet
- polov nastavek
- spojni del za pritrditev polovega nastavka na magnet
- tuljavnik s kontakti
- tuljava
- priključni kabel z nosilcem, tesnili in mehansko zaščito.

Ključni del senzorja je AlNiCo-magnet valjaste oblike, ki je generator magnetnega polja. Po potrebi je ta magnet lahko tudi profilno brušen.

Na sliki 5 je prikazan značilni magnet pred vgradnjo v senzor, na slikah 6 - 8 pa izdelan, nezalit senzor brez kabelskih povezav za priključitev na elektronsko enoto.



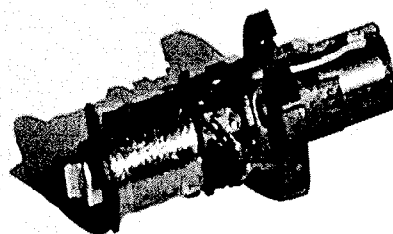
Slika 5: Liti AlNiCo-magnet za ABS-senzor



Slika 6: Zabrizgan magnet s polovim nastavkom in kontakti za priključitev na kabel



Slika 7: Polov nastavek za koncentracijo silnic



Slika 8: Izdelan, nezalit senzor s tuljavo

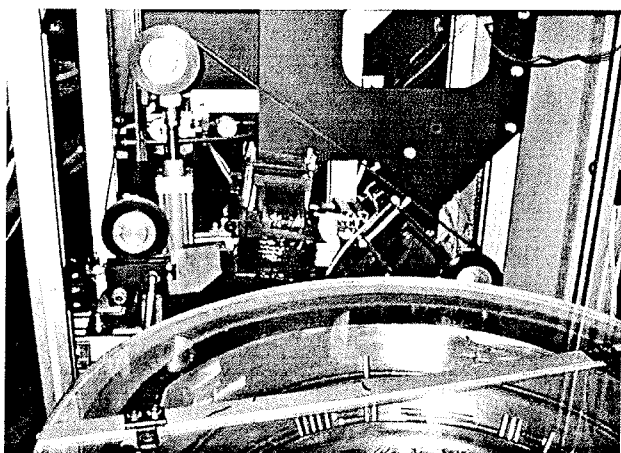
Značilni podatki za magnete so podani v tabeli 1. Navadno je uporabljen liti material, ki daje pri enakem volumnu nekoliko boljše magnetne lastnosti, in razmerje med premerom in dolžino 1:3, kar postavi delovno točko magneta nekoliko nad področje maksimalnega energijskega produkta.

Tabela 1: Najpomembnejše karakteristike AlNiCo-magneta

Karakteristika	Značilna vrednost
Premer valja	od 4 do 10 mm
Dolžina valja	od 15 do 40 mm
Remanenca B_r - minimalno	od 1100 do 1250 mT
Koercitivnost B_{H_c}	od 45 do 60 kA/m
Maksimalni energijski produkt BH_{max}	od 32 do 40 kJ/m ³

Ker so magnetne lastnosti za pravilno delovanje senzorja kritične, v podjetju zagotavljamo zanje nivo 0 ppm s 100-odstotnim kontroliranjem in preskušanjem. Z ozirom na funkcijo ter način vgradnje so za magnet postavljene relativno visoke zahteve glede toleranc dimenzij in druge geometrije, videza, t.j. okrušitev in livarskih napak, pa tudi nivoja razmagnetanja. Za izpolnjevanje teh zahtev je bilo tre-

ba razviti visokoproduktivne elektronske merilne sisteme za magnetenje, merjenje magnetnega fluksa, razmagnetnje, vizualno kontrolo ter nekontaktno kontrolo dimenzij in geometrije. Ta oprema je zanimiva tudi za organizacije, ki se ukvarjajo z razvojem magnetnih materialov, vgradnjo magnetov in izdelavo magnetnih sistemov ter podobnih elektronskih komponent in je bila razvita v okviru lastnega razvoja procesne ter merilne opreme oziroma v okvirih projektov izboljšav v tehnoloških procesih v sodelovanju z Ministrstvom za gospodarstvo /5/. Na sliki 9 je prikazan del naprave za elektromagnetno preskušanje magnetov za ABS-senzorje.



Slika 9: Naprava za EM-preskušanje magnetov za ABS-senzorje

Magnet mora biti čim bolj tesno povezan s polovim nastavkom iz mehkega železa, ki koncentrira silnice in s tem omogoča bolj izrazito spreminjanje magnetnega fluksa glede na razdaljo med vrhom polovega nastavka ter zobnikom.

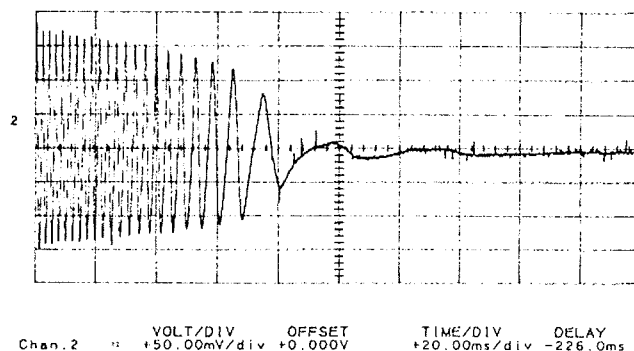
Konstrukcija in izdelava tuljave je tehnološko zahtevna in se izvaja po posebnem programu navijanja.

Značilne karakteristike tuljave in izhodni signal senzorja so podane v tabeli 2:

TABELA 2	
Karakteristika	Tipične vrednosti
Upornost	od 0,5 do 2 k Ω
Induktivnost (1 kHz)	od 500 do 1200 mH
U, inducirana (tip. 400 r/min, reža 0,8 mm)	od 0,5 do 4,5 V

Glede na izhodno napetost imajo nekateri tipi senzorjev integrirane elektronske elemente za obdelavo inducirane napetosti, kar omogoča miniaturizacijo ter nižje skupne stroške izdelave senzorja, predvsem na račun cene vgrajenih magnetov.

V laboratoriju smo izvedli simulacijo delovanja senzorja (915 r/min, 70 zob) in posneli časovni potek inducirane napetosti ob prehodnem pojavu trenutne zaustavitve zobnika (slika 10).

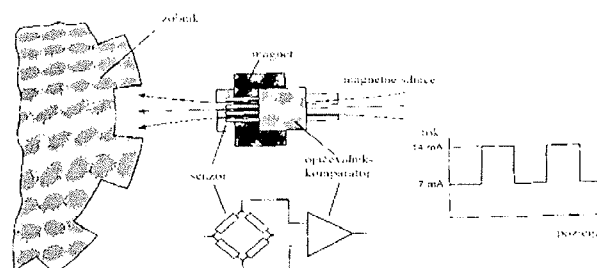


Slika 10: Prehodni pojav ob zaustavitvi zobnika

3 Sodobni načini merjenja hitrosti vrtenja na osnovi integriranih vezij oz. senzorjev

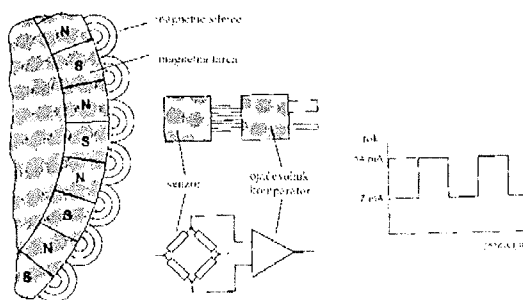
V zadnjem obdobju se v nižjem cenovnem razredu vse bolj uveljavljajo cenejše rešitve, temelječe predvsem na integriranih elektronskih elementih – Hallovih ter magnetouporovnih senzorjih /6/. Tu lahko še vedno ostane pasivni dajalnik – mehkomagnetni zobnik (slika 11) ali pa zobnik nadomestimo z multipolno namagnetnim plastomagnetnim aktivnim dajalnikom (slika 12).

ELEKTRONSKI SENZORJI MAGNETNEGA POLJA MERJENJE HITROSTI VRTENJA - PASIVNI DAJALNIK



Slika 11: Sodobno merjenje hitrosti vrtenja s pasivnim dajalnikom in integriranim vezjem oz. magnetouporovnim senzorjem /6/

ELEKTRONSKI SENZORJI MAGNETNEGA POLJA - AKTIVNI DAJALNIK



Slika 12: Sodobno merjenje hitrosti vrtenja z aktivnim dajalnikom in integriranim vezjem oz. magnetouporovnim senzorjem /6/

Predvidevamo, da ti novi proizvodi doslej uveljavljenih senzorjev z ALNiCo-magneti tudi v naslednjem srednjeročnem obdobju večinoma še ne bodo nadomestili, zato vidimo v programu izdelave ABS-senzorjev z ALNiCo-magneti novo priložnost za uspeh. Kupci namreč pri sebi instalirajo proizvode, temelječe na novih materialih, zmanjšujejo število svojih dobaviteljev oziroma celo prenašajo dele svojih proizvodnih programov k svojim ključnim dobaviteljem, da od njih prejmejo izdelke z višjo stopnjo integracije.

4 Sklep

Predstavljena je bila fizikalna osnova delovanja, izgradnja senzorja na osnovi paličastih ALNiCo- magnetov, značilne vrednosti njegovih najpomembnejših karakteristik za morebitno izdelavo elektronskega krmilnega modula ali alternativnih rešitev samega senzorja in možnost podjetja Magneti Ljubljana, d.d., da ponudi trgu proizvod z večjo stopnjo integracije ter si tako še naprej zagotovi poslovni uspeh na trgu.

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A 12-BIT FLASH ADC

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Key words: digital-to-analog, converter, precision, accuracy, INL, DNL, linearity

Abstract: A 12 bit, single step flash digital-to-analog converter (DAC) in 0.6 μ m CMOS was realized on 1.5mm² silicon area and has power consumption of 0.5mW at 5V supply. Converter architecture based on resistor-string having 2**N resistor taps and layout-efficient coding scheme. The system features a precision, fast settling, offset canceling operational amplifier and has 0.002% linearity. The conversion time is 4 μ s.

12-bitni bliskovni DAC

Ključne besede: digitalno-analogni, pretvornik, precizija, točnost, integralna nelinearnost, diferencialna nelinearnost

Izveček: Bliskovni digitalno-analogni pretvornik, izdelan v standardni 0.6 μ m tehnologiji CMOS na površini silicija 1.5mm², ima minimalno porabo 0.5mW. Arhitekturo pretvornika sestavlja uporovna veriga z napetostnimi odcepi in CMOS stikali, ki so krmiljena na način, ki optimizira porabo silicija. Doseženo linearnost pretvornika (0.002%) zagotavlja ustrezno povprečenje, ki minimizira gradient spreminjanja upornosti polisilicija po silicijevi rezini. Z ustrezno optimizacijo internih zaklasnitev je dosežena hitrost pretvorbe 4 μ s.

I. Introduction

The paper will discuss the digital-to-analog converter having the fast conversion time of 4 μ s at worst-case process. Concept based on resistors matching which guarantee the linearity of monolithic DAC to be in the 9 to 10 bit range. Performances can be extended to more than 12 bits, using so called layout averaging technique, which includes proper interleaving of passive components. Technique will be described in detail later in this paper. The result of such a technique is desensitizing the DAC to doping, thermal and misalignment gradients.

In present paper we will describe the layout efficient architecture of the 12 bit flash DAC with proposed algorithm to extend linearity to 0.003%. We will discuss the basic flash system, followed by section with detail description of the DAC converter blocks, DAC converter operational amplifier and the concept for offset compensation. The layout averaging and gradient-over-silicon analysis using Matlab and in final section the measurement and performances will be presented.

II. Basic Flash DAC

A single step flash DAC converter, based on resistive chain and digitally controlled switches are shown from Fig. 1. The input digital code is converted to switch-control signals. Only one switch is close at a time. Resistor-chain is supplied from constant, temperature and supply stable reference voltage. Ideally, here are only two current contacts – on bottom and on top of the chain where the voltage reference is connected. There are 2**N taps which are voltage contacts to switches and no current flows through them. The large number of switches with their parasitic

capacitance loaded the sensitive – internal analog line. The resistance of the chain, the parasitic capacitance, switch resistance and internal – analog line (IVA) parasitic have influence on converter settling performances and therefore conversion time.

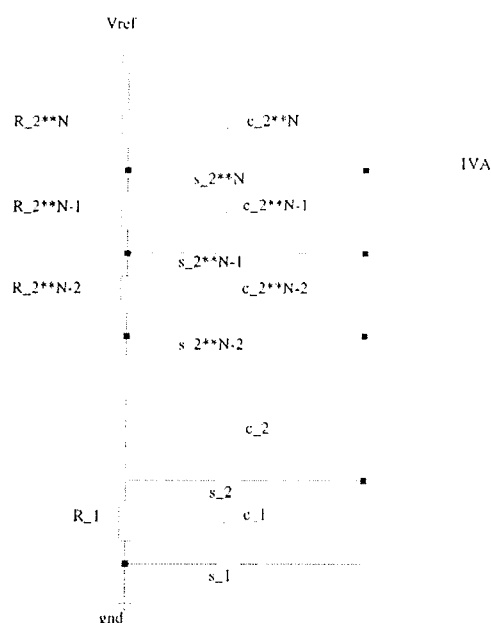


Fig. 1 DAC12 basic architecture.

It is therefore important to make the resistance small enough to speed up the conversion. Lower chain resistivity requires larger driving capability of the voltage reference. The optimum exists between switch resistance, chain resistance and capacitance. To reduce the number of switches, connected to the IVA, the so called tree-decoding scheme might be a solution. As we will show later in this paper,

the good compromise can be found between layout density and the settling performances. Using additional resistive parallelism, the equalizing of the settling performances over full scale can be achieved.

III. Circuit Realization

A. Layout efficient decoding

The principle is shown from Fig. 2. The 12 input NOR gate is realized by 12 N-channel devices in serial. The P-channel devices are omitted, the single PMOS current generator is used instead. There are $2^{**}N$ current generators in the circuit, only one delivers current into system at a time. Overall required bias current is therefore single generator current which is in the range of 5uA for 12 bits converter. The complete decoding is optimized to fast controlled of the switch having on IAL side the capacitive loading, including the operational amplifier input capacitance.

The layout concept including four-bit intersection is in Fig. 2. Twenty metal lines (double metal process) passes the N-channel area. One kilo-bit block is organized as binary coded area from 1, 2, 4, and 8 bits sub-blocks inserted into 9-bit converter. Last – 10-th bit select between the two 9-bit converters. To get 12-bit converter, four such a 10-th stages are organized in proper way. Voltage reference was chosen to be 4.1V at 4.5V minimum supply. To minimize the parasitic, the switches are realized from negative reference side to be NMOS only, around mid-area switches are T-gates and on positive-reference side, switches are again single channel-PMOS only.

B. Interleaving and layout averaging

The principle of operation of presented DAC guarantee the monotonisity and therefore the analog output always increasing with increasing of the digital code. No matter how large is poly1 resistivity gradient, It will mainly influence on integral non-linearity (INL) and can be expressed as a dif-

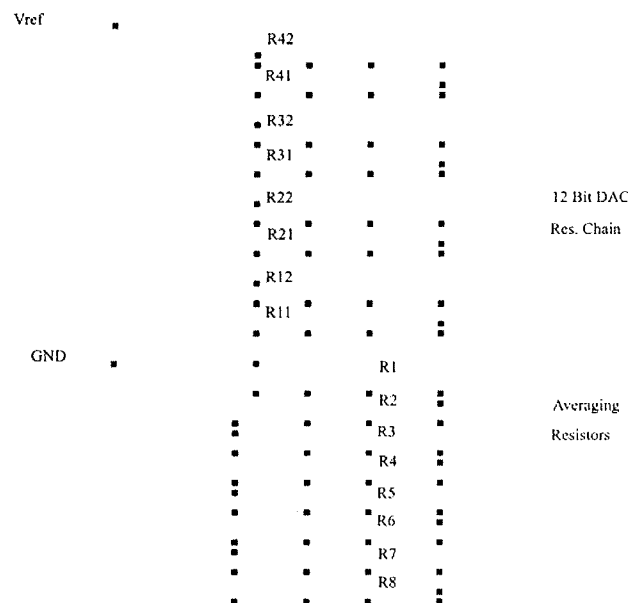


Fig. 3. Layout averaging. Dark dots represent the current-poly1-metal1 contacts. This scheme corresponds to "lay2" curves on MatLab analysis figures.

ference between actual analog value (V_{ana_i}) and ideal one (V_{ana_ideal}) on internal analog bus (IVA - Fig. 1) and is equal to:

$$INL = V_{ANA_i} - V_{ANA_ideal} = \frac{V_{ref}}{2^N} \cdot \sum_{k=1}^i \frac{dR_k}{R}$$

R is resistor-unit (ideal), dR_k is difference from unit value,

If we assume that all mismatch terms are zero over resistors chain, then the worst-case error will occur at the middle of the chain:

$$i = 2^{N-1}$$

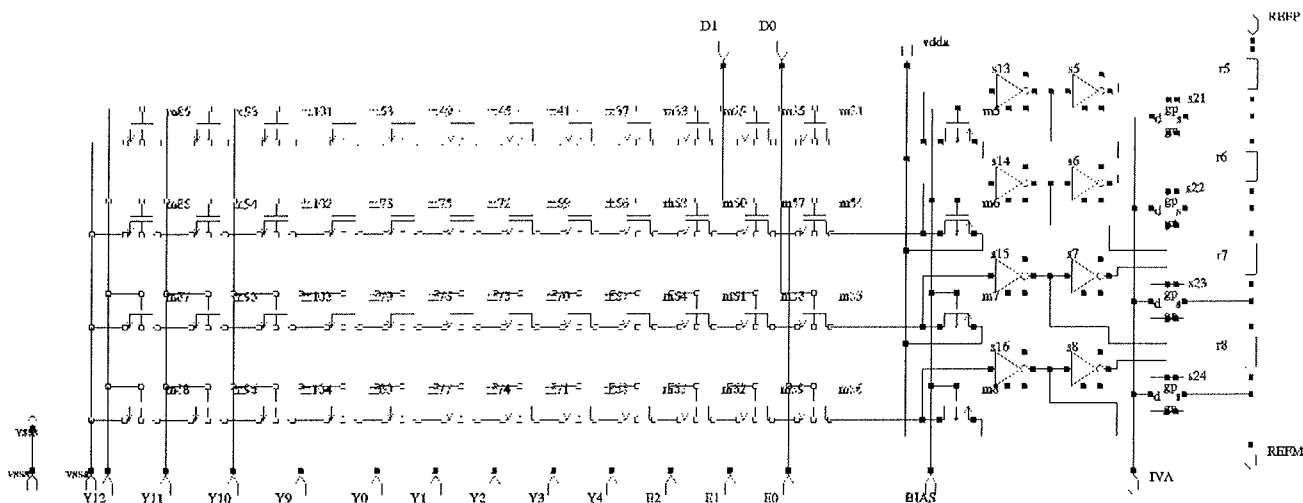


Fig. 2: Four – bit segment from 12 bit DAC

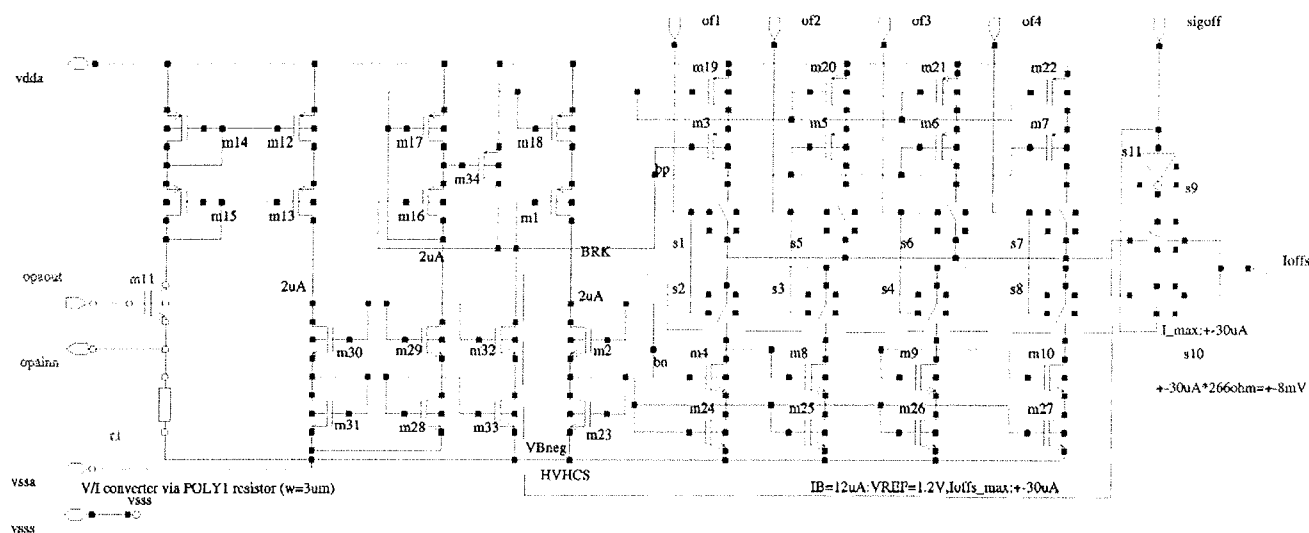


Fig. 4: Stable current generator for offset calibration. Binary weighted source and sink currents are generated from stable bandgap reference voltage.

And the maximum value of INL is:

$$INL_{\max} = \frac{V_{ref}}{2} \cdot \left[\frac{dR_k}{R} \right]_{\max}$$

It is evident that there is also an amplifier offset voltage contribution to INL. It contributes directly to INL. For high precision conversion, offset cancellation is a must (Fig. 4, Fig.5 and Fig. 6).

Maximum negative mismatch dominates at all the resistors in the lower half of the chain and the maximum positive mismatch occurs in the upper half of the chain or vice-versa, depends on resistivity gradient. Fig. 8 shows the INL error over all 12 bit on digital input.

Layout averaging principle uses additional parallel resistors to each sub-block of the DAC (Fig.3). The number of sub-blocks and the appropriate number of additional resistors define the possible layout mirroring and scrambling combinations. The different types of mismatches may occur randomly in X and Y direction on silicon. The sub-blocks mirroring and scrambling are therefore required in all directions (Fig. 8, Fig. 9, and Fig. 10). The number of sub-blocks is limited by the connectivity between sub-blocks and between the averaging resistors. The poly1-to-metal contact resistivity may vary from 2 Ohm to 20 Ohm, which could be more the one LSB unit resistor. Serial connections are required (metal1 and metal2), but they need to be done in proper way (temperature coefficient of Al metal resistivity). These contacts conduct the all-resistors main-chain current and may cause the majority of INL and DNL error.

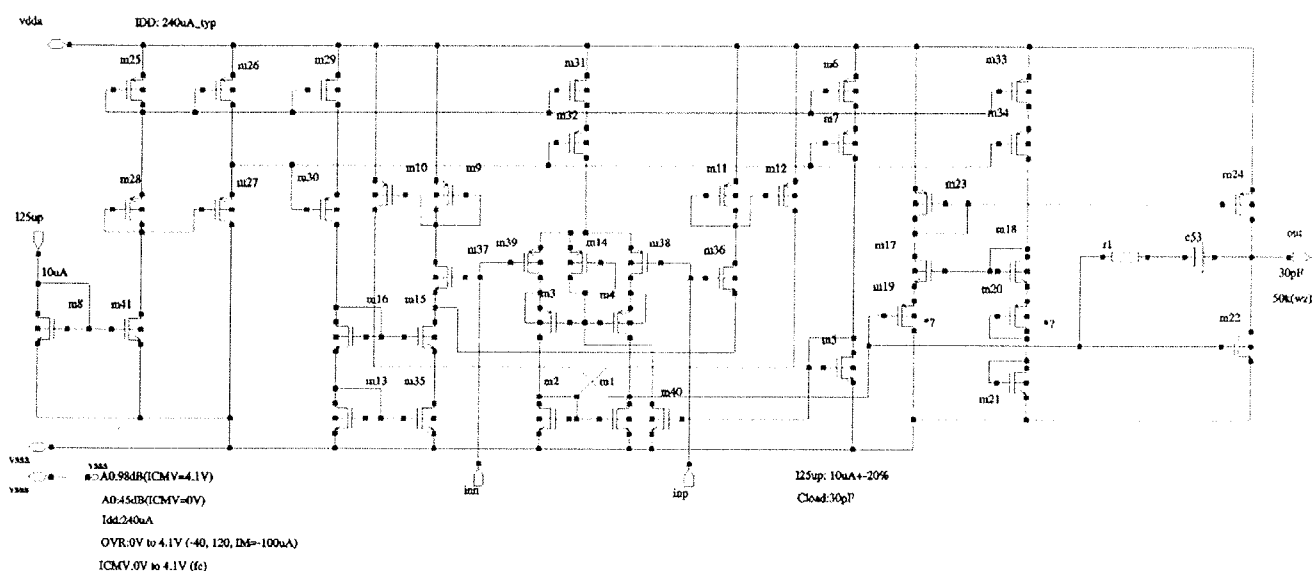


Fig. 5: High gain class AB amplifier having input voltage range from negative rail to 300mV from positive rail.

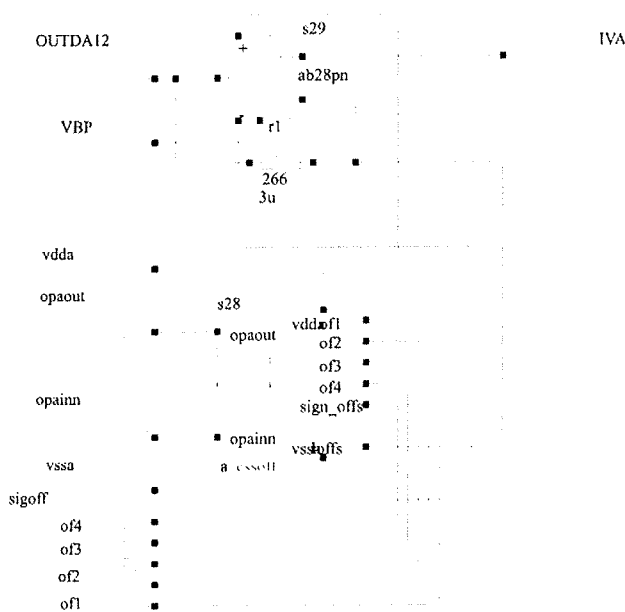


Fig. 6: Amplification of internally generated analog voltage Viva and offset correction circuitry.

Next important layout constraint is mismatch minimization. The resistor-unit value and its width on layout influence on analog output delay and on mismatch between units. Huge mismatch occurs when equal units have different neighbors.

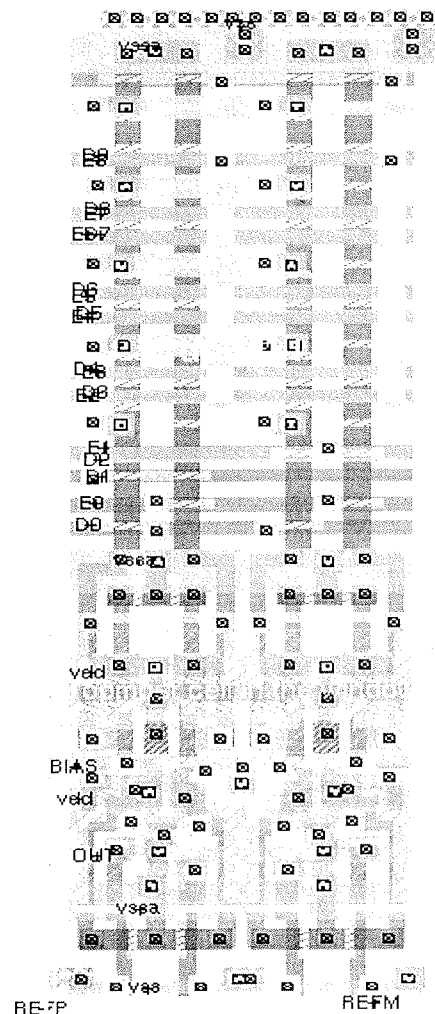
IV. Conclusion

The required matching of resistors in chain using so called end-point analysis is relatively high and is derived from INL expression:

$$INL < 0.5LSB \dots \dots \dots \frac{1}{2^N} [\%matching]$$

N is converter precision. The 12 bit DAC require 0.025% resistors matching which is theoretical and practical possible limit when all available techniques are implemented. That means the layout is very critical part of the analog circuit design. Again, theoretically is possible to realize the active element matching. As a result, the mismatch and drift occur and the conversion accuracy may again be much lower then is converter precision. Our first measurements using code density principle and end-point approach without layout averaging give an encouraging result for INL, which was within +-2LSB at more then 50% samples. Layout averaging may improve the result for more then +-1.5LSB as is shown from Fig. 8 to Fig. 10. Much better result gives so called "best-fit" approach. Nevertheless, the proposed layout averaging, as is shown from Fig. 3 for 12 bit flash DA converter, is a challenge for designers to improve the result where fast conversion is of the most importance in integrated system on silicon. The principle itself guaranty the DNL performance to be much better then +-0.5LSB.

The layout - four bit intersection is shown from Fig. 7.



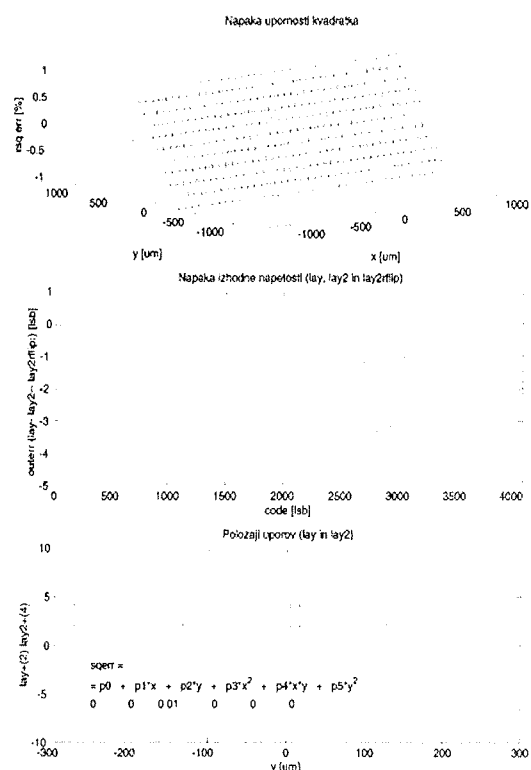


Fig. 8: Three curves are as follows: -4LSB maximum INL at the middle of the string, mirroring-parallelism -1.5LSB and layout averaging 8:4 give accuracy of 1LSB. Gradient in Y direction is (0.5K-code-direction).

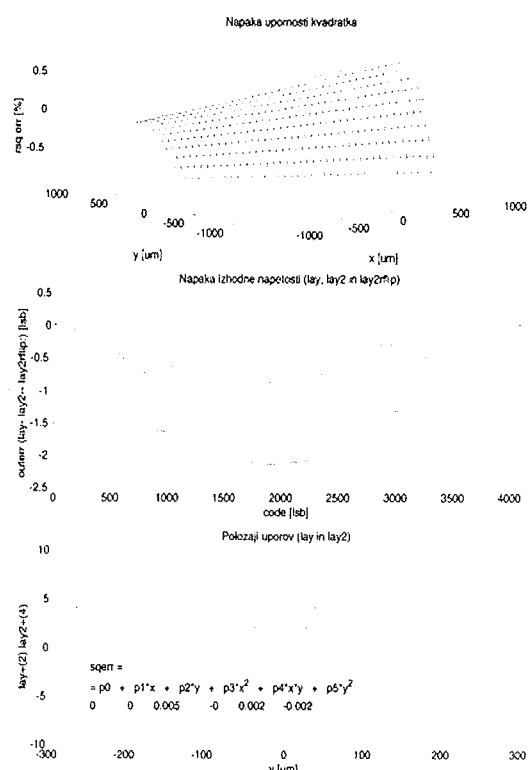


Fig. 10: Random mismatch and random weighting as is shown on first and last canvas. In X direction are resistors string of 0.5k codes, in Y direction are 8 times 0,5k codes and parallel string.

Acknowledgment

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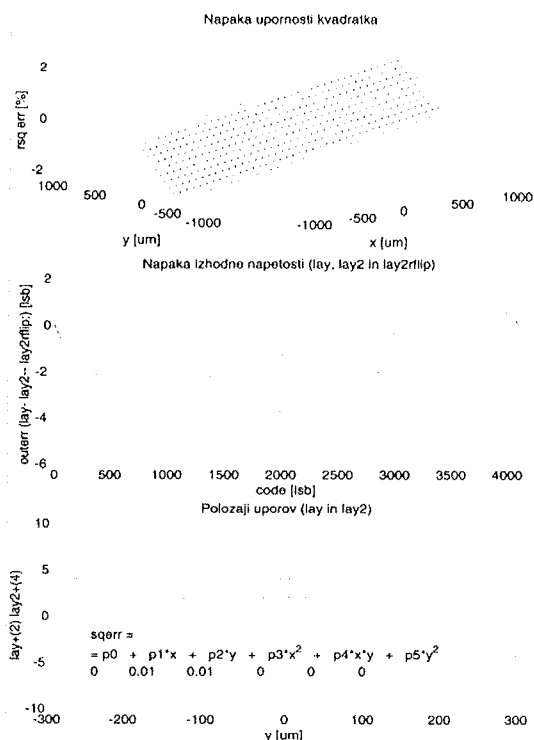


Fig. 9: Linear gradient in X/Y direction gives four max. and four minimums. They correspond to the number of segments that alternate in direction X.

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AUTOMATIC GAIN ADJUSTMENT IN CONTACTLESS COMMUNICATION SYSTEMS

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Key words: automatic gain control

Abstract: Systems for contactless short range communications are more and more frequently used for different applications like access control, inventory and ticketing. Such systems comprise a RF transmitter emitting magnetic (electromagnetic) field and one or more transponders, which are supplied by the RF field. The transponder modulates the RF field to send information to the transmitter, which also comprises a reader system. The data transfer can be unidirectional (from transponder to reader) or bi-directional.

The receiver system in the transmitter senses the modulation of RF field caused by transponder(s) on the transmitter antenna. Since the distance from transmitter antenna to transponder can vary from practically zero to the maximum operation range, the dynamic range of receive signals is very high. The gain of receive channel must be high to successfully detect the small receive signal but high gain can cause problems in case of large input signals. The solutions to the problem are the clipping of the input signal or automatic gain control or receive channel. The proposed solution describes an automatic gain control, which is specially adapted for RFID applications, as it successfully exploits the special nature of signals in such systems.

Avtomatsko nastavljanje ojačenja v brezkontaktnih komunikacijskih sistemih

Ključne besede: avtomatska nastavitve ojačenja

Izvleček: Sistemi za brezkontaktno komunikacijo skokovito pridobivajo na pomenu, saj njihova uporaba nezadrdno narašča. Takšen sistem sestavlja oddajnik RF moči, ki oddaja elektromagnetno polje in eden ali več odzivnikov ki to polje uporabljajo za vir energije in preko modulacije RF polja pošiljajo podatke oddajniku. Pretok podatkov je lahko enosmeren, samo od odzivnika do oddajnika, ali pa v obe smeri.

Za sprejem podatkov od odzivnikov vsebuje oddajnik RF moči tudi sprejemni kanal. Sprejemnik opazuje signal na oddajni anteni in ojači vsako spremembo nivoja oddajnega signala. Na ta način sprejemnik zazna modulacije RF polja s strani odzivnikov. Ker je razdalja med sprejemnikom in odzivnikom lahko zelo različna, od praktično nič pa do maksimalne razdalje, ki še omogoča komunikacijo, je razpon možnih nivojev sprejemnega signala zelo velik. Ker seveda želimo zanesljivo sprejemati tudi najmanjše vhodne signale, ima sprejemna stopnja veliko ojačenje, kar lahko povzroči probleme pri visokih nivojih vhodnih signalov. Da bi preprečil napačno delovanje v takšnih primerih imamo na razpolago dve možni rešitvi. To je omejevalnik signala ali pa avtomatsko prilagoditev ojačenja nivoju vhodnega signala. Članek opisuje posebno izvedbo sistema za avtomatsko nastavitve ojačenja, ki je prilagojena za sprejemnike signala brezkontaktnih odzivnikov in uspešno izkorišča posebnosti signalov v teh sistemih.

1. Introduction

When designing an RFID receiver a maximum communication range is always one of major design goals. This implies that the receive gain is set as high as possible considering the input noise level. The result is that in case the transponder is close to reader antenna and the input signal level is much higher than the minimum one, the signal at the end stages of receive channel exceeds the linear region of amplifier stage thus causing problems in data communication. Two possible solutions for this problem exist.

The simplest possible solution is signal clamping. When the predefined level of the signal amplitude is reached the gain of the gain stage is decreased so that the amplitude can not increase further. This of course causes signal distortion but since we are usually only interested in receiving digital data the distortion can be tolerated. A bigger disadvantage of clamping system becomes evident in case of communication where a significant level of disturbance signal is added to the communication signal. The disturbance signals usually do not exceed the signal clipping

level so they appear at the end of receive gain chain amplified with full gain of receive channel. On the other hand the communication signals are usually higher than the clipping level so their amplitude is amplified with smaller gain. The obvious result is that the ratio of communication signal to disturbance signal can significantly degrade at the end of receive gain chain compared to the input. The communication signal recognition is aggravated or in worst case becomes impossible.

The second possibility is automatic gain adjustment of the receive channel where the receive gain is decreased in case of higher input signal levels. The gain then is the same for communication signal as well as for any possible disturbance signals resulting in no decrease of signal to disturbance ratio.

2. AGC system design

Automatic gain control (AGC) circuits are well established in telecommunication and audio systems. The basic design problem in AGC design is the impact of gain change on

the input signal. The input signal degradation due to AGC action must be kept at minimum and all important signal parameters (information content) should not be affected. To achieve this the nature of the input signal must be carefully studied and the AGC system designed for the particular input signals. The most important parameters are the gain change decision algorithm and the speed at which the gain is decreased and increased.

The classical AGC solution comprises compactors which determine if the signal amplitude at given gain stage is lower or higher than the predefined level for AGC action. If that level is exceeded the AGC reacts by rapid gain decrease. This mode of operation is called attack mode and the speed of gain decrease attack speed. The AGC system remains in this attack mode till the gain decrease results in signal amplitude below the AGC threshold level. At that point the AGC system enters second mode called decay mode. During decay the gain starts increasing back towards its original (high) level. In case the signal amplitude again exceeds AGC threshold level as a result of decay action or input signal increase the AGC system returns to attack mode. At constant signal level the AGC system constantly switches between attack and decay mode so the decay speed must be orders of magnitude lower than attack speed to minimise the impact of mode switching on the input signal. The AGC system action is finally finished when the input signal is low enough that the decay action restores the default high gain and the AGC system is deactivated.

Our design solution of AGC system differs from above described classical one as it was designed for specific type of input signals existing in RFID communication. The protocol of RFID communication starts with the command sent from the reader to the transponder. The transponder reacts on the command and sends required data to the reader. The actual data is usually preceded by a preamble to prepare the reader for receiving the data. The coding format of the data is known so the AGC system has the information of the minimum and maximum possible time between two pulses. It is also reasonable to assume that the transponder is not able to change position in the RF field in the timeframe of data transfer so the same signal amplitude inside one data package can be expected. But immediately after the end of data transfer from one transponder a communication with different transponder, having completely different position in RF field and therefore different signal amplitude can start.

It is evident that the AGC system for such signals must have a fast attack speed to set the gain correctly well inside the preamble before the actual data receive starts. The second imperative is that also decay speed must be relatively high since the reader must be prepared to receive new data at completely different signal level in a short time after the first data transfer is finished.

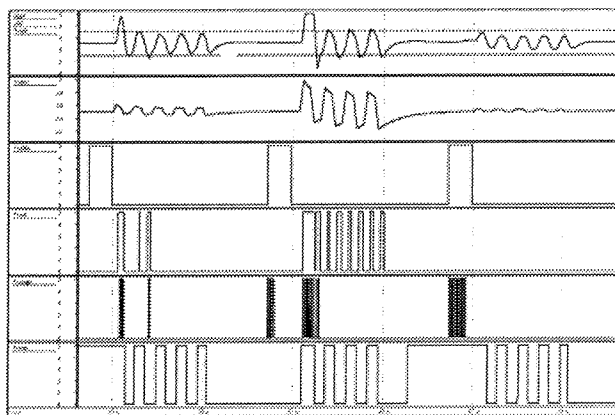
To satisfy these requirements we devised an AGC system, which has three modes of operation instead of two as in classical solution. These modes are attack, decay and idle

mode. The attack mode is started when the signal amplitude at the output of gain stage exceeds the defined threshold level. A rapid gain decrease is triggered and the signal amplitude is reduced below the threshold level. The conditions for attack mode are not preset anymore but the system does not enter usual decay mode. Instead the system waits in idle mode till conditions for decay or new attack are fulfilled. In idle mode the gain is not changing and is kept at the level defined by previous attack mode. The transition from idle mode to decay mode occurs if there are no incoming signals for a certain amount of time. The detection of data is performed using second comparator which has threshold level far below the AGC attack level (approximately one half of attack level) but still well above expected noise level. During data transfer package input pulses are always above idle mode comparator level. When the data transfer is finished these pulses stop and the idle mode comparator is not producing output pulses. If this condition persists longer than twice the maximum time space between two pulses as defined by data coding protocol the AGC system changes state from idle to decay. The decay is fast since the reader must be prepared for new data package from another transponder in relatively short time. The AGC action is finished when the gain is increased back to the default value.

The typical data receiving sequence using such AGC system starts with the preamble sent by the tag. During preamble the receive channel evaluates if the signal is too high and reduces the gain accordingly by setting the AGC system to attack mode. Well before the preamble transmission from transponder is finished is the receive channel AGC system already in idle mode. It stays in idle mode all through data transfer since input signal above idle mode threshold is always present. After the data transmission is finished the AGC stays in idle mode for a defined time and changes state to fast decay mode. A case of short data transfer from three different transponders having different signal levels is presented on fig. 1.

In the upper canvas the output signal of the receive gain stage is shown. The receiving signal from the first transponder (shown in second canvas) was higher than the AGC limit presented as two straight lines on the same canvas. The attack mode is triggered. The flag presenting the attack mode is shown in canvas four. The attack is repeated every time the output signal exceeds the upper or lower limit. After two periods of incoming signal the gain is adjusted and the AGC system enters idle mode. Following pulses are received correctly with the gain set during attack time. The correctly received digitised signal is presented on the lowest canvas. After the receive signal stops the AGC system remains in idle for a time longer than two maximum receive signals periods. This is followed by a fast decay mode (the decay mode flag is presented on canvas three). Two more signal packages follow. The second one has higher amplitude than the first one so the AGC system must reduce the gain practically to the lowest possible. After the end of receive signal package another fast decay

cycle follows. The receive system is again ready for new receive signal package (third one) which has a low signal amplitude so no AGC action is needed.



Canvas 1: Analog output signal after the AGC gain stage

Canvas 2: Analog input signal

Canvas 3: Fast decay mode flag

Canvas 4: Attack mode flag

Canvas 5: Clock signal for gain change counters (active during attack and decay)

Canvas 6: Digitised receive signal

3. Conclusion

The AGC system for contactless data communication system using RF powered transponders was designed based on the idea that only through a throughout knowledge of the nature of receive signal an optimum automatic gain control can be devised. The resulting system is perfectly suited for the task since it performs necessary gain adjustment only during the preamble of the incoming data package while there is absolutely no gain change during the actual data transfer. It also allows extremely fast gain recovery after the end of data transmission. All this ensures a reliable data receive in complete incoming signal amplitude range.

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MICROSYSTEM FOR ELECTRICAL CURRENT SENSING

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Key words: integrated sensors, Hall sensors, current measurement, microsystems

Abstract: In this paper a method for measuring electrical currents with a magnetic microsystem is presented. With the use of two coils, core and a magnetic microsystem closed loop system can be constructed to measure the electrical current through the primary coil. The magnetic field, generated by the primary coil current is sensed by the sensor in the air gap and amplified. This signal is used to generate a current through the secondary coil and therefore compensating the magnetic field in the air gap.

Mikrosistem za merjenje električnega toka

Ključne besede: integrirani senzorji, Hall senzorji, merjenje toka, mikrosistemi

Izleček: Članek predstavlja metodo merjenja toka z uporabo magnetnega mikrosistema. Z uporabo dveh tuljav, jedra in magnetnega mikrosistema je možno sestaviti zaprtolančni sistem, ki meri tok skozi primarno navitje. Tok skozi primarno navitje ustvari magnetno polje v jedru, katerega zazna senzor v zračni reži. Ta signal ustvari tok skozi sekundarno navitje in s tem kompenzira magnetno polje v zračni reži.

1. Introduction

There are various methods to measure electrical current. The most common methods include the use of a shunt resistor, a transformer or a magnetic sensor. Resistive shunts operate by giving a voltage proportional to the current going through the resistor. This offers good accuracy and low offset, but does not provide electrical isolation and can have high thermal drift. Due to this nonisolated method the resistor or the electronics can be destroyed due to transients. Transformers can be used to electrically isolate the measurement system from the main system, but the main disadvantage of this method is that this only works for AC currents. To extend the operation to DC or low frequency currents, a DC magnetic field sensing element must be added to the system. This can be achieved by adding a magnetic field sensor into the transformer core, by which the DC magnetic field is measured. If the magnetic field sensor signal is combined with the AC signal the measurement range of such a microsystem is extended into the low frequency region.

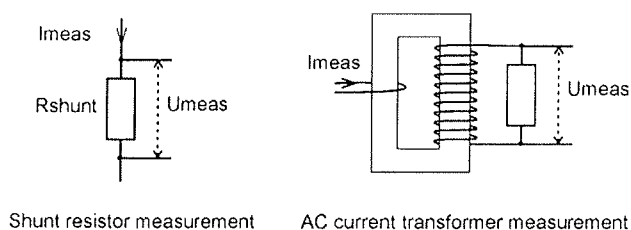


Fig. 1: Methods of current measurement – direct and galvanically separated

2. Closed loop system

The signals from the magnetic sensor and from the coil are combined in such a way, that the field in the magnetic core is always zero. This combination is a closed loop system.

In a closed loop current measuring system the sensor is placed in a compensating field which drives the field across the sensor to zero. The compensating field is generated by a secondary coil with N -turns. Therefore the current in the feedback (secondary) coil is proportional to the field from the primary current scaled by the turns ratio. Usually a shunt resistor is placed in series with the secondary coil to generate a voltage proportional to the measured current. The sensor is situated in the air gap. The magnetic sensor and the amplifying circuitry can be integrated on the same die, reducing the complexity of the wiring. The principle schematic of this closed loop system is shown on fig.2.

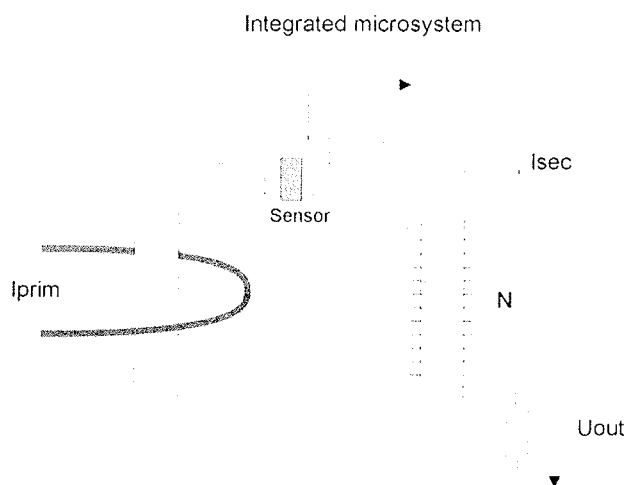


Fig. 2: Closed loop magnetic current sensing circuit

The output voltage for a single turn primary coil can be calculated from the following equation:

$$U_{out} = R_{out} \cdot I_{sec} = R_{out} \cdot I_{prim} \cdot \frac{1}{N}$$

The measured output voltage is dependent on the R_{out} shunt resistance and on the secondary coil N turn number. With these two parameters the measured secondary current can be scaled down to the values, deliverable by the integrated circuit.

The advantages for the closed loop system are:

- closed loop allows for higher accuracy
- the sensor always operates around zero magnetic field strength
- closed loop systems have higher bandwidths
- fast responses
- galvanic separation of the measuring system

3. Integrated microsystem for magnetic field sensing

To measure the magnetic field in the magnetic core gap a magnetic field sensor must be placed into the gap. Two types of sensors can be used:

- discrete sensors (for example magneto-resistive, Hall sensors)
- integrated sensors (integrated together with the processing and amplifying electronics)

The only requirement for the sensor is that it fits into the magnetic core air gap. Both types of sensors (discrete and integrated sensors) have been successfully used. The advantage of the integrated sensor system is the simpler wiring, due to the minimal on-chip wire length also the noise introduction is largely reduced. The disadvantage of the integrated version is the overall larger device, which must be fitted into the magnetic core gap.

The emphasis in this article is on the closed loop system with an integrated magnetic sensor, although the discrete version is very similar in operation. A N-well Hall sensor array was used as the sensing element. The Hall sensors can be easily integrated in standard CMOS processes. The array is made from 12 Hall sensors, each biased with 1 mA. On the same die also the processing electronics and the current driving amplifiers are integrated. Figure 3. shows the block diagram of the presented integrated circuit, figure 4. the layout of the integrated circuit with the integrated Hall sensor array in the middle.

The magnetic sensor signal processing is similar for the Hall sensors and for the magneto-resistive sensors. Both sensor signals need to be alternated for offset compensating reasons. The sensor signal is amplified and buffered to provide current capability.

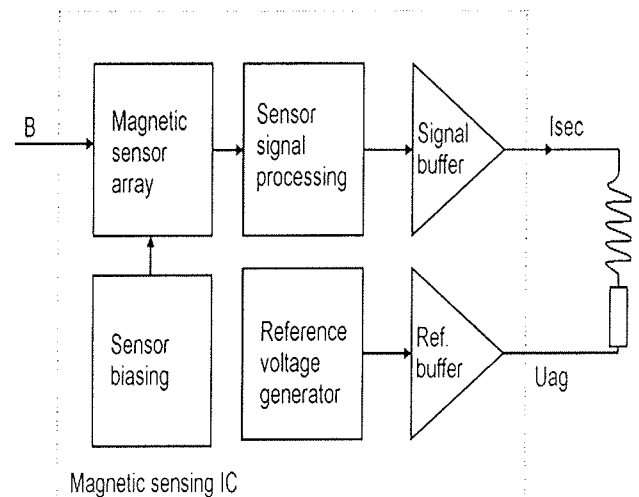


Fig. 3: Magnetic sensing integrated circuit block diagram

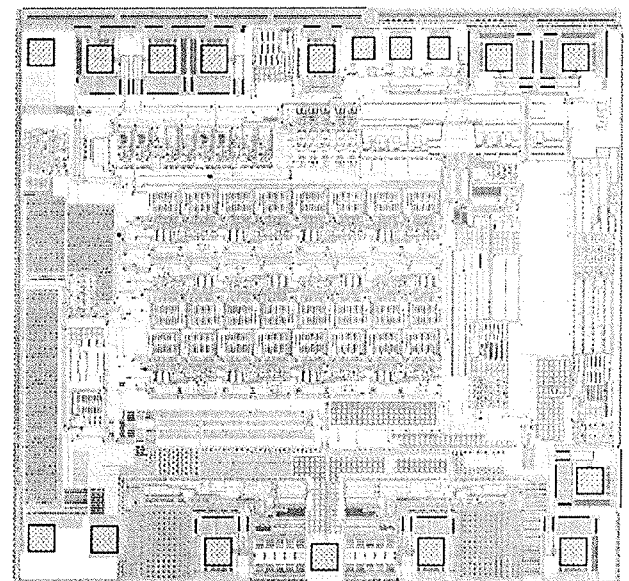


Fig. 4: Integrated microsystem for closed loop measurement

4. Simulation and measurement results

The magnetic core and the two coils have been modeled, enabling the SPICE simulation of the whole microsystem. With that the principle and the realization could be simulated. On fig 5. the step response ($0 \rightarrow 25A$) simulation is visible. The expected secondary coil current is 12.5mA ($25A / N=2000$). The simulated current is smaller due to the finite open loop gain of the amplifiers. On the secondary current the internal offset canceling circuitry settling is visible. This offset canceling is achieved by HF switching of the sensor signals.

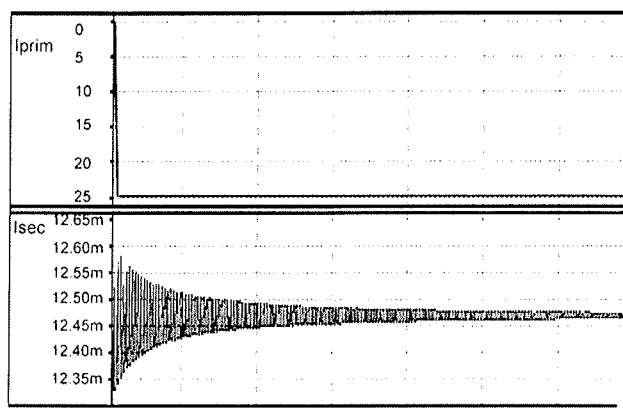


Fig. 5: Simulated 25A step response

On the following simulation the response to a 20A pulses with a frequency of 250Hz is shown. The response to these pulses is a combination of the secondary coil (HF response) and the sensor signal (LF response).

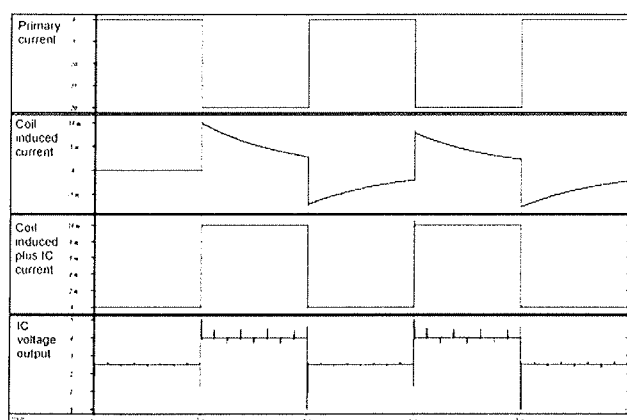


Fig. 6: Simulation of current pulses

The measured frequency response shows a flat frequency characteristics over the requested bandwidth. At lower frequencies the IC microsystem is the dominant contributor to the output signal, at higher frequencies the microsystem acts as a virtual ground and the signal comes from the current transformer. The frequency response is on fig.7. As can be seen, the frequency response shows variations below 0.6dB over the frequency range of up to 200kHz (the scale of the plot is 1dB/div). This means, that the mismatch between the secondary coil (dominant at high frequencies) and the sensor signal (dominant at low frequencies) is less than 0.6dB.

The measurement was made with a network analyzer and coils with a 5/2000 turn ratio. The primary current was measured on a 10Ω resistor, the secondary on a 100Ω. The expected result can be calculated :

$$\frac{U_{out}}{U_{in}} = \frac{I_{sec} \cdot R_{out}}{I_{prim} \cdot R_{in}} = \frac{5 \cdot 100\Omega}{2000 \cdot 10\Omega} = 0.025 \Rightarrow -32.04dB$$

The measured value is -32.27dB (at low frequencies) and shows good matching with the expected value.

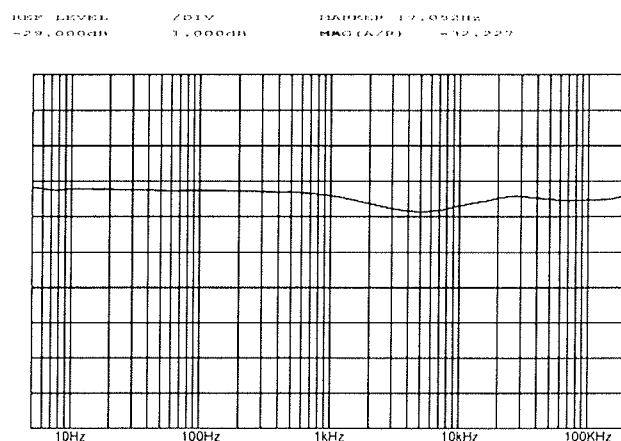


Fig. 7: Frequency dependency of the system

The positioning of the two coils largely influences the performance of the system, the best results are achieved when the primary and the secondary coil are overlapped and physically near to the sensor.

The frequency response of a non-optimal coil positioning can be seen on fig. 8, where the secondary coil was placed on the opposite side of the primary coil on the magnetic core. In this position the secondary coil induces less voltage and therefore the coil induced high frequency response is lower by almost 3dB.

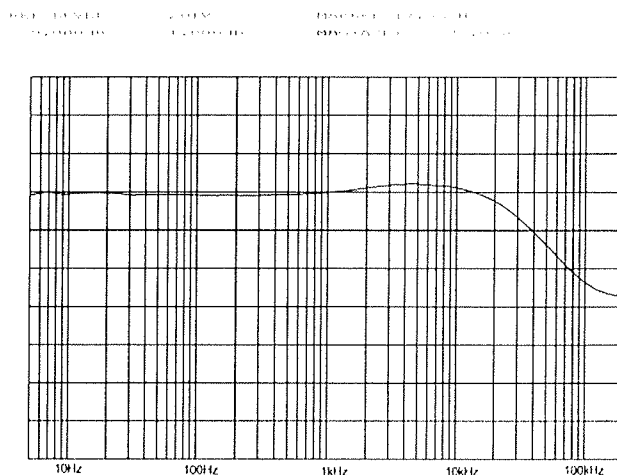


Fig. 8: Frequency dependency of the system with non-optimal coil position

5. Conclusion

It was shown, that a magnetic field sensing microsystem in a closed loop configuration for measuring currents has many distinct advantages over other methods. It combines the fast response times of the transformer method with the DC accuracy of the shunt resistor method. The Hall

magnetic sensor, processing electronics and the current amplifiers are all integrated on the same silicon die, creating an integrated microsystem. This die with the sensors is placed into the core air gap. With the use of the microsystem approach the interconnecting lines are largely shortened and therefore crosstalk and interference possibilities are reduced in comparison with the discrete sensor version. With an optimal positioning of the two coils on the magnetic core a matching error of 0.6dB between the low frequency sensor and the high frequency coil response can be achieved.

6. Literature

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Čestitka prof. dr. Mariji Kosec za priznanje Ambasador Republike Slovenije v znanosti za leto 2003



20. junija 2003 je Slovenija dobila tri nove Ambasadorje Republike Slovenije v znanosti: Prof. dr. Marijo Kosec, Prof. dr. Damijana Miklavčiča in akademika prof. dr. Jožeta Trontlja. O odličnosti nagrajencev pričajo uradne utemeljitve, dostopne na spletnih straneh <http://www.mszs.si/slo/ministrstvo/nagrade/ambasador/2003.asp>.

Svečani dogodek nas je še toliko bolj razveselil, saj je med nagrajenci prvič tudi članica društva MIDE, **prof. dr. Marija Kosec**, ki jo vsi člani dobro poznamo. Ne samo zato, ker je predsednica društva, temveč zaradi njene izžarevajoče energije in zagnanosti.

Prof. dr. Marija Kosec, izredna profesorica za materiale na Naravoslovnotehnični fakulteti, Univerze v Ljubljani, in vodja Odseka za elektronsko keramiko na Institutu „Jožef Stefan“, je vodilna raziskovalka na področju elektronske keramike, pretežno feroelektrikov in piezoelektrikov. Med svetovne dosežke prištevajo rezultate njenih raziskav razumevanja sinteze sol-gel tankih plasti in prahov v sistemih $\text{Pb}(\text{Zr}, \text{Ti})\text{O}_3$. S tem je odprla nove možnosti nizkotemperaturnih sintez (pri 400°C), kar je novost v svetu keramičnih materialov.

Rdeča nit njenega dela je odličnost in mednarodno uveljavljanje Slovenije in slovenske znanosti. Rezultate raziskav

je prof. Koščeva objavila v 95 člankih, večinoma v uglednih revijah na področju materialov. Imela je 25 vabljenih predavanj na konferencah in 20 vabljenih predavanj na univerzah in inštitutih. Bila je sourednica 11 zbornikov s konferenc. Ima tri domače patente in en evropski patent. Njena dela so citirana več kot 500-krat. Z več prispevki je sodelovala v monografiji z naslovom „Sol-gel science and technology“, ki je letos izšla pri založbi Kluwer.

Ena izmed njenih odlik je zagotovo sposobnost, da zna odlično povezovati osnovne raziskave z razvojnimi in uporabnimi. Prof. Marija Kosec je nosilka več kot 30 pogodb z industrijo, tako tujo kot domačo. O kvaliteti njenih raziskav pa govorijo tudi pogodbe s tujimi partnerji, kot je npr. razvoj prototipov iz feroelektrične keramike, ki omogočajo popolnoma nov način tiskanja (MAN Roland, Druckmaschinen, Augsburg, Nemčija).

Prof. Koščeva s svojo raziskovalno aktivnostjo skrbi za stalno promocijo slovenske znanosti v svetu. V to kategorijo spadajo v prvi vrsti mednarodni projekti (NATO, 5. OP, COST) v vrednosti več kot milijon EUR. Pomembna je njena mednarodna pedagoška aktivnost. Bila je gostujoča znanstvenica leta 1993, predavateljica v okviru letne šole „Feroelektrične tanke plasti“ leta 1995 in gostujoča profesorica leta 2001 s serijo predavanj „On ceramic processing“, na elitni šoli École Polytechnique Fédérale de Lausanne (EPFL) v Laboratoriju za keramiko, ki ga vodi prof. Neva Setter. Prof. Koščeva sodeluje kot mentorica za diplomska dela, magisterije in doktorate tako z Univerzo v Ljubljani, kot v komisijah za zagovor doktorskih del po svetu, npr. v prej omenjeni EPFL, na Tehnični univerzi Copenhagen (Danska), Univerzi Oulu (Finska) in Univerzi v Corku (Irsko).

Pod njenim vodstvom je bila skupina na Institutu »Jožef Stefan« imenovana za Marie Curie Training Site in si od Evropske unije pridobila naziv Centre of Excellence za naslednja štiri leta. Leta 1997 je uspešno organizirala mednarodno delavnico v okviru N.A.T.O., leta 2000 pa je predsedovala organizacijskemu odboru svetovnega kongresa o elektrokeramiki »Electroceramics VII«.

Prof. Koščeva je članica vrste odborov in komisij s področja keramike tako v Sloveniji kot tudi v svetu. Omeniti je treba njeno prestižno članstvo v IEEC Ferroelectric Committee, saj so v njem samo štirje člani iz Evrope. Je marljiva in prizadevna predsednica društva MIDE, ki ga je že leta 1999 popeljala v ugledno mednarodno združenje IMPAS.

Kar koli se v svetu zgodi na področju elektronske keramike, še posebej na področju feroelektrikov, ne mine brez prof. Koščeve; naj bo to nova knjiga, posvetovanje, letna šola, večji projekt v okviru Evropske skupnosti ali pa samo zagovor doktorske disertacije.

Prof. Koščeva je z raziskovalnim delom dosegla neverjetno mednarodno odmevnost in z nastopanjem v mednarodnih znanstvenih krogih veliko prispevala k prepoznavnosti Slovenije v svetu in k povečanju njenega mednarodnega ugleda. Tudi društva MIDEM.

V imenu članov društva MIDEM ji izrekam **iskrene čestitke!**

Marko Topič

Posvet o novih tehnologijah Symposium on new technologies

Igor Pompe

Zavod TC SEMTO, Stegne 25, 1000 Ljubljana, Slovenija, semto@guest.arnes.si

Zavod TC SEMTO je organiziral posvet o novih tehnologijah v dveh delih: 3. 6. 2003 v prostorih Univerze v Ljubljani, Fakultete za elektrotehniko, in 20. 6. 2003 v prostorih Instituta "Jožef Stefan" (IJS). Namen posveta je bil seznaniti člane TC SEMTO z novimi tehnologijami in dejavnostjo nekaterih raziskovalno-razvojnih laboratorijev in skupin.

V nadaljevanju podajamo naslove in kratko vsebino prispevkov. Obširnejše bodo posamezni avtorji poročali v člankih, ki bodo objavljeni v revijah **Materiali in tehnologije** ali **Informacije Midem**.

Zavod TC SEMTO has organized Symposium on New Technologies in two parts: on June 3, 2003 in the premises of Univerza v Ljubljani, Fakulteta za elektrotehniko and on June 20, 2003 at Jožef Stefan Institute in Ljubljana. The aim of the symposium was information of TC SEMTO members about new technologies and activities of some of the research laboratories and groups.

The titles and abstracts of the lectures are published as follows. More details can be found in the articles that will be published in the reviews **INFORMACIJE MIDEM** and **MATERIALI IN TEHNOLOGIJE**.

Prispevki:

Prof. dr. Marija Kosec, Institut "Jožef Stefan": **Keramične tehnologije, keramične plasti iz raztopin**

Predstavljene so bile razne keramične tehnologije. Podrobneje je bil predstavljen postopek pridobivanja keramičnih plasti iz raztopin.

Dr. Peter Panjan, Institut "Jožef Stefan" : **Razvoj keramičnih prevlek za zaščito orodij in strojnih delov**

Predstavljena je bila paleta raznih nekaj mikrometrov debelih keramičnih trdih prevlek na površini orodja za zaščito pred abrazijsko, adhezijsko in kemotermično obrabo. S temi prevlekami se trajnost orodij poveča. Predstavljeni so bili

tudi tehnološki postopki za nanašanje prevlek.

Dr. Uroš Cvelbar, Laboratorij za plazmo, Institut "Jožef Stefan": **Aktivacija površin polimernih materialov s kisikovo plazmo**

Obravnavan je bil postopek aktivacije površin polimernih materialov s kisikovo plazmo, da se doseže boljša omočljivost površine (lepše in lažje tiskanje ali boljše tesnjenje pri zalivanju ohišij).

Dr. Miran Mozetič, Laboratorij za plazmo, Institut "Jožef Stefan": **Perspektive široke industrijske uporabe plazemskega čiščenja**

Prikazan je bil postopek čiščenja površin z vodikovo plazmo. Možno je doseči atomsko čiste površine. Postopek je ekološko prijazna alternativa mokremu kemijskemu postopku, vendar zahteva relativno drage plazemske reaktorje.

Dr. Vojteh Leskovšek, Institut za kovinske materiale in tehnologije: **Nitriranje v plazmi**

Obdelan je bil postopek nitriranja v plazmi, postopek kemotermičnega modificiranja površin za utrjevanje strojnih delov in orodij, ki se jim s tem poveča trajno nihajna in upogibna trdnost, občutljivost jekla na zareze pa se zmanjša. Poveča se korozijska odpornost nizko in srednje legiranih jekel. Opisan je bil tehnološki proces. Parametri se prilagajajo kemični sestavi in predhodni toplotni obdelavi jekel. Nizke temperature nitriranja omogočijo, da jedro strojnega dela ali orodja tudi po nitriranju ohrani svoje prejšnje mehanske lastnosti.

Doc. dr. Drago Resnik, doc. dr. Danilo Vrtačnik, prof. dr. Slavko Amon, Laboratorij za mikrosenzorske strukture, Fakulteta za elektrotehniko, Univerza v Ljubljani: **Napredni načini mikroobdelave silicija za senzorske in aktuatorske mikrostrukture**

Prikazani so bili postopki obdelave silicija pri izdelavi silicijevih 3D-mikrostruktur, kjer se izkoriščajo poleg električnih tudi mehanske lastnosti silicija. Kombinacije novih mikro-

elektronskih materialov in naprednih tehnologij omogočajo realizacijo precizne površinske in globinske mikroobdelave zahtevnih silicijevih mikrostruktur.

Marija Zupan, univ. dipl. kem. tehnolog, IETP PT, Kranj: **Pet korakov do spajkanja brez Pb**

Predavanje je obsegalo razloge za vpeljavo spajkanja brez Pb v elektronski industriji, časovni načrt in korake, ki so potrebni za vpeljavo te tehnologije v proizvodnjo. Predstavljeni so bili ustrezni materiali in oprema ter merila za njihov izbor (plošče, zlitine spajk, prevleke itd.).

Doc. dr. Roman Kamnik, prof. dr. Tadej Bajd, Laboratorij za robotiko, Fakulteta za elektrotehniko, Univerza v Ljubljani: **Robotika v sodobnem svetu**

Podano je bilo stanje pri razvoju in uporabi robotike. Podani so bili osnovni pojmi iz robotike in osvetljeni vzroki za pospešen razvoj. Predstavljena je bila uporaba robotov v industrijskem okolju in delo Laboratorija za robotiko na Fakulteti za elektrotehniko v Ljubljani.

Dr. Vladimir Jovan, TC ARI: **Avtomatizacija v industriji**

Predstavljeno je bilo stanje avtomatizacije in informatizacije v slovenskih proizvodnih podjetjih. V nadaljevanju je avtor predstavil glavne razloge za vlaganja v avtomatizacijo in informatizacijo proizvodnje v slovenskih podjetjih, podal oceno rezultatov izvedenih projektov, izpostavil kritične aktivnosti teh projektov in opisal strategije njihovega izvajanja v slovenskih podjetjih. V drugem delu je predavatelj predstavil vrsto izvedbenih projektov avtomatizacije in informatizacije proizvodnje, ki sta jih izvedli dve skupini z Instituta "Jožef Stefan", in sicer Odsek za sisteme in vodenje ter Odsek za avtomatiko, biokibernetiko in robotiko. Ob koncu je bilo v kratkem predstavljeno delo Tehnološkega centra ARI (TC za avtomatizacijo, robotizacijo in informatizacijo proizvodnje).

Dr. Slavko Dolinšek, Fakulteta za strojništvo, Univerza v Ljubljani in Regionalni tehnološki center Zasavje: **Tehnologija DMLS (neposredno lasersko sintranje kovinskih prahov – od izdelave prototipnih orodij do hitre proizvodnje)**

Predstavljeno je bilo delo Regionalnega tehnološkega centra Zasavje (RTCZ) s poudarkom na neposrednem laserskem sintranju kovinskih prahov za hitro izdelavo orodij ali

malih serij izdelkov zelo zahtevnih oblik. Predstavljene so bile možnosti izdelave delov in/ali orodij v RTCZ.

Dr. Martin Bizjak, Iskra Stikala: **Kontaktne materiale za nizkonapetostne stikalne aparate**

Obravnavani so bili kontaktne materiale za nizkonapetostne stikalne aparate v energetiki. Osnovni material je srebro, ki je lahko legirano s kovinami, lahko pa so srebru primešana zrnca ali vlaknenca kovine ali kovinskih oksidov in grafita. Grafit je lahko primešan tudi v obliki drobnih palčk. Dodatki v srebru določajo lastnosti kontaktnega materiala.

Franc Koplan, univ. dipl. inž., Magneti; Paul McGuinness, Institut "Jožef Stefan": **Merjenje razmagnetilnih krivulj do 450 °C**

Predstavljeno je bilo delo, opravljeno v sodelovanju med IJS in podjetjem Magneti Ljubljana, katerega rezultat omogoča merjenje razmagnetilnih krivulj pri temperaturah merjenec do 450 °C . Nova tehnologija daje potencialnim uporabnikom konkurenčno prednost pri razvoju aplikacij z magneti pri visokih temperaturah.

Dr. Vincenc Nemanič, Institut "Jožef Stefan": **Novi nanomateriali – obetaven točkasti vir elektronov**

Predstavljeno je bilo delo na Odseku za tehnologijo površin in optoelektroniko IJS.

Predstavljene so bile katode s hladno emisijo iz ogljikovih nanocenk in drugih, novih materialov (npr. iz molibden sulfida).

Dr. Darko Makovec, Institut "Jožef Stefan": **Priprava MnZn-feritov s hidrotermalno obdelavo oksidov**

Podana je bila informacija o delu skupine z IJS in iz Iskre Feriti pri razvoju nove tehnologije priprave MnZn-feritnih prahov, ki temelji na hidrotermalnih reakcijah med izhodnimi oksidi. S hidrotermalno obdelavo oksidov je možno pripraviti fin feritni prah podobne sestave kot pri klasični metodi kalcinacije in mletja. Nova metoda je predvsem energijsko ugodnejša, ker dobljenih prahov ni treba intenzivno mleti kot pri klasičnem postopku.

Darko Belavič, univ. dipl. inž., Hipot: **Debeloplastne tehnologije**

Predstavljene so bile novosti v tehnologijah izdelave debeloplastnih vezij in izdelava LTCC-podlag .

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